

Technical design of the phase I Mu3e experiment

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ARTICLE INFO

Keywords:

lepton flavour violation
muon decays
monolithic pixel detector
scintillating fibres
scintillating tiles

Abstract

This is revision: 1706706a on branch frank.

The Mu3e experiment aims to find or exclude the lepton flavour violating decay $\mu \rightarrow eee$ at branching fractions above 10^{-16} . A first phase of the experiment using an existing beamline at the Paul Scherrer Institute (PSI) is designed to reach a single event sensitivity of $2 \cdot 10^{-15}$. Here we present the complete technical design of this phase I Mu3e detector. The high rate of up to 10^8 muon decays per second and the low momenta of the decay electrons and positrons pose a unique set of challenges, which we tackle using an ultra thin tracking detector based on high-voltage monolithic active pixel sensors combined with scintillating fibres and tiles for precise timing measurements.

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1. The Decay $\mu \rightarrow eee$ and the Experimental Challenge

1.1. Goals of the Experiment

The goal of the Mu3e experiment is to observe the process $\mu \rightarrow eee$ if its branching fraction is larger than 10^{-16} , or otherwise to exclude a branching fraction of $> 10^{-16}$ at the 90% confidence level. In order to achieve these goals, more than $1 \cdot 10^{17}$ muons have to be stopped in the detector (assuming a total reconstruction efficiency of 20%) and any background mimicking the signal process suppressed to below the 10^{-16} level. The additional requirement of achieving these goals within a reasonable measurement time of one year of data taking dictates a muon stopping rate of $2 \cdot 10^9$ Hz, along with a high geometrical acceptance and efficiency for the experiment.

The current best source of low-energy muons in the world, the $\pi E5$ beam line at PSI, provides muon rates up to $1 \cdot 10^8$ Hz. Higher intensities are possible and currently under study in the *high intensity muon beam* (HiMB) project. However, the new beamlines will not be available before 2025. In order to establish the novel technologies for Mu3e, set first competitive limits and prepare for the very high intensity running, we plan to run a phase I experiment at $\pi E5$. The aim of this phase I experiment is a single event sensitivity of $2 \cdot 10^{-15}$ on the branching fraction, which would require $> 2.5 \cdot 10^{15}$ stopped muons¹⁴ or $2.5 \cdot 10^7$ s (290 days) of run time at $1 \cdot 10^8$ Hz stopping rate. The present document describes the technical design of this phase I detector.

For more on the physics motivation and theory predictions, please consult the Mu3e letter of intent [1] and research proposal [2]. This chapter describes the kinematics of the signal and the main background sources, and how these motivate the design of the experiment. Running with $1 \cdot 10^8$ Hz of muon decays also poses challenges for the detectors, the data acquisition and the readout, which will be discussed in later chapters.

1.2. Signal Kinematics

To discriminate the signal from the background, energy and momentum conservation are exploited. The decay $\mu \rightarrow eee$ is assumed to be prompt, and the decaying muons are at rest. The vectorial sum of all decay particle momenta \vec{p}_i should therefore vanish:

$$|\vec{p}_{tot}| = \left| \sum \vec{p}_i \right| = 0 \quad (1)$$

and the invariant mass, which is equal to the sum of the energies in the case of vanishing momentum, be equal to the muon mass:

$$m_{inv} = \sum p_i = \sum E_i = m_\mu. \quad (2)$$

The energies of the decay particles range from the electron mass up to half the muon mass, which is about

¹⁴ $N_{\text{required}} = 1/(s \cdot \epsilon)$ for a sensitivity s and a total efficiency $\epsilon \approx 20\%$ (phase I)

53 MeV. All decay particles must lie in a plane. Therefore, the decay is described by two independent variables in addition to three global rotation angles describing the orientation in space.

1.3. Modelling of the Signal

The decay dynamics for the $\mu \rightarrow eee$ signal are dependent on the unknown lepton flavour violating (LFV) mechanism. We typically assume a phase-space distribution for the signal electrons in our simulations, if not stated otherwise. In order to study effects of different decay dynamics, we utilise the general parametrised Lagrangian proposed by Kuno and Okada [3]:

$$\begin{aligned} L_{\mu \rightarrow eee} = & - \frac{4G_F}{\sqrt{2}} [m_\mu A_R \overline{\mu}_R \sigma^{\mu\nu} e_L F_{\mu\nu} \\ & + m_\mu A_L \overline{\mu}_L \sigma^{\mu\nu} e_R F_{\mu\nu} \\ & + g_1 (\overline{\mu}_R e_L) (\overline{e}_R e_L) \\ & + g_2 (\overline{\mu}_L e_R) (\overline{e}_L e_R) \\ & + g_3 (\overline{\mu}_R \gamma^\mu e_R) (\overline{e}_R \gamma_\mu e_R) \\ & + g_4 (\overline{\mu}_L \gamma^\mu e_L) (\overline{e}_L \gamma_\mu e_L) \\ & + g_5 (\overline{\mu}_R \gamma^\mu e_R) (\overline{e}_L \gamma_\mu e_L) \\ & + g_6 (\overline{\mu}_L \gamma^\mu e_L) (\overline{e}_R \gamma_\mu e_R) + H.c.] \end{aligned} \quad (3)$$

The form factors $A_{R,L}$ describe tensor type (dipole) couplings, mostly acquiring contributions from the photon penguin diagram, whereas the scalar-type ($g_{1,2}$) and vector-type ($g_3 - g_6$) form factors can be regarded as four fermion contact interactions, to which the tree diagram contributes at leading order. We generate different signal models by varying the relative strengths of the $A_{R,L}$ and $g_1 - g_6$ parameters.

1.4. Signal Acceptance

For a three-body decay with a priori unknown kinematics such as $\mu \rightarrow eee$, the acceptance has to be as high as possible in order to test new physics in all regions of phase space. To illustrate the phase space coverage needed, the energy spectrum of the highest energy decay particle (E_{max}) for various LFV coupling amplitudes is shown in Figure 1, and the fraction of events where all decay particles have energies above E_{min} is shown in Figure 2. For these figures, it can be seen that a high acceptance for the signal is only possible if the detector can reconstruct tracks with momenta ranging from half the muon mass down to a few MeV. This must be achieved with large solid angle coverage, limited by the beam entry and exit points preventing instrumentation.

1.5. Backgrounds

The Standard Model branching fraction for the $\mu \rightarrow eee$ process is $2.9 \cdot 10^{-55}$ (normal neutrino mass ordering) or $4.6 \cdot 10^{-55}$ (inverted ordering) [5]; the experiment therefore has no physics backgrounds, and the

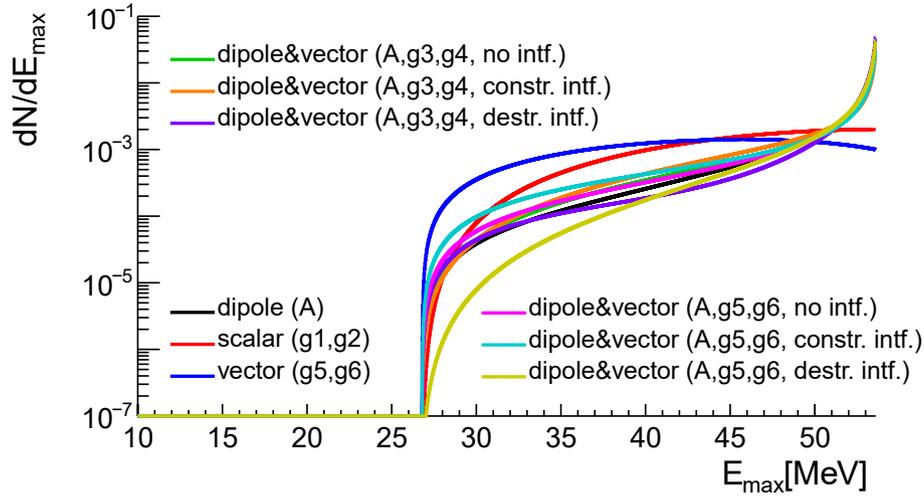


Figure 1: Energy distribution of the highest energy decay particle in the decay $\mu \rightarrow eee$ for different effective LFV models. The black line corresponds to pure dipole and the red and blue line to pure four-fermion contact interaction models (no penguin contribution); the other lines correspond to a mixture of dipole and vector interactions. Based on [3].

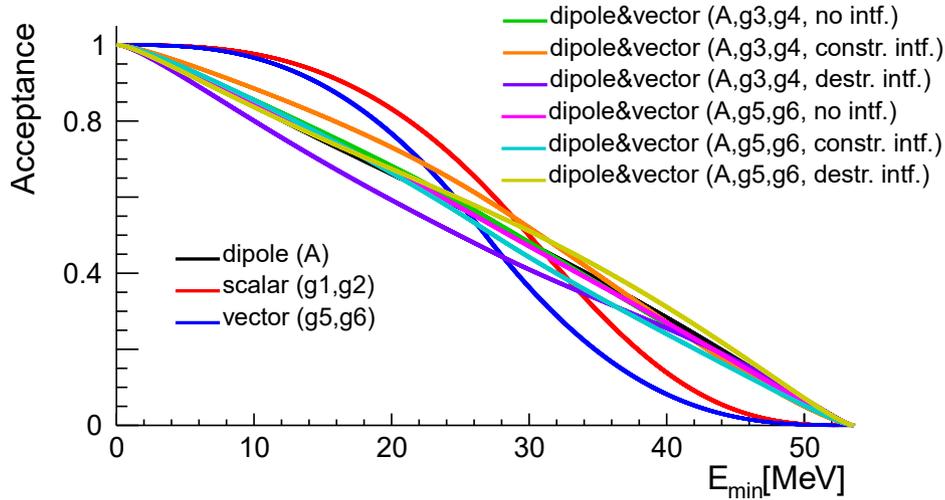


Figure 2: The acceptance, defined as the fraction of $\mu \rightarrow eee$ decays in which all decay products have energies above E_{min} , against E_{min} for different effective LFV models. The black line corresponds to pure dipole and the red and blue line to pure four-fermion contact interaction models (no penguin contribution); the other lines correspond to a mixture of dipole and vector interactions. Based on [3].

94 final sensitivity depends purely on the ability to reduce
 95 backgrounds in two categories: overlays of different
 96 processes producing three tracks resembling a
 97 $\mu \rightarrow eee$ decay (*combinatorial background*) and radiative
 98 decays with internal conversion (*internal conversion
 99 background*) with a small energy fraction carried
 100 away by the neutrinos. Combinatorial backgrounds
 101 have to be suppressed via vertexing, timing and mo-
 102 mentum measurement; momentum measurement is the
 103 only handle on internal conversion. In the following

sections, these main background sources are discussed. 104

1.5.1. Internal Conversions 105

The decay $\mu \rightarrow eee\nu\nu$ occurs with a branching frac- 106
 tion of $3.4 \cdot 10^{-5}$ [6]. It can be distinguished from the 107
 $\mu \rightarrow eee$ process by making use of energy and mo- 108
 mentum conservation to infer the presence of the un- 109
 detected neutrinos: in order to separate the $\mu \rightarrow eee$ 110
 events from $\mu \rightarrow eee\nu\nu$ events, the total momentum in 111
 the event is required to be zero and the visible mass 112

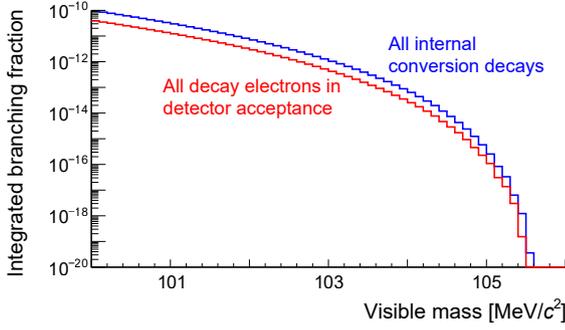


Figure 3: Integrated branching fraction of the decay $\mu \rightarrow eee\nu\nu$ for which the invariant mass of the three decay electrons lies above the x axis value. This is shown for all internal conversion decays (blue line) and those with all three decay particles in the detector acceptance, defined as $E > 10$ MeV and $|\cos\theta| < 0.8$ (red line). The matrix element was taken from [4].

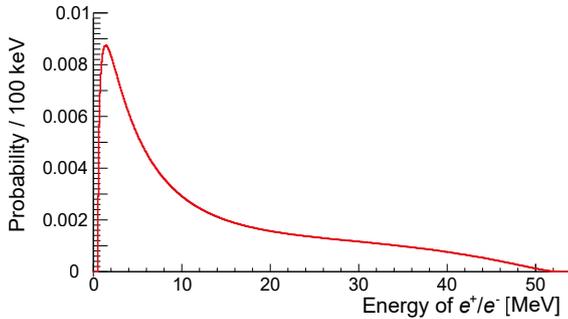


Figure 4: Energy spectrum of all electrons and positron from internal conversion decays.

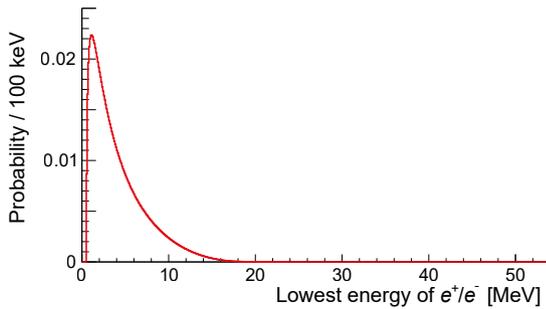


Figure 5: Energy spectrum of the electron or positron with lowest energy from internal conversion decays.

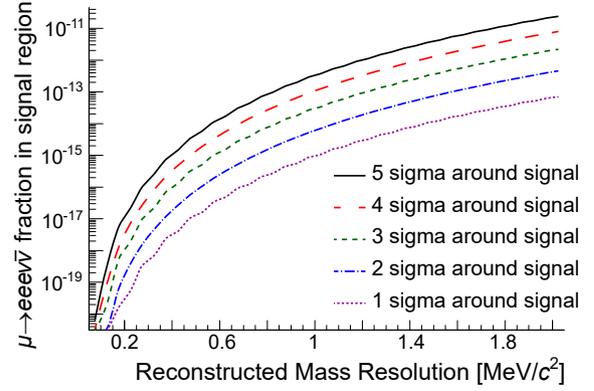


Figure 6: Contamination of the signal region (one sided cut) with internal conversion events as a function of momentum sum resolution.

they predict branching fractions close to the end-point that are about 10% smaller than the LO prediction.

Internal conversion is the most serious background for the $\mu \rightarrow eee$ search, and the momentum resolution directly determines to what level it can be suppressed and thus the experiment run background free. In order to reach a sensitivity of $2 \cdot 10^{-15}$ with a 2σ cut on the reconstructed muon mass, the average momentum resolution has to be better than 1.0 MeV, see Figure 6, and is not allowed to have sizeable tails towards the high momentum side.

1.5.2. Combinatorial Backgrounds

Michel Decays Using a beam of positive muons, one of the main processes contributing to combinatorial background is that of the Michel decay $\mu^+ \rightarrow e^+\nu_\mu\bar{\nu}_e$. This process does not produce a negatively charged particle (electron), so it can only contribute as a background in combination an incorrectly reconstructed track, or with other processes that “naturally” provide negatively charged particles.

The rate of fake electron tracks being reconstructed from the recurling (incoming) section of a positron track is reduced by a reliable determination of the direction of motion of a particle: achieved by accurate curvature measurements and repeated timing measurements. The main sources of genuine negatively charged particles are Bhabha scattering and radiative decays.

Radiative Muon Decays The process $\mu^+ \rightarrow e^+\gamma\nu\bar{\nu}$ (branching fraction $1.4 \cdot 10^{-2}$ for photon energies above 10 MeV [9]) can deliver a negatively charged electron if the photon converts either in the target region or in the detector. Conversions in the target region generate an event topology similar to the radiative decay with internal conversion $\mu \rightarrow eee\nu\nu$ discussed above. Contributions from conversions outside the target region are greatly suppressed both by a vertex constraint and by minimising the material in both the target and

(defined as the invariant mass of the three electrons) equal to the muon rest energy. The branching fraction for $\mu \rightarrow eee\nu\nu$ [4] decays above a given visible mass value is shown in Figure 3. Figures 4 and 5 show the energy spectrum of all and the lowest energy electron from $\mu \rightarrow eee\nu\nu$ decays calculated with the matrix element from [4]. Recently, NLO calculations of the internal conversion decays have become available [7, 8];

detector. However, this process can still contribute to the combinatorial background in combination with an ordinary muon decay.

As for the internal conversion background, a NLO calculation for radiative decay has recently been published [10] and is implemented in our simulation.

Bhabha Scattering Any positron, either from a muon decay on target or in the beam, can undergo Bhabha scattering with electrons in the target material, leading to an electron-positron pair from a common vertex. In combination with a positron from a Michel decay, this can mimic a signal decay. In addition, Bhabha scattering is the main source of electrons for combinatorial background involving two Michel decays. Similarly to the external photon conversion background, the amount of Bhabha scattering is reduced by minimising both the amount, and the average atomic number of the material in the target.

Vertex and Timing Resolution Requirements Separating vertices from different muon decays is a key tool in suppressing combinatorial background. The vertex position resolution is essentially determined by the amount of multiple scattering (and thus material) in the innermost detector layer and the stopping target as well as the average distance between the vertex and the first detector layer.

At high muon rates, good time resolution is essential for reducing combinatorial background, while also facilitating event reconstruction. The combinatorial background has a component scaling linearly with the rate (e^+e^- pair plus a Michel positron) and a component quadratic in the rate (electron plus two Michel positrons). The suppression of these components by timing measurements is also linear and quadratic in the timing resolution. Simulation studies have shown that the linear part is dominating at rates at least up to $2 \cdot 10^9$ muon stops per second. The requirement of reducing the combinatorial background by at least two orders of magnitude puts very tight demands on the resolution of the timing detectors. The timing resolution should be below 500 ps per track to allow for reliable charge identification by time-of-flight and ideally 100 ps or better to identify non-synchronous muon decays.

1.5.3. Other Backgrounds

Pion Decay Certain pion decays, especially $\pi \rightarrow eee\nu$ (branching fraction $3.2 \cdot 10^{-9}$ [11]) and $\pi \rightarrow \mu\gamma\nu$ (branching fraction $2.0 \cdot 10^{-4}$ [12]) with subsequent photon conversion are indistinguishable from signal events if the momenta of the final state particles fit the muon mass hypothesis. The low pion contamination in the muon beam delivered to the experiment, in addition to the small branching fractions, lead to negligible rates for this background.

Mis-reconstruction Mis-reconstruction of tracks (e.g. from hits created by different particles or noise hits) combined with real tracks from muon decays can fake $\mu \rightarrow eee$ decays. Great care is taken in the track reconstruction algorithms to keep a minimal rate of fake tracks, balanced against reconstruction efficiency.

1.5.4. Summary

The sensitivity aims of the Mu3e experiment place strict requirements on the experimental design. Electrons and positrons must be reconstructed down to a few MeV with large solid angle coverage, running at a rate of $1 \cdot 10^8$ Hz of muon decays. The material in the target and detector must be minimised, while achieving excellent momentum, vertex and timing resolution to suppress backgrounds to the necessary level. The rest of this document will discuss how this is achieved.

2. Experimental Concept

Phase I of the Mu3e experiment aims for the background free measurement or exclusion of the branching fraction for the decay $\mu \rightarrow eee$ at the level of $2 \cdot 10^{-15}$. As discussed in more detail in chapter 1, these goals require running at high muon rates, excellent momentum resolution to suppress background from internal conversion decay ($\mu \rightarrow eee\nu\nu$), and a good vertex and timing resolution to suppress combinatorial background.

The momenta of electrons and positrons from muon decays are measured using a silicon pixel tracker in a solenoidal magnetic field. At the energies of interest, multiple Coulomb scattering in detector material is the dominating factor affecting the momentum resolution. Minimising the material in the detector is thus of the utmost importance.

The detector consists of an ultra-thin silicon pixel tracker, made possible by the High-Voltage Monolithic Active Pixel (HV-MAPS) technology (see chapter 7). Just four radial layers of HV-MAPS sensors around a fixed target in a solenoidal magnetic field allow for pre-

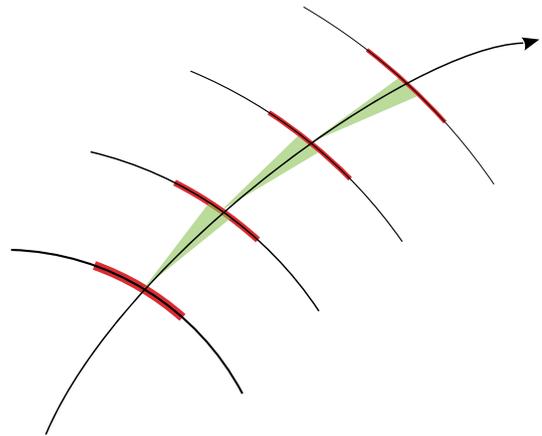


Figure 7: Tracking in the spatial resolution dominated regime

248 cise momentum and vertex determination. Two timing
 249 detector systems guarantee good combinatorial back-
 250 ground suppression and high rate capabilities.

2.1. Momentum Measurement with Recurlers

251
 252
 253 Due to the low momenta of the decay particles,
 254 multiple scattering is the dominant effect on the mo-
 255 mentum measurement. With a fine-grained pixel de-
 256 tector, we are in a regime where scattering effects dom-
 257 inate over sensor resolution effects, see Figures 7 and 8.
 258 Adding additional measurement points does not neces-
 259 sarily improve the precision.

260 The precision of a momentum measurement depends
 261 on the amount of track curvature Ω in the magnetic
 262 field B and the multiple scattering angle Θ_{MS} , see Fig-
 263 ure 9; to first order:

$$264 \quad \frac{\sigma_p}{p} \propto \frac{\Theta_{MS}}{\Omega}. \quad (4)$$

265 So in order to have a high momentum precision, a large
 266 lever arm is needed. This can be achieved by moving
 267 tracking stations to large radii, which would limit the
 268 acceptance for low momentum particles. Instead, we
 269 utilise the fact that, in the case of muon decays at rest,
 270 all track momenta are below 53 MeV and all tracks will
 271 curl back towards the magnet axis if the magnet bore
 272 is sufficiently large. After half a turn, effects of multi-
 273 ple scattering on the momentum measurement cancel
 274 to first order, see Figure 10. To exploit this feature,
 275 the experimental design is optimised specifically for the
 276 measurement of recurling tracks, leading to a narrow
 277 long tube layout.

278 Determining the momentum from a particle's tra-
 279 jectory outside the tracker allows us to place thicker
 280 timing detectors on the inside both upstream and down-
 281 stream of the target without significantly affecting the
 282 resolution, see Figure 11.

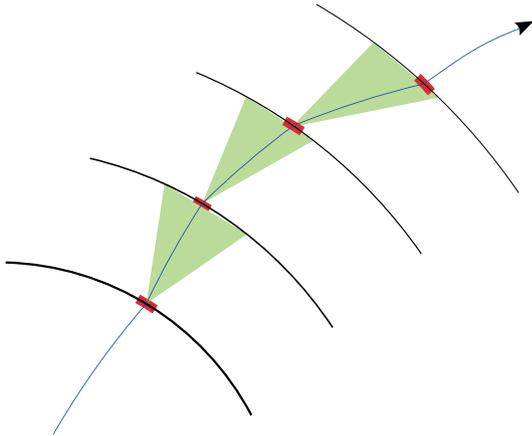


Figure 8: Tracking in the scattering dominated regime

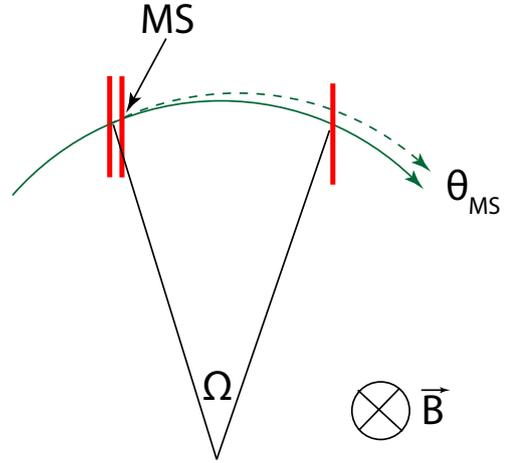


Figure 9: Multiple scattering as seen in the plane transverse to the magnetic field direction. The red lines indicate measurement planes.

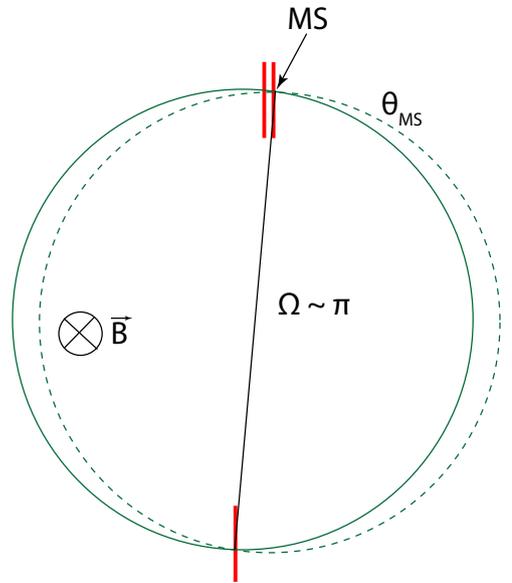


Figure 10: Multiple scattering for a semi-circular trajectory. The red lines indicate measurement planes.

2.2. Coordinate System

283 The Mu3e coordinate system is centred in the muon
 284 stopping target with the z axis pointing in beam direc-
 285 tion, the y axis pointing upward and the x axis chosen
 286 to obtain a right handed coordinate system. The po-
 287 lar angle measured from the z axis is denoted with ϑ ,
 288 and measured from the x - y plane denoted with λ . Az-
 289 imuthal angles are denoted with φ .
 290

2.3. Baseline Design

291 The proposed Mu3e detector is based on two double-
 292 layers of HV-MAPS around a hollow double cone tar-
 293 get, see Figures 11 and 12. The outer two pixel sensor
 294 layers are extended upstream and downstream to pro-
 295 vide precise momentum measurements in an extended
 296 region to increase the acceptance for recurling electrons
 297

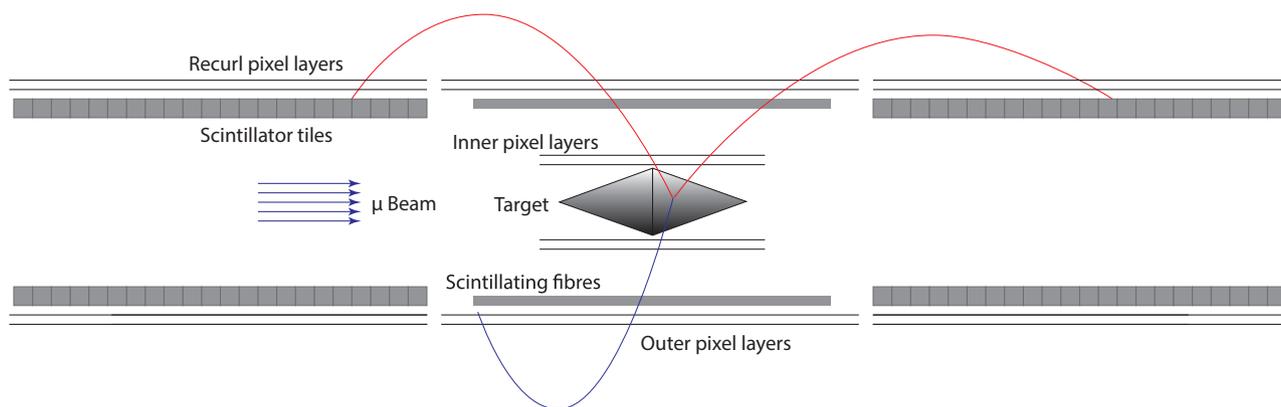


Figure 11: Schematic view of the experiment cut along the beam axis in the phase I configuration.

and positrons. The silicon detector layers (described in detail in chapter 7) are supplemented by two timing systems, a scintillating fibre tracker in the central part (see chapter 10) and scintillating tiles (chapter 11) inside the recurl layers. Precise timing of all tracks is necessary for event building and to suppress the combinatorial background.

2.4. Detector Readout

The Mu3e experiment will run a continuous, triggerless readout, and employs custom ASICs for the pixel and timing detectors which stream out zero-suppressed digital hit data. These hits are collected by FPGAs located on *front-end boards* and then optically forwarded to *switching boards*, which in turn distribute them to a computer farm. This network makes it possible for every node in the farm to have the complete detector information for a given time slice. Decays are reconstructed using graphics processing units, and interesting events are selected for storage. A system overview is shown in Figure 13 and a detailed description can be found in chapter 17.

2.5. Building up the Experiment

One of the advantages of the design concept presented is its modularity. Even with a partial detector, physics runs can be taken. In an early commissioning phase at smaller muon stopping rates, the detector will run with all of the timing detectors but only the central barrel of silicon detectors. The silicon detectors of the recurl stations are essentially copies of the central outer silicon detector; after a successful commissioning of the latter, they can be produced and added to the experiment as they become available. The configuration

with two recurl stations (Figures 11 and 12) defines a medium-size setup, well suited for phase I running at the highest possible rate at the $\pi E5$ muon beam line at PSI of $\approx 1 \cdot 10^8$ Hz. The sensitivity reach in this phase of the experiment of $\mathcal{O}(10^{-15})$ will be limited by the available muon rate.

2.6. The Phase II Experiment

A new high intensity muon beam line, delivering $> 2 \cdot 10^9$ Hz muons and currently under study at PSI, is crucial for Mu3e phase II. To fully exploit the new beam facility the detector acceptance of phase I will be further enhanced by longer detector stations, see Figure 14. These longer stations will allow the precise measurement of the momentum of all particles in the acceptance of the inner tracking detector. At the same time the longer tile detector stations with their excellent time resolution and small occupancy will help to fight the increased combinatorial backgrounds at very high decay rates. The larger initial muon rate allows for a more restrictive collimation of the beam and thus a smaller (and potentially longer) target region leading to a much improved vertex resolution. The HV-MAPS technology can reach a time resolution of $\mathcal{O}(1\text{ ns})$ if an adequate time-walk correction is implemented – this would allow to further reduce combinatorial background without adding material and could eventually replace the scintillating fibre detector. Advanced wafer post-processing technologies and chip-to-chip bonding could obviate the need for parts of the flexprints, further reducing the multiple scattering. The combined performance of the enhanced detector setup together with the high stopping rate will allow to search for the $\mu \rightarrow eee$ decay with a sensitivity of $B(\mu \rightarrow$

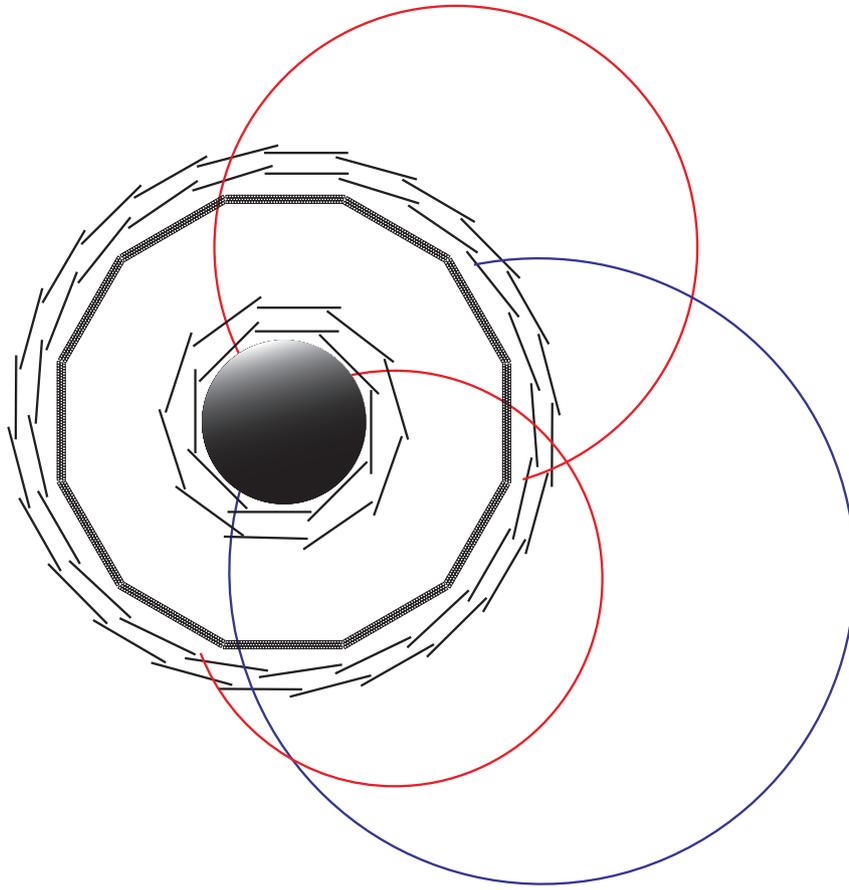


Figure 12: Schematic view of the experiment cut transverse to the beam axis. Note that the fibres are not drawn to scale.

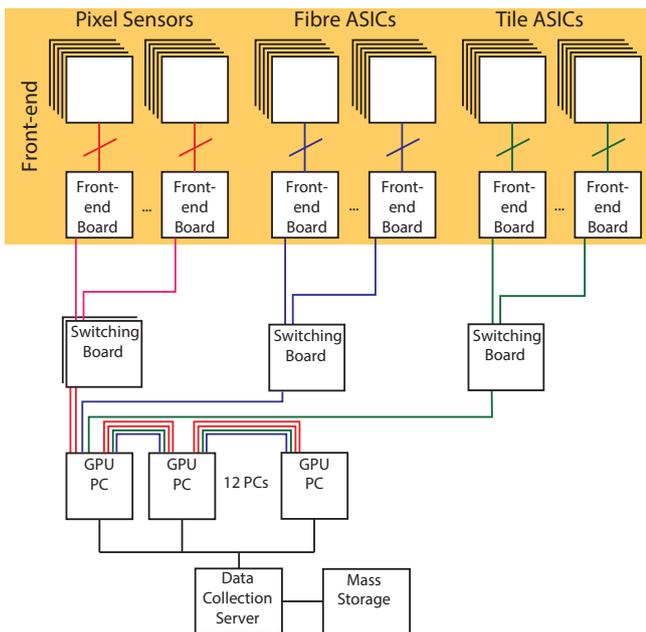


Figure 13: Schematic overview of the Mu3e readout system.

$eee) \leq 10^{-16}$. Whilst we always keep this ultimate goal in mind, the rest of this document is concerned with the phase I detector for existing beamlines.

3. Muon Beam

3.1. Beam Requirements

An experiment such as Mu3e, with a phase I sensitivity goal of $2 \cdot 10^{-15}$ while challenged by combinatorial background, not only requires running at the intensity frontier, but also substantially benefits from a continuous beam structure rather than a pulsed one, allowing a lower instantaneous muon rate. Both of these conditions are satisfied by the high intensity proton accelerator complex (HIPA) at PSI running at 1.4 MW of beam power.

Mu3e requires a muon beam with the highest possible rate of “surface muons”, produced from stopped pion decay at the surface of the primary production target [13]. The surface muon yield and hence beam intensity peaks at around 28 MeV/c, close to the kinematic edge of the two-body momentum spectrum of pion decay at rest as can be seen from the measured momentum spectrum in Figure 15.

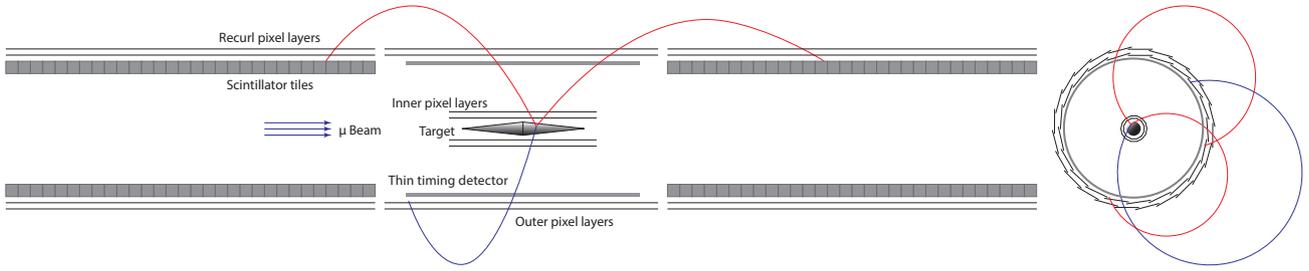


Figure 14: Possible final detector with longer recurl stations, smaller target and more segmented inner layers for high intensity physics runs (phase II).

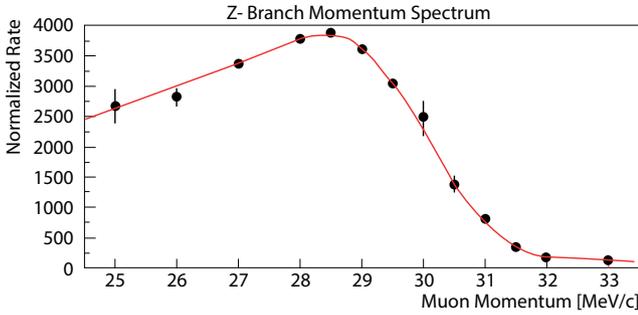


Figure 15: Measured muon momentum spectrum in $\pi E5$, with full momentum acceptance. Each point is obtained by optimising the whole beam line for the corresponding central momentum and measuring the full beam-spot intensity. The red line is a fit to the data, based on a theoretical $p^{3.5}$ behaviour, folded with a Gaussian resolution function corresponding to the momentum-byte plus a constant cloud-muon background.

structure are permanently located in the rear-part of the $\pi E5$ area.

The new CMBL for Mu3e, as presented in the following, not only allows the 3.2 m long Mu3e solenoid to be placed in the front part of the $\pi E5$ area – see Figure 16 – but also allows both experiments MEG II and Mu3e to share the front beam transport elements required by both. This solution allows the efficient switching between experiments by only replacing the superconducting beam transport solenoid of MEG II by a dipole magnet (ASL) for Mu3e.

The initial optical design of the CMBL was modelled using the beam optics matrix code programs GRAPHIC TRANSPORT FRAMEWORK [15] and GRAPHIC TURTLE FRAMEWORK [16], while the detailed modelling was undertaken using the newer GEANT4 based simulation software G4BEAMLIN (G4BL) [17]. The 1st-order optical design showing the vertical and horizontal beam envelopes from Target E to the downstream end of the Mu3e detector are shown in Figure 17.

The design includes the elements of the backward (165°) extraction channel $\pi E5$ from Target E up to the ASC dipole magnet, the background cleaning-stage including triplet I, the Wien-filter (SEP41), triplet II and the collimator system, used to eliminate the beam-related background. The final injection stage is based on a very compact “split triplet” layout which starts after the 90° dipole ASL41. The “split triplet” consists of the quadrupole doublet QSO41/42 and quadrupole singlet QSM41. In combination with the vertical edge-focusing of the ASK41 65° dipole magnet they serve the same purpose as a total of six quadrupoles that would be needed in a more standard beamline configuration. This allows sufficient space to place the 3.2 m long Mu3e detector in the front area without compromising the optics and physics goals of the experiment.

Based on the GRAPHIC TRANSPORT model, two G4BL models were constructed, one including the full $\pi E5$ channel and Target E, simulating the whole pion production process by protons in the primary target, followed by surface muon production and transport to the intermediate collimator. The second shorter version starts from Triplet II, just upstream of the interme-

The intensity goal and low energy not only necessitates a beam line capable of guiding these muons to a small, thin stopping target with minimal losses but at the same time minimising beam-related backgrounds. The former requires a small beam emittance and a moderate momentum-byte (full width at half maximum of the momentum acceptance $\Delta p/p$), with an achromatic final focus to balance between beam intensity and stopping density in the target. The minimising of beam-related backgrounds, in the form of Michel e^+ from μ^+ -decay, e^+ produced from π^0 -decays in the production target, or from decay-in-flight particles produced along the beam line, puts strong restrictions on the amount of material, such as windows and momentum moderators, that can be placed along the beam path, requiring an extension of the vacuum system to just in front of the target.

3.2. The Compact Muon Beam Line (CMBL)

For Mu3e phase I, muon intensities close to 10^8 muons/s will be required, which leaves only one choice of facility in the world, PSI’s $\pi E5$ channel. This channel will be shared with the upgrade version of the MEG experiment – MEG II [14], whose large detector and infras-

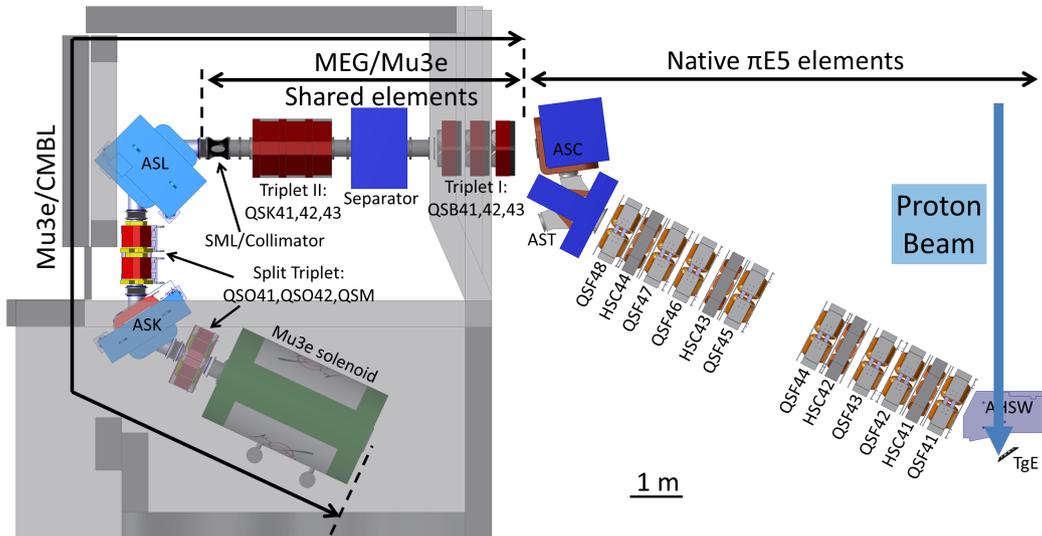


Figure 16: CAD model of the entire π E5 channel & CMIBL used as a basis for the G4BL models.

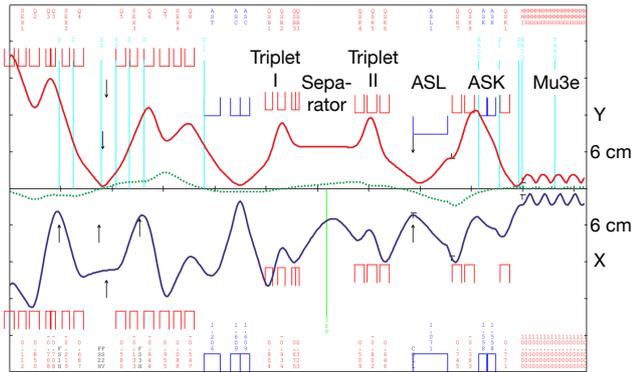


Figure 17: Optical Model of the CMIBL from the GRAPHIC TRANSPORT FRAMEWORK program, showing 1st-order vertical and horizontal beam envelopes along the entire beam line from Target E to the end of the Mu3e solenoid with some of the beam elements labelled (note the horizontal scale unit is 2 m, whereas the vertical is 6 cm). The dotted line shows the dispersion trajectory for a 1% higher central momentum.

validated G4BL model was then used, and identified the ASL and ASK dipole apertures as the main limitations for the transmission to the final focus. Consequently, increased pole-gaps and modified vacuum chambers for both dipole magnets allowed for an expected enhanced transmission of 18%, which was proven in the following 2016 measurements [18].

In 2017, the commissioning emphasis was placed on confirmation of increased muon yield using a 60 mm long production Target E instead of the usual 40 mm version. The expectation of only an $\sim 30\%$ increase in muon yield (surface phenomenon) with a full 50% increase in beam positron contamination (bulk phenomenon) for the 165° backward extraction was confirmed. Furthermore, the expected impact on the experiment from an increased beam positron background was also studied and a differential measurement technique developed to distinguish Michel positrons from beam positrons at the final focus [19]. These measurements showed that for the 60 mm Target E a beam- e^+/μ^+ -ratio = 10.1 was measured, with no Wien-filter in operation, whereas for a 40 mm target the ratio was ~ 7 . However, with the Wien-filter on, an unacceptably high number of beam positrons, seen as a vertically displaced spot, were measured. On investigation it was found that the off-centre, vertically displaced (by the Wien-filter) beam positrons entering triplet II are partially swept-back into the acceptance of the downstream collimator, as demonstrated in Figure 20. The situation was quickly and temporarily solved by placing a lead e^+ -stopper between QSK41/42 reducing the contamination by a factor of 15, with a 10% loss of muons. The final solution is the modification of the Wien-filter, which was upgraded in 2019 to have a symmetric electric field with double the present voltage of 200 kV. While not yet experimentally confirmed, this

diate focus at the collimator system, where measured phase space parameters determine the initial beam used for the simulation - see Figure 18. The shorter version predictions were used as a direct comparison to the CMIBL commissioning measurements described in the next section.

3.3. CMIBL Commissioning Steps

Initial commissioning of the CMIBL beam layout was undertaken in two 4-week beam periods in November and December 2014 and May 2015, using mostly existing elements. Figure 19 shows the good agreement between predicted and measured beam sizes at the injection point to the Mu3e solenoid, based on a 1st-order transverse phase space reconstruction. The

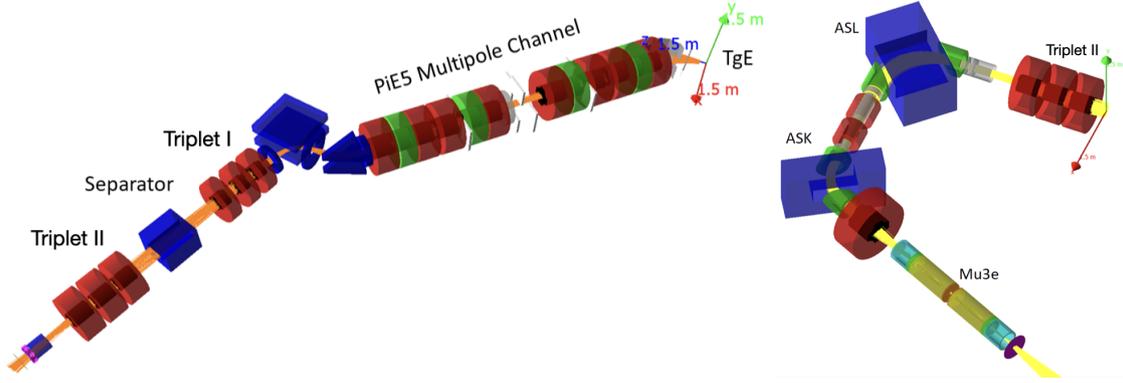


Figure 18: Shows the graphical outputs of the G4BL simulations with some of the beam elements labelled. (Left) – simulation of the full beam line from Target E up to the intermediate collimator system. (Right) – shows the shorter version of the simulation from Triplet II past the intermediate collimator system to the end of the Mu3e Detector solenoid.

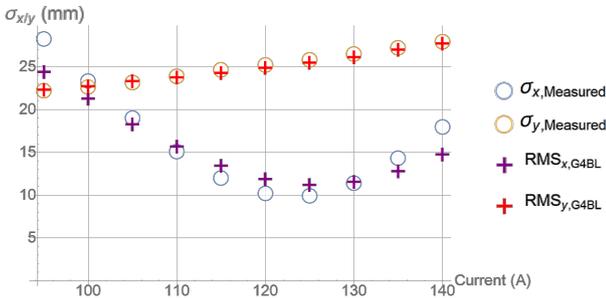


Figure 19: Simulated and measured 2-D beam sizes at the Mu3e solenoid injection point, showing good agreement for a wide range of currents applied to the last quadrupole QSM41.

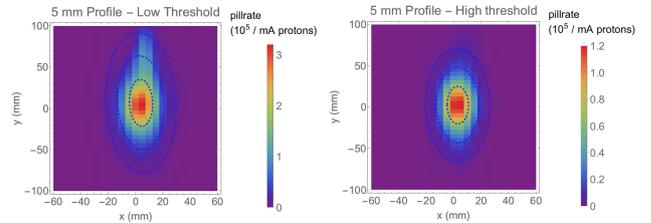


Figure 21: Measured beam spot at the injection point to the Mu3e solenoid triggering on either a low (left: muons + Michels + beam positrons) or high (right: muons only) threshold. A 2D Gaussian fit to the muon data yields $\sigma_x = 8$ mm and $\sigma_y = 23$ mm with a total rate of $1.1 \times 10^8 \mu^+/\text{s}$ at a proton current of 2.4 mA for a 40 mm long Target E. The vertical beam positron tail in the low threshold profile (top-part) is without the e^+ -stopper in triplet II and will be totally removed with the upgraded Wien-filter.

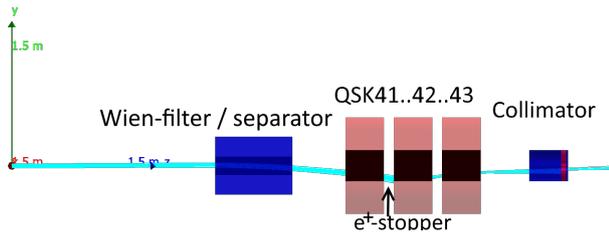


Figure 20: Demonstration of beam positron contamination vertically separated post Wien-filter being swept-back into the acceptance at the collimator by QSK42/43.

During the shutdown 2017/18 all magnet power supplies for $\pi E5$ were replaced with digitally controlled ones. The better stabilisation of magnet currents contributed to a further increased transmission during the 2018 commissioning run. Optimisation at the injection point of the Mu3e solenoid yielded a final rate of $1.1 \times 10^8 \mu^+/\text{s}$, normalised to the expected future proton beam current of 2.4 mA for a 40 mm long Target E, with profile widths of $\sigma_x = 8$ mm and $\sigma_y = 23$ mm. The measured high (muons only) and low threshold (muons + Michels) profiles are shown in Figure 21, these 5 mm raster scan profiles were measured with a 2D automated pill scintillator scanner system with each profile consisting of ~ 1025 single measurements. The beam intensity is extracted from a 2D Gaussian fit to the profiles.

The 2018 measurements therefore successfully conclude the beam commissioning up to the injection point of the Mu3e solenoid. The final commissioning to the centre of the Mu3e detector will be undertaken when the magnet is placed in the area.

is expected to reduce any beam positron contamination by 3-orders of magnitude.

Finally, using the measured contamination rate, the impact of this on the experiment's sensitivity to combinatorial Michel and beam positron events mimicking a 3-particle signature via Bhabha scattering was investigated [19] and found that only muon decay-in-flight events have a chance of coming close to the reconstructed muon mass region, though occurring at a rate twelve orders of magnitude lower than the most dominant background (Bhabha scattering with overlapping Michel decays).

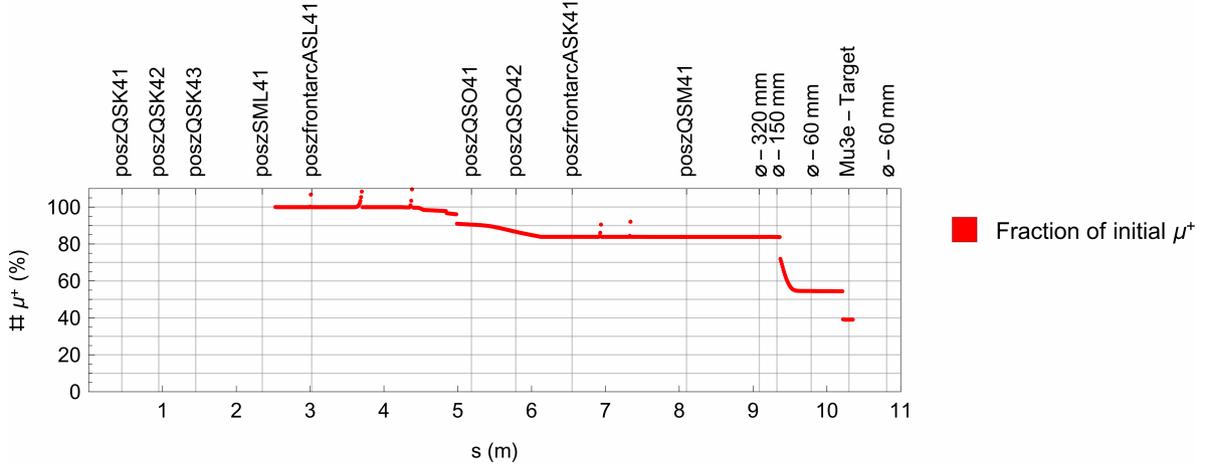


Figure 22: Beam losses along the Mu3e Compact Muon Beam Line (CMBL) starting from the intermediate collimator system to the centre of the Mu3e magnet. In front of the Mu3e target a narrowing of the beam-pipe down to 40 mm diameter takes place.

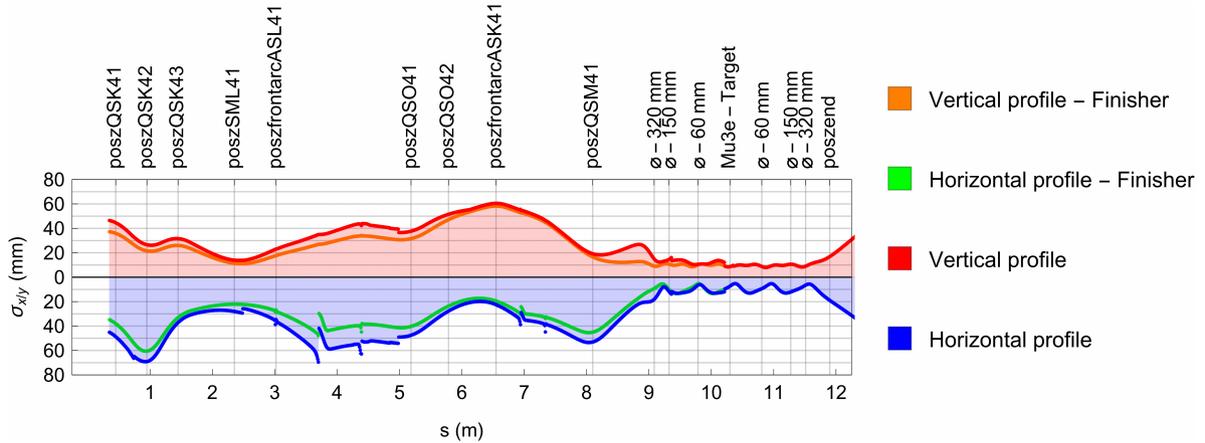


Figure 23: Horizontal and vertical beam envelopes for 'all' particles started in the simulation or only for those that reach the centre of the solenoid ('finishers').

3.4. Expected Muon Rate and Distribution on the Mu3e Stopping Target

As described in the previous section the final optimisation of the CMBL resulted in a surface muon rate at the injection point of the Mu3e magnet of $1.1 \times 10^8 \mu^+/\text{s}$, normalised to the expected future proton beam current of 2.4 mA for a 40 mm long Target E, with profile widths of $\sigma_x = 8 \text{ mm}$ and $\sigma_y = 23 \text{ mm}$.

The coupling to the central detector region inside the solenoid magnet is planned to be with a custom bellows system (see Figure 30) reducing step-wise the aperture to an inner diameter of 60 mm for the inner vacuum-pipe. This will contain a $600 \mu\text{m}$ thick Mylar (biaxially-oriented polyethylene terephthalate) moderator located at an intermediate focus point some few hundred millimetres in front of the target and will end with a $35 \mu\text{m}$ Mylar vacuum window, placed just in front of the Mu3e target, where the aperture narrows down to 40 mm diameter due to the support structure of the inner pixel layers. A double-cone Mylar target

of radius 19 mm, length 100 mm and total thickness of $150 \mu\text{m}$ (see chapter 6) is located close to the vacuum window at the centre of the solenoid. The warm bore of the solenoid is filled with helium gas at atmospheric pressure to reduce multiple scattering. Furthermore, a 20 mm thick lead collimator system will be introduced shortly after the moderator to protect the inner pixel layers from hits by the muon beam as well as from particles outside of the target acceptance.

Estimates for the final muon stopping rate on the target are based on the re-measured $1\text{-}\sigma$ beam emittances at the intermediate collimator system in 2018, corresponding to $\epsilon_x = 950 \pi \cdot \text{mm} \cdot \text{mrad}$, $\epsilon_y = 490 \pi \cdot \text{mm} \cdot \text{mrad}$ and the G4BL simulation. The beam losses along the beam line can be seen in Figure 22 and the corresponding beam envelope sizes in Figure 23.

Even though the muon beam intensity at injection into the solenoid achieves the commissioning goal, it is the inner silicon detector diameters and the associated beam-pipe size that determine the stopping tar-

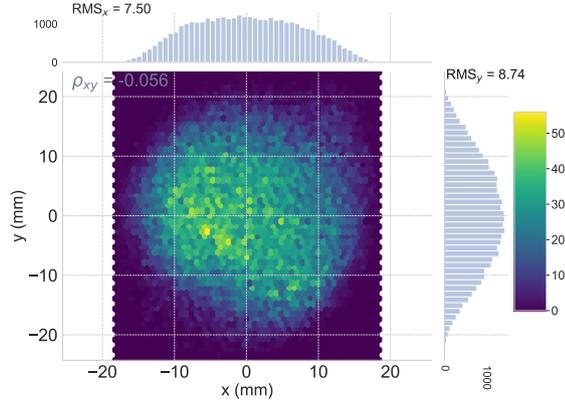


Figure 24: Estimated beam profile at the Mu3e target position.

MAGNET PARAMETER	VALUE
field for experiment	1.0 T
field range	0.5 – 2.0 T
warm bore diameter	1.0 m
warm bore length	2.7 m
field inhomogeneity $\Delta B/B$ around center	$\leq 10^{-3}$
field stability $\Delta B/B$ (100 days)	$\leq 10^{-4}$
field description $\Delta B/B$	$\leq 2.0 \cdot 10^{-4}$
outer dimensions: length	≤ 3.2 m
width	≤ 2.0 m
height	≤ 3.5 m

Table 1

Requirements for the Mu3e magnet.

get diameter, which has been maximised to a radius of 19 mm. These conditions are a compromise between stopping rate, occupancy and vertex resolution.

The main losses are associated with the transition to the initial diameter of the beam-pipe, and the final narrowing to a 40 mm diameter at its end. The final beam-spot at the target is shown in Figure 24. The beam intensity on the target is expected to be $\sim 5 - 6 \times 10^7 \mu^+ / s$ at 2.4 mA proton current for the current 40 mm long production Target E. The final muon rate can further be enhanced by the use of the 60 mm production target, or the recently tested 40-mm long slanted target. Both of these targets lead to a further $\sim 30-40\%$ enhancement, so yielding muon rates on the Mu3e target of about $\sim 7 - 8 \times 10^7 \mu^+ / s$ at 2.4 mA proton current. Further enhancements are still under study.

4. Magnet

The magnet for the Mu3e experiment has to provide a homogeneous solenoidal magnetic field of $B = 1$ T for the precise momentum determination of the muon decay products. Field inhomogeneities along the beam line are required to stay below 10^{-3} within ± 60 cm around the center. The magnet also serves as beam optical element for guiding the muon beam to the target. To further improve the field homogeneity, and for matching the magnetic field of the last beam elements of the compact muon beam line, compensating coils are included on either side of the magnet.

The basic parameters of the superconducting solenoid magnet are given in Table 1. The outer dimensions also include an iron shield, reducing stray fields to less than 5 mT at a distance of 1 m. This, however, lead to an overall weight of the magnet of 31 tons, 27 of which are due to the iron shielding.

The long term stability of the magnetic field should

be $\Delta B/B \leq 10^{-4}$ over each 100 days data-taking period. This is achieved with state of the art power supplies and by permanently monitoring the absolute field with NMR and Hall probes inside the apparatus. The NMR system and hall probes will also be used to map the field. The goal is to measure and describe the field distribution with a precision better than $2.0 \cdot 10^{-4}$.

The tight requirements on the dimensions of the magnet come from the space constraints of the $\pi E5$ area as described in the next chapter. In this respect a good compromise had to be found as in particular the total length of the magnet is a critical parameter impacting the specified homogeneity of the field in the central region.

In addition, the magnet also acts as containment for the helium gas used for cooling as described in chapter 12. For this reason, the warm bore is designed with helium-tightness in mind and is sealed off on both ends by removable flanges.

A superconducting magnet design with a closed cooling system was determined to be the most stable and economic solution. The magnet made from niobium-titanium superconductor will operate at nominally 4 K and be cooled by four Gifford McMahon two-stage cryocoolers, each delivering 1.5 W cooling power at their second stage. The cool-down time for the system is about 10 days with liquid nitrogen pre-cooling and the ramp up time to 1 T will be less than 2 hours.

The company Cryogenic Ltd.¹⁵ was tasked to design and produce the Mu3e solenoid magnet. Cryogenic Ltd. has prepared a technical design report for the complete magnet system in 2018. The picture shown in Figure 25 depicts the delivery of the magnet to PSI's experimental hall in July 2020 after initial testing of the magnet at the company showed excellent performance.

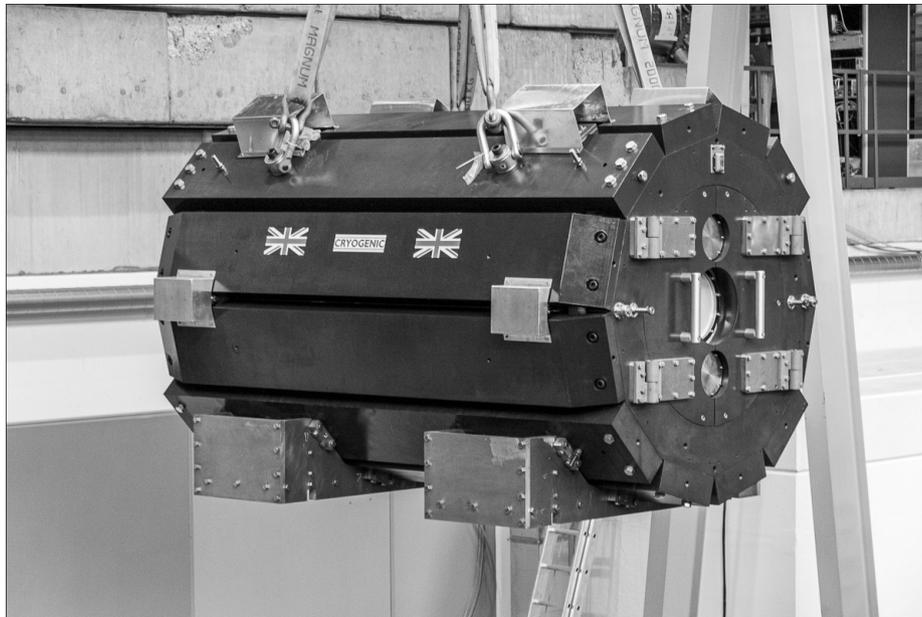


Figure 25: Picture of the delivery of the 31-ton Mu3e magnet to PSI's experimental hall where the Mu3e experiment will take place.

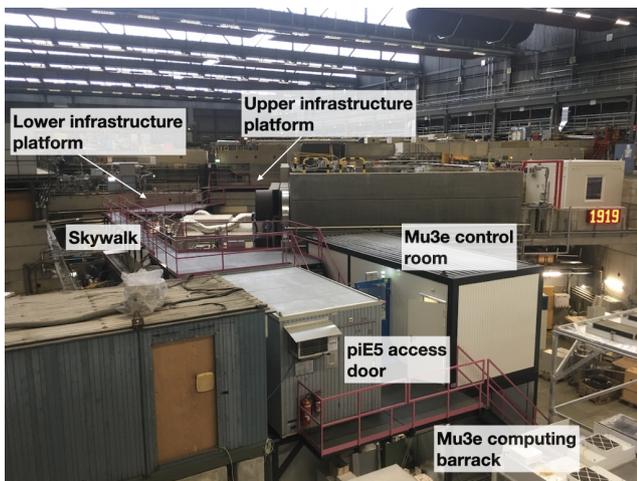


Figure 26: The new rear access to the $\pi E5$ Area with the Skywalk and the two new infrastructure platforms for the Mu3e experiment. In the front, the Mu3e control room and computing barrack are located.

5. Area Layout, Infrastructure & Beam Line Connection

Due to the spatial restrictions in the $\pi E5$ front area and the substantial infrastructure needs of the experiment, an optimised area layout is necessary. Upgrades were needed to both the electrical installation and cooling-water and, due to safety requirements, an additional access route to the front area had to be added. Figure 26 shows the overview of the new rear access to the $\pi E5$ Area via the 'skywalk' with its two new in-

¹⁵Cryogenic Ltd., Acton Park Industrial Estate The Vale London W3 7QE, UK

frastructure platforms and the Mu3e control room and computing farm barrack. The experimental area in the front part of $\pi E5$ is located below the two infrastructure platforms and will have a stairway added as a safety requirement, once the large magnet is in place, leading from the lower platform into the experimental area.

The upper infrastructure platform, above the beam entrance wall, is constructed to be removable in order to grant service access the $\pi E5$ channel during accelerator shutdown periods, if required. This platform is closest to the magnet and detector and will house the cooling elements such as the compressors for the cryogenic cold-heads as well as the helium and water cooling circuits for the Mu3e detector. The lower, larger platform will not be removable and will carry the magnet power supplies, quench detection system and electronics as well as the power-control circuitry associated with both magnet and detectors.

Also seen in Figure 26 are the two new $\pi E5$ barracks located on top of each other. The upper barrack will serve as the Mu3e experiment's control room, while the lower barrack will house the filter farm responsible for the readout of the detector (see chapter 17).

Due to the limited space in the front part of the $\pi E5$ area, as can be seen in Figure 27, as well as the fact that the Mu3e magnet is located underneath the roof formed by the $\pi E3$ area above, a rail system is required to move the Mu3e magnet from a position where it can be lowered down into the experimental area by crane – shown in Figure 28 – to its final position underneath the roof shown in Figure 27. The crane operation will be a challenging one and extra degrees of rotational freedom included in the rail system are needed to allow for such a movement of the 30-ton magnet to its final

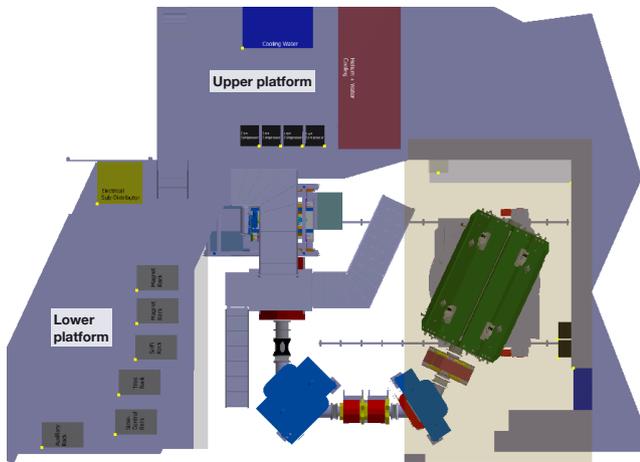


Figure 27: Top view of the $\pi E5$ experimental area showing the completed installation. Also visible are the two new infrastructure platforms located on the shielding blocks above the area and the stairs leading down to the experiment. The transparent beige-area marks the roof underneath which the Mu3e magnet has to be installed.

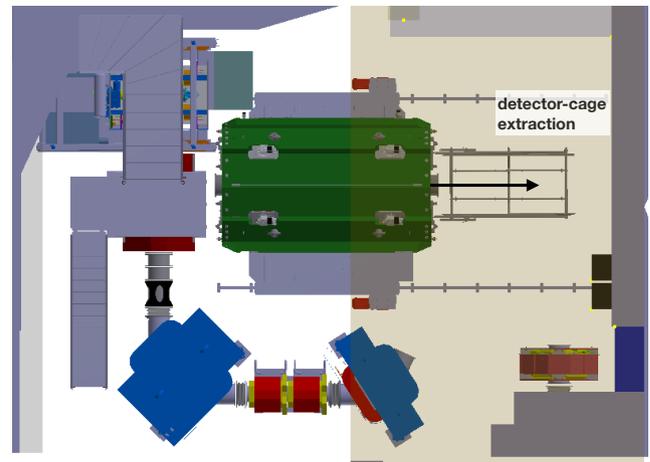


Figure 29: Maintenance position of the magnet on the rail system used to extract the detector-cage onto its transport unit.

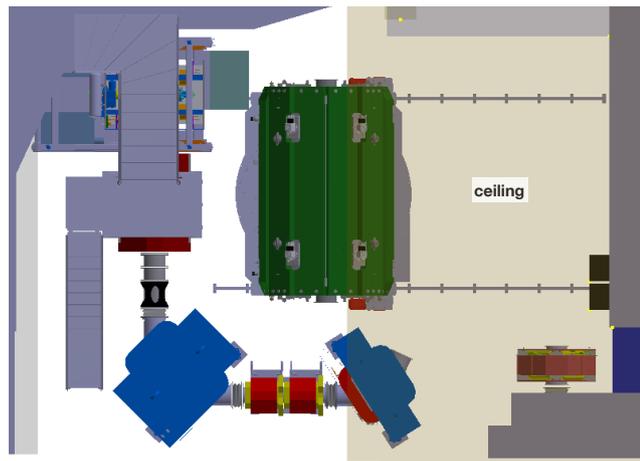


Figure 28: Position of the magnet when lowered into the experimental area onto its rail system. The rail system allows to move the 30-ton magnet underneath the ceiling and turn it in line with the rest of the beam elements.

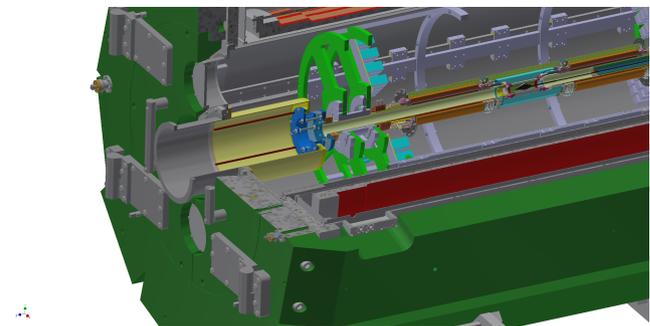


Figure 30: Connection of the Mu3e detector to the muon beam line is achieved through a custom bellows assembly inside the solenoid.

nection protrudes into the magnet allowing a maximum acceptance of the converging beam envelopes before entering a custom 150-mm diameter intermediate bellows connection to the final 60-mm diameter beam tube of the Mu3e detector. The mounting sequence is as follows: In a first step the detector system is mounted with its cage inside the magnet bore and fixed in position. Subsequently, the internal beam line elements are mounted onto the inside end of the He-tight flange of the magnet bore, which is then bolted onto the cryostat. In order to achieve a vacuum tight connection between the custom bellows assembly and the Mu3e detector cage beam-flange, the final screws are tightened from the inside of the ISO-320-K vacuum tube, so pressing on the O-ring seal. As a last step, internal tensioning supports for the bellows are mounted and securely fixed in place to prevent the bellows from collapsing when evacuated.

6. Stopping Target

The main challenge for the design of the stopping target is to optimise the stopping power, while also minimising the total amount of material in order to reduce

689 position under the roof. In addition, a small crane is
 690 needed to move the last quadrupole QSM41 away from
 691 its position along the beamline in order to allow the
 692 free movement of the magnet.

693 Figure 29 shows the magnet in its maintenance posi-
 694 tion. This position allows the Mu3e solenoid to be
 695 rotated in such a way that the full detector-cage can
 696 be extracted onto its transport support structure for
 697 repairs, maintenance or transportation. A detailed de-
 698 scription on how the detector can be extracted onto the
 699 support structure can be found in chapter 13.

700 Finally, the detailed coupling mechanism of the beam
 701 line to the solenoid magnet is described. The compo-
 702 nents are shown in Figure 30. The standard ISO-320-K
 703 beam line vacuum tube, with its upstream bellows con-

726 both backgrounds and the impact on the track mea-
 727 surement. Therefore the stopping target should con-
 728 tain just enough material in the beam direction to stop
 729 most of the muons, which is facilitated by a modera-
 730 tor in the final part of the beam line, but should be as
 731 thin as possible to minimise the material in the flight
 732 direction of decay electrons entering the detector ac-
 733 ceptance. Usage of a low- Z material is advantageous as
 734 photon conversion and large-angle Coulomb scattering
 735 are suppressed. In addition, the decay vertices should
 736 be spread out as wide as possible in order to reduce ac-
 737 cidental coincidences of track vertices and to produce a
 738 more or less even occupancy in the innermost detector
 739 layer.

740 **6.1. Baseline Design**

741 These requirements can be met by a hollow double
 742 cone target à la SINDRUM [20, 21]. In our baseline

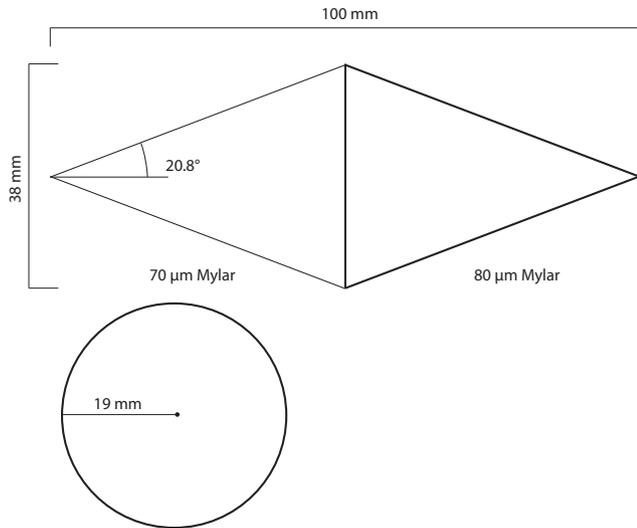


Figure 31: Dimensions of the baseline design target. Note that the material thickness is not to scale.

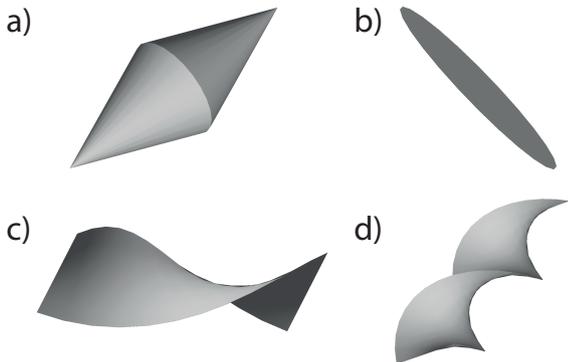


Figure 32: Target shapes studied. a) Is the default hollow double cone, b) a simple plane, c) a single-turn garland and d) a double-turn garland. For the chiral shapes c) and d), both senses of rotation were tried.

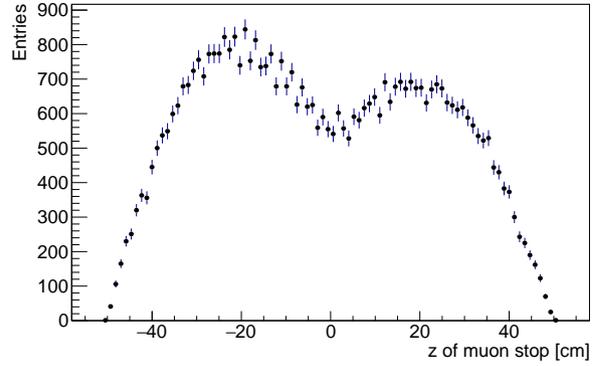


Figure 33: Simulated stopping distribution along the beam (z) axis for the baseline target.

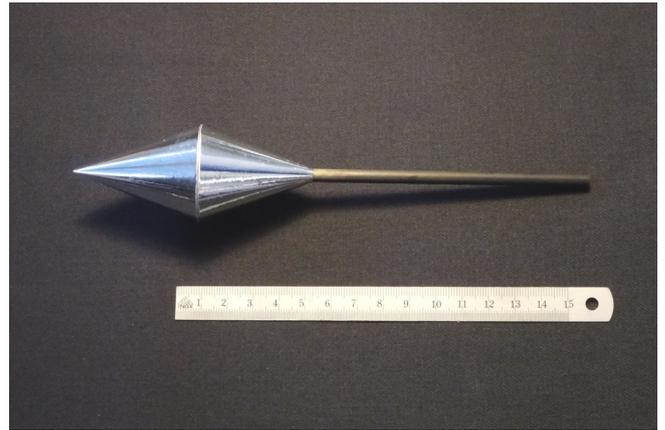


Figure 34: Hollow double-cone muon stopping target made of aluminized Mylar foil.

743 design (see Figure 31), the target is made from 70 μm
 744 of Mylar in the front part and 80 μm Mylar in the back
 745 part, with a total length of 100 mm and a radius of
 746 19 mm. This leads to an incline of 20.8° of the target
 747 surface with regards to the beam direction. The pro-
 748 jected thickness is thus 197 μm for the front and 225 μm
 749 for the back part, giving a total of 422 μm of Mylar cor-
 750 responding to 0.15% of a radiation length. The mass
 751 of the Mylar in the target is 0.671 g. The total area of
 752 the target is 6386 mm^2 .

753 We have studied the stopping power and material
 754 budget for a variety of target shapes (see Figure 32)
 755 and found that for the given beam parameters and ge-
 756 ometrical constraints, the double cone offers the highest
 757 stopping fraction with the least material. The simula-
 758 tion was performed with Mylar as the target material, a
 759 previous study using aluminium however gave very sim-
 760 ilar results. The stopping distribution along the beam
 761 axis for the baseline target is shown in Figure 33.

6.2. Production

762 At PSI, a manufacturing procedure was developed
 763 and a complete target was produced, see Figure 34.
 764 Each single hollow cone of the double cone structure
 765



Figure 35: Cross section of target support and alignment mechanism. Muons hit the target from the left. The stopping target is mounted on a thin carbon tube which is steered and fixed in the support structure. The rear end of the support structure consists of an alignment mechanism to adjust the position of the target.

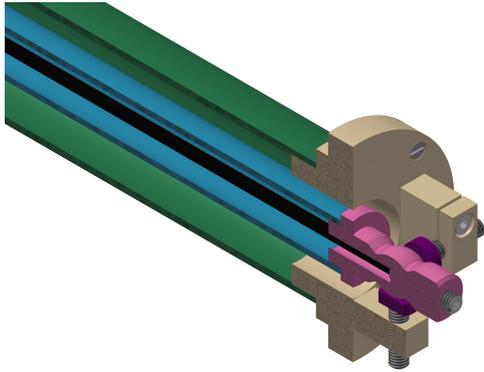


Figure 36: Cross section of alignment mechanism. The setup is spring-loaded towards the two screws and allows an adjustment of the target position in 3 coordinates. The direction of the spring is in the bisecting line with respect to the two screws and is in this view therefore hidden by the holder.

on the tip of the downstream cone of the stopping target. Along the first 10 cm downstream of the target the original wall thickness of 0.5 mm of the carbon tube is reduced to ~ 0.125 mm by means of centerless-grinding in order to reduce the material budget in the central region of the detector.

To avoid possible vibrations of the target due to a long lever arm the carbon tube is not only rigidly fixed at the rear end of the support structure (pink part in Figure 36), but also guided in a joint at the front end of the structure close to the target itself.

The alignment mechanism (see Figure 36) allows an adjustment of the target position in all 3 coordinates. To ensure sufficient clearance between the target and the innermost layer of the silicon detectors, the range of movement for the target is limited to ± 2 mm in x- and y-directions, and ± 4 mm in z-direction. This is achieved with a limited range for the adjustment screw at the rear end of the support structure, in conjunction with the transformation ratio due to the different lengths of carbon tube and support structure.

The central tube (turquoise part in Figure 36) of the support structure hosting the carbon tube and connected to the holder at the end (pink part in Figure 36) is spring-loaded towards the adjustment screws to allow for a hysteresis-free adjustment of the target.

is manufactured separately and is a sandwich structure consisting of 2 or 3 rolled up thin Mylar foils glued together with epoxy glue. The thickness of the individual Mylar foils and the combination of several foils are chosen to match best with the desired final thickness. Finally, the two individual cones are glued together to build up the hollow double cone structure.

The inner and the outer foil in each sandwiched stack is aluminium coated and the orientation of the aluminium layers is such that the inner and outer surface of the cones features an aluminium layer. The conductive surfaces, in combination with the mounting on a conductive carbon tube avoid a possible charging up of the target due to the high stopping rate of positive muons.

6.3. Support

The double cone structure will be glued on a carbon tube which will be fixed in a dedicated support structure with an alignment mechanism. Figure 35 shows a cross section of the complete target system consisting of stopping target, carbon tube and support, while Figure 36 shows an enlarged view of the rear end of the support structure consisting of the alignment mechanism. The target support structure will be placed on the downstream side of the experiment in order not to disturb the incident muon beam.

The carbon tube (silver / black rod in Figures 35 and 36) has an inner diameter of 5 mm and will be glued

7. Pixel Tracker

The Mu3e pixel tracker provides precision hit information for the track reconstruction of the electrons produced in muon decays. Achieving the best possible vertex and momentum resolution measurements for these electrons is of key importance to the success of the experiment. Due to the dominance of multiple scattering, a rigorous minimisation of the material in the active region of the tracking detector is critical. For this reason, the tracker relies on High-Voltage Monolithic Active Pixel Sensors (HV-MAPS) [22], thinned to $50\ \mu\text{m}$ and mounted on a low mass service flex circuit. The detector is operated inside a dry helium atmosphere and cooled by helium gas flow to further reduce multiple scattering.

7.1. Overview of the Pixel Tracker

The Mu3e pixel tracker consists of three parts, the central pixel tracker and two recur stations, see Figure 37. Pixel layers in the central tracker provide the main hits used for the reconstruction of tracks and of

the decay vertex associated with multiple tracks. The hits detected in the recurl stations allow us to reconstruct tracks with higher purity and improved momentum resolution.

Throughout the pixel tracker all MUPIX sensors have the same dimensions, with an active area of $20 \times 20 \text{ mm}^2$. A small non-active area of the sensor chip houses peripheral digital and analogue circuitry, enlarging the chip in one dimension to about 23 mm. The chips are mounted on High Density Interconnect (HDI) circuits, which incorporate both signal and power lines as aluminium traces on thin polyimide substrates. The HDIs provide power and bias voltage, and transmit control signals and data. The latter over, up to, 3 differential lines per chip at a bandwidth of 1.25 Gbit/s per line.

The MUPIX chips are bonded to the HDI using *Single-point Tape Automated Bonding* (SpTAB) without the need for additional bonding material [23]. Pixel modules are constructed from self-supporting sensor-HDI-polyimide ladders. These host between 6 and 18 sensors, and represent a total radiation length of approximately $X/X_0 = 0.115\%$ per layer.

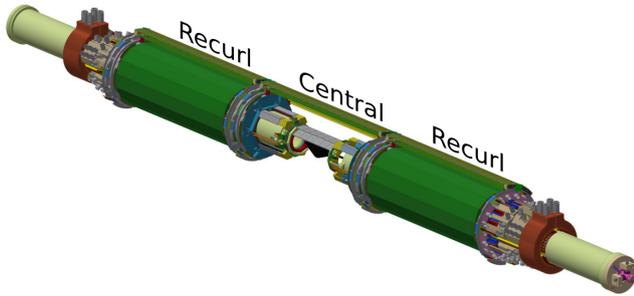


Figure 37: The Mu3e pixel tracker with the central pixel tracker in the middle and the two recurl stations down- and upstream. Some modules in the central pixel tracker have been removed for visibility.

7.1.1. Pixel Tracker Layout

The central pixel tracker has four layers of MUPIX sensors: two inner layers (layer 1 and 2) at small radii and two outer layers (layers 3 and 4) at larger radii. The inner and the outer layers are both arranged as double layers, pairs that work together to provide a track trajectory. The layout of the central pixel tracker is shown in Figure 38 and the corresponding geometrical design parameters are listed in Table 2. The recurl stations have only two pixel layers (layers 3 and 4) which are identical in design to the outer layers in the central tracker.

Each tracking layer is composed of mechanically robust modules which integrate 4 or 5 of the more fragile sub-modules (ladders). Ladders represent the smallest mechanical unit in the tracker.

The inner tracking layers, 1 and 2, are of equal

length, 12 cm, hosting 6 chips per ladder. These provide the vertexing in Mu3e. The inner layers have full overlap in z with the muon stopping target, which has a length of 10 cm. The outer and recurl pixel tracker modules are significantly longer and provide a larger acceptance for downstream and upstream going particles. The outer and recurl layers are critical for selection of high-quality tracks and for the momentum resolution in Mu3e. The outer layers instrument a region with a length of 34 cm (layer 3) and 36 cm (layer 4), corresponding to 17 and 18 MUPIX chips, respectively.

The MUPIX ladders are mounted with a small overlap, in the radial direction, of the active area with the adjacent ladder, see Figure 39. The lateral overlap is 0.5 mm, which ensures high acceptance for low momentum tracks and also helps with the alignment of the pixel tracker. There is a small physical clearance between overlapping sensors of $\approx 200 \mu\text{m}$.

7.1.2. Signal path

The signal connection between the front-end FPGA board, located on the service support wheels (SSW, section 13.3), and the MUPIX chips is purely electric and differential with impedance-controlled lines. A schematic path of a differential signal is shown in Figure 40. The FPGA board is plugged into a back-plane where basic routing is performed. The distance to the detector (about 1 m) is bridged with micro-twisted pair cables, each consisting of two copper wires with $127 \mu\text{m}$ diameter, insulated with $25 \mu\text{m}$ polyimide and coated together with a polyamide enamel. The differential impedance of this transmission line is $Z_{\text{diff}} \approx 90 \Omega$. 50 such pairs are combined to a flexible bundle with a diameter of less than 2 mm. At both ends, the wires are soldered onto small PCBs, plugged into zero-insert-force (ZIF) connectors. On the detector end, the signals are routed on flexible PCBs to the HDI (see section 7.2.5). The connections between the components use industry-standard parts (back-plane connectors, gold-ball/gold-spring array interposers) and SpTAB bonding, as shown in the figure.

7.2. Pixel Tracker Modules

The pixel tracker modules of all layers have a very similar design. They consist of either four or five instrumented ladders mounted to a polyetherimide (PEI) end-piece at the upstream and downstream ends. The ladders host between 6 and 18 MUPIX chips glued and electrically connected to a single HDI circuit. For the inner two layers, self-supporting half-shells define a module, with each half shells comprising four (layer 1) or five (layer 2) short ladders with six MUPIX sensors.

For the outer two layers, a single module is an arc-segment, corresponding to either 1/6th (layer 3) or 1/7th (layer 4) of a full cylinder. Outer layer modules comprise four ladders with either 17 (layer 3) or 18 (layer 4) MUPIX sensors.

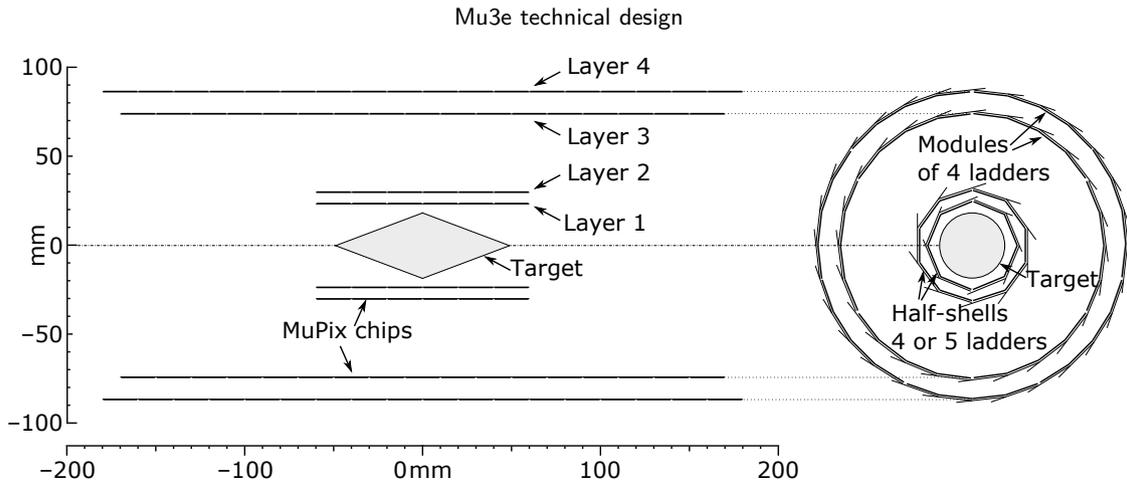


Figure 38: Geometry of the central pixel tracker including the target.

layer	1	2	3	4
number of modules	2	2	6	7
number of ladders	8	10	24	28
number of MUPIX sensors per ladder	6	6	17	18
instrumented length [mm]	124.7	124.7	351.9	372.6
minimum radius [mm]	23.3	29.8	73.9	86.3

Table 2

Pixel tracker geometry parameters of the central barrel. The radius is defined as the nearest distance of MUPIX sensor w/o polyimide support to the symmetry axis (beam line).

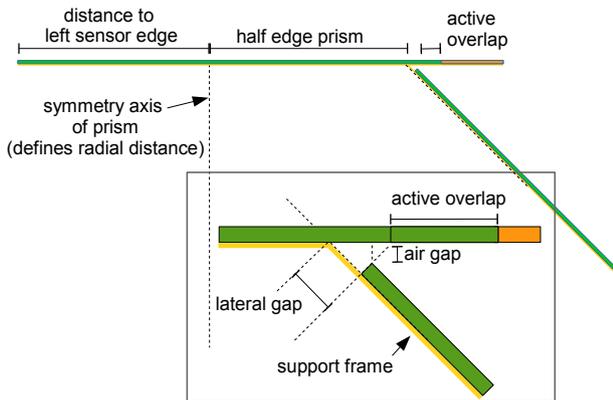


Figure 39: Design of the MUPIX ladder overlap region of pixel layer 1. The green region indicates the active part of the sensor, the orange part the inactive periphery and the yellow part the polyimide support structure. The lower edge shows a zoom into the overlap region. Note that the sensor thicknesses are not to scale.

7.2.1. Inner Layer Modules

Modules for layers 1 and 2 are constructed by mounting for or five ladders to upstream and downstream half-shell end-pieces. The half shells are strengthened with a 25 μm polyimide foil, glued to the MUPIX ladders on the inward facing side. The foil also restricts helium from flowing through the gaps between ladders. After mounting and gluing, the half module represents a mechanically robust structure. To construct the full layers 1 and 2, half-shell modules are mounted on two end-rings, see Figure 41.

The electrical connection to the outside is made through multilayer copper-polyimide interposer flexprints which are SpTAB-bonded to the HDI just outside the active region at the position of the end-pieces. The interposer flex is connected to repeater PCBs via the interposer, which provides a 7×12 micro grid array of gold-spring contacts. The repeater PCB distributes all the signal and power lines.

7.2.2. Outer Layer Modules

The thirteen outer tracking modules in the central detector, see Figure 42, have a modular structure. Each module comprises four MUPIX ladders which are glued to upstream and downstream module endpieces. As with the inner layers, the HDI circuit is SpTAB bonded to a multilayer copper-polyimide interposer flex circuit that connects to the 7×12 micro grid interposer plate. Connections from four ladders are combined on

935 The longer outer layer ladders require additional
 936 reinforcement to achieve a mechanical stability com-
 937 parable to the shorter ladders of the inner layers. For
 938 this purpose, two polyimide strips folded into a v-shape
 939 (yellow structure in Figure 43) are glued to each ladder
 940 on the inner side. The obtained v-channels also serve
 941 as high flux helium cooling channels.

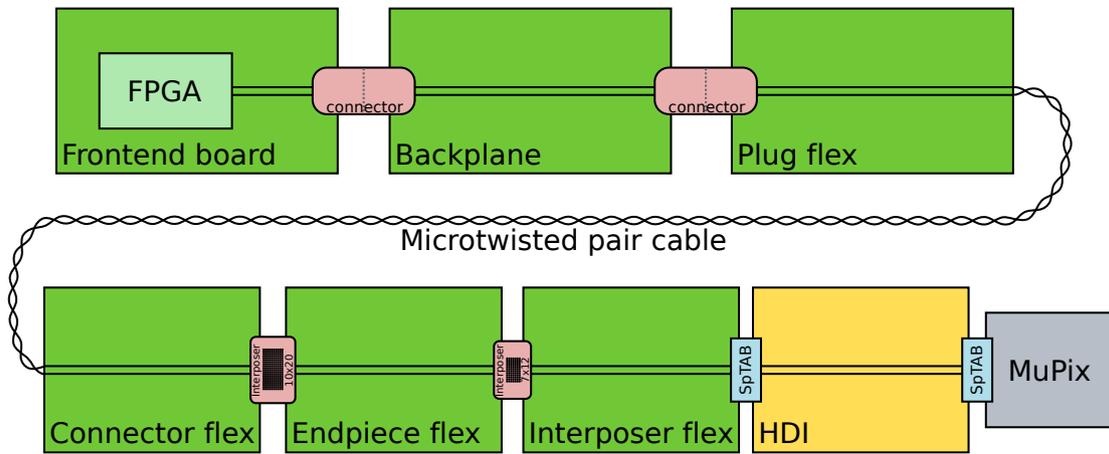


Figure 40: Signal path between MuPIX chip and FPGA for a differential readout line. The parts on the top are located on the SSW, the ones on the bottom in the tracker barrels.

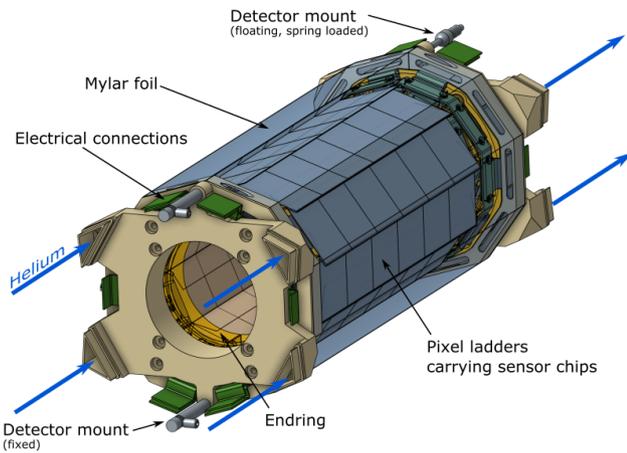


Figure 41: Schematic view of the vertex pixel barrel. Each of the 8+10 ladders carry 6 sensor chips. End-rings (split in halves) provide the mechanical support to the ladders.

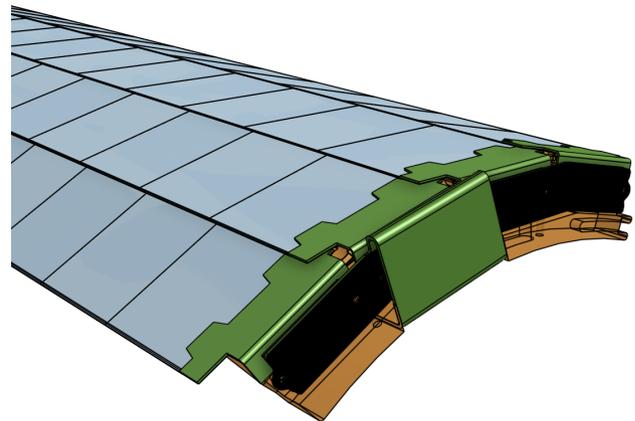


Figure 42: Schematic representation of a layer 4 module, integrating four long ladders with 18 MuPIX sensors each. The picture shows one end, including the holding end-piece which also provides the electrical connections. An exploded view can be found in Figure 49.

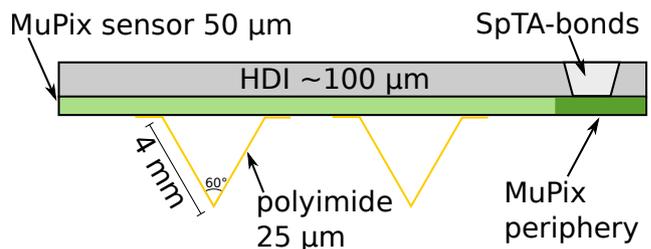


Figure 43: Cross section of an outer layer ladder. From top to bottom: HDI, MuPIX sensor, polyimide support structure. Not to scale.

970 the endpiece flex circuit. The final connection from
 971 a module to the outside world is made through a fur-
 972 ther 10×20 interposer plate, combining gold-spring and
 973 ball-grid array contacts, to which the module connects
 974 when mounted on its endrings. Layer 3 and 4 modules
 975 are assembled into full cylinders by mounting to a PEI
 976 endring. The design foresees a swing-in mechanism for
 977 installation, where modules are located by a dowel pin
 978 on each end-ring and fixed by two screws on the end-
 979 pieces at either end. Modules for the recurv stations
 980 are identical to the outer layer modules in the central
 981 region.

982 7.2.3. Pixel Ladder Design

983 The MuPIX ladders integrate and support the pixel
 984 sensors. They have a compound structure optimised
 985 for a minimal material budget. The material composi-
 986 tion for the inner and outer MuPIX ladders is listed in

987 Table 3 and amounts to a radiation length of approxi-
 988 mately $X/X_0 = 0.115\%$ per layer.

989 The mechanical stability of the outer MuPIX lad-
 990 ders is mainly determined by the two v-fold channels
 991 on the inner side which also serve as cooling channels.

	thickness [μm]	Layer 1-2 X/X_0	thickness [μm]	Layer 3-4 X/X_0
MuPIX Si	45	$0.48 \cdot 10^{-3}$	45	$0.48 \cdot 10^{-3}$
MuPIX Al	5	$0.06 \cdot 10^{-3}$	5	$0.06 \cdot 10^{-3}$
HDI polyimide & glue	45	$0.18 \cdot 10^{-3}$	45	$0.18 \cdot 10^{-3}$
HDI Al	28	$0.31 \cdot 10^{-3}$	28	$0.31 \cdot 10^{-3}$
polyimide support	25	$0.09 \cdot 10^{-3}$	≈ 30	$0.10 \cdot 10^{-3}$
adhesives	10	$0.03 \cdot 10^{-3}$	10	$0.03 \cdot 10^{-3}$
total	158	$1.15 \cdot 10^{-3}$	163	$1.16 \cdot 10^{-3}$

Table 3
Material budget of a MuPIX ladder. The thicknesses and radiation length are given as an average over the 23 mm width of the ladder.

992 The inner layers do not have v-folds and are supported
993 by the polyimide support structure, see Figure 39.

994 Every ladder is electrically divided into two halves
995 and MuPIX sensors are read out from both ends of
996 the ladder, i.e. three sensors per half ladder for the
997 inner layers and eight or nine sensors per half for the
998 outer layers. The components of the MuPIX ladders
999 and modules are described in the following in more detail.
1000

1001 7.2.4. Sensors

1002 The MuPIX sensors are monolithic pixel sensors in
1003 HV-CMOS [22] technology. A full discussion of the
1004 functionality of the MuPIX sensors as well as detailed
1005 performance results can be found in chapter 8. For the
1006 purpose of this section we discuss geometric properties
1007 and aspects relevant to the physical connectivity be-
1008 tween the sensors and the outside world. Each sensor
1009 has a sensitive area of $20.48 \times 20.00 \text{ mm}^2$ equipped with
1010 pixels of size $80 \times 80 \mu\text{m}^2$, corresponding to 256×250
1011 pixels. The overall dimensions of each chip are $20.66 \times$
1012 23 mm^2 , where the additional non-sensitive area hosts a
1013 comparator and memory cells for each pixel, as well as
1014 voltage regulation and digital logic circuits. All MuPIX
1015 sensors will be thinned to a thickness of $50 \mu\text{m}$. The
1016 MuPIX sensors can send data over up to three serial
1017 links, each running at a data rate of 1.250 Gbit/s. The
1018 sensors require an operating voltage of 1.8 V, a sensor
1019 bias voltage of up to -100 V , ground potential, and dif-
1020 ferential signal traces for the readout, clock, slow con-
1021 trol and monitoring. Bond pads of size $200 \times 100 \mu\text{m}^2$
1022 provide all electrical connections. All pads are arranged
1023 in one row in the inactive peripheral area of the chip.

1024 7.2.5. High Density Interconnects

1025 The High Density Interconnects (HDI) provide all
1026 electrical connections for the MuPIX sensors which are
1027 directly glued onto the HDI after which electrical con-
1028 nections are made using SpTAB-bonding. In order to
1029 achieve the target material budget of one per mille of
1030 a radiation length per layer, the HDIs have to be very
1031 thin and must not contain any high Z materials. The
1032 HDIs are produced by LTU Ltd. (Ukraine) [24], who

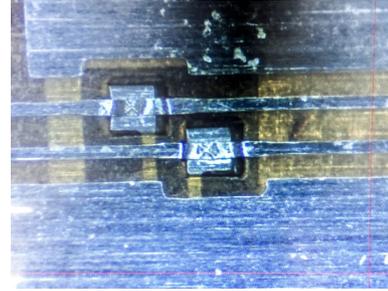


Figure 44: Photograph of two SpTAB bonds on a test flexprint produced by LTU Ltd [24].



Figure 45: Stack chosen for the LTU produced 2-layer HDI circuits. PI=polyimide, Al=aluminium.

1033 offer thin aluminium/polyimide technology as well as
1034 preparing the HDI for SpTAB-bonding. With the lat-
1035 ter, aluminium traces are directly connected through
1036 vias either to chip pads or to other aluminium layers,
1037 see Figure 44 for an image of such bonds. This tech-
1038 nique avoids the use of fragile wires and also saves ma-
1039 terial. Tests with prototypes circuits have shown good
1040 results [25].

1041 The performance of all electrical lines on the HDI is
1042 critical to the successful performance of the MuPIX lad-
1043 ders. The traces for power and ground have to be large
1044 enough to provide the required power of up to 30 W
1045 on the longest MuPIX ladders. On the other hand,
1046 all traces should be as small as possible to fit them in
1047 the two aluminium layers available within the material
1048 budget. All fast signals (serial links, clocks, resets, etc.)
1049 are implemented using the LVDS standard to minimise
1049

Material	Thickness [μm]	X/X_0
upper Al layer	14	$1.57 \cdot 10^{-4}$
insulator (PI)	35	$1.22 \cdot 10^{-4}$
glue	10	$0.25 \cdot 10^{-4}$
lower Al layer	14	$1.57 \cdot 10^{-4}$
lower PI shield	10	$0.35 \cdot 10^{-4}$
total	83	$4.96 \cdot 10^{-4}$

Table 4
Material composition of the HDI for a $Z_{\text{diff}} = 100 \Omega$ prototype.

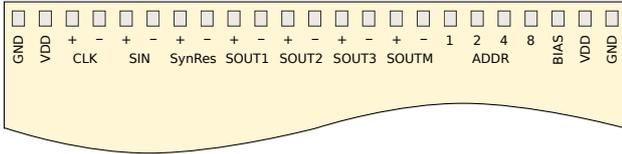


Figure 46: Conceptual MUPix pad layout on the HDI. Depending on location, either SOUT1 to SOUT3 or SOUTM is connected to accommodate for different data rate needs (vertex or recur layers, respectively). Power and ground have multiple pads to reduce effects of voltage drop.

production yield.

1084

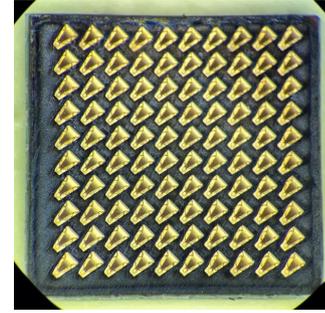


Figure 47: Interposer ZA8 from Samtec, version with 10×10 connections. The pins have a pitch of 0.8 mm

The MUPix ladders will be electrically connected to the end-rings by interposers. The chosen interposer from Samtec (ZA8H)[26] is a type of flat connector allowing for high speed electrical signal transmission up to 30 GHz, see Figure 47, with a high density of connections and a total thickness (compressed) of 0.3 mm.

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7.2.6. Module End-Pieces

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The end-pieces of the inner layers consist of half-arcs made from PEI¹⁶ to which the polyimide support structure and the MUPix ladders are glued. The end-pieces of layer 1 (layer 2) have a four (five)-fold segmentation, see Figure 48.

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The end-pieces of the outer layers have a fourfold segmentation and include an internal open volume to distribute helium gas for the cooling-system, see Figure 49. To realise the internal volume for helium distribution the endpieces are manufactured out of a main part with a thin lid, glued on, to seal the open volume after machining. The endpieces also accommodate the

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¹⁶We use this insulator material to mitigate the risks of eddy currents in case of magnet quenches.

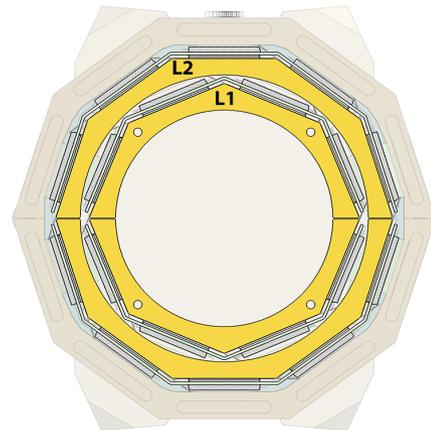


Figure 48: Holding end-pieces and end-rings of the inner layers with the octagonal (layer 1) and decagonal (layer 2) geometry, shown in yellow.

cross-talk. The differential impedances of all fast differential transmission lines are designed to match the specification. Differential bus terminations are foreseen on the last chip in a row, i.e. at the centre of the HDI. All fast differential transmission lines are laid out underneath wide ground and VDD potential traces which serve as shielding and define the impedance. With a minimum possible width of the aluminium traces of $63 \mu\text{m}$ (LTU), the distance between signal and shielding layer is $45 \mu\text{m}$ with polyimide as the insulator. The thickness of the insulator and aluminium layers and the outer shielding define the total thickness and thus the material budget of the HDI. The main parameters of the HDIs are listed in Tables 4 and 5 and a schematic stack is shown in Figure 45.

Space constraints on the HDI have motivated the use of a minimal set of traces for power, control and readout. Differential buses are used for slow control, clock and reset. Global power and ground lines are foreseen. Voltage gradients between sensors due to path length dependent ohmic losses are minimised by design. The remaining small voltage differences are planned to be equalised using voltage regulators implemented in the MUPix chip. A fall-back design solution is to place these voltage regulators on the end-ring and to route the power and ground lines point-to-point to every single – or a small group – of sensors.

Every pixel sensor is electrically connected by only 21 pads, see Figure 46. Four address bits, selected by SpTAB bonding pads to ground or the supply voltage bus are used to set the chip address for the uplink communication bus. All bond pads have a relatively large size of at least $150 \times 150 \mu\text{m}^2$ to fulfil the specification requirement for SpTAB-bonding and to ensure a high

	layer 1&2	layer 3	layer 4
HDI length [mm]	140	360	380
instrumented area [mm ²]	120 × 20	340 × 20	360 × 20
number of MUPiX chips	6	17	18
<i>the following numbers refer to ladder halves</i>			
number of traces:			
bias (HV) (BIAS)	1	1	1
1.8 V (VDD)	1	1	1
ground (GND)	1	1	1
number of differential pairs:			
data (SOUT)	3 × 3	9 × 1	9 × 1
clock bus (CLK)	1	1	1
reset bus (SynRes)	1	1	1
slow control bus (SIN)	1	1	1

Table 5

Specification of the HDIs for inner and outer layers. All lines have a shared bus topology except for the fast data lines (SOUT), which are point-to-point. Note that the numbers of electrical lines refer to each half of the HDI.

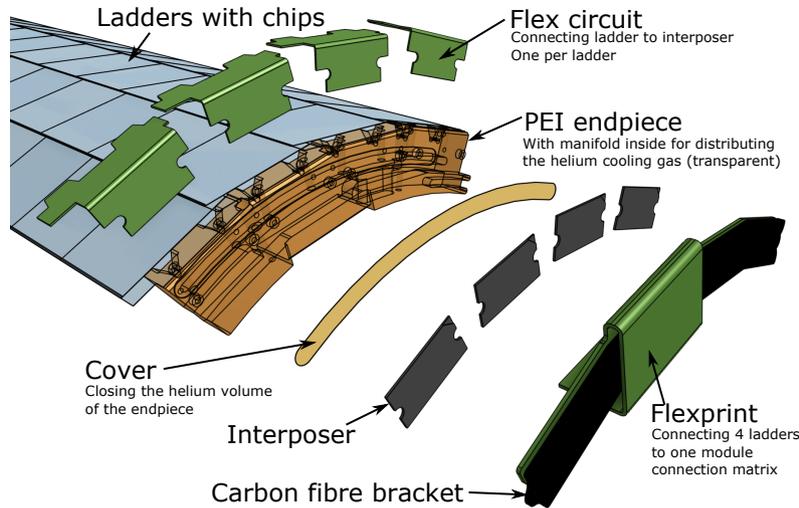


Figure 49: Exploded view of the outer layer module assembly. The end piece region provides a manifold for distributing the helium cooling gas and holds the flexible circuits to connect ladders to a single electrical connection matrix on the bottom.

1104 interposer connectors for power, control and data trans-
1105 mission.

1106 **7.2.7. MUPiX Ladder Integration and Chip**
1107 **Bonding**

1108 During fabrication of the MUPiX ladders, chips are
1109 placed accurately on the HDI by use of fiducial marks
1110 on the chips and cut-outs on the HDI. The chips are
1111 then glued using an epoxy (Araldite 2011) and the posi-
1112 tions are checked again. The flex circuit for connecting
1113 to the interposer is placed and glued in a similar man-
1114 ner. After curing, all connections between the HDI and
1115 each chip, and between the HDI and the interposer are
1116 SpTAB-bonded (any vias on the HDI are bonded be-
1117 forehand by the manufacturer). Once all the connec-
1118 tions are in place, the unit is electrically fully func-
1119 tional. This allows for the comprehensive quality test-

ing of a MUPiX ladder before they are assembled into
1120 modules.
1121

1122 **7.3. Pixel Tracker Global Mechanics**

1123 Pixel tracker inner and outer layer modules are inte-
1124 grated into the full cylindrical tracking layers by mount-
1125 ing the modules to the inner or outer layer pixel end-
1126 rings. The latter in turn are connected to the up- and
1127 downstream beam-pipes. Like the module endpieces
1128 these are manufactured out of PEI. For the inner lay-
1129 ers the endrings have gas inlets and outlets to provide
1130 the helium flow between layers 1 and 2.

1131 A drawing of an outer layer end-ring equipped with
1132 a layer 3 module is shown in Figure 50. The outer end-
1133 ring supports six modules of layer 3 and seven modules
1134 of layer 4. The end-rings have dowel pins for every
1135 module to guide the module when it is rotated into

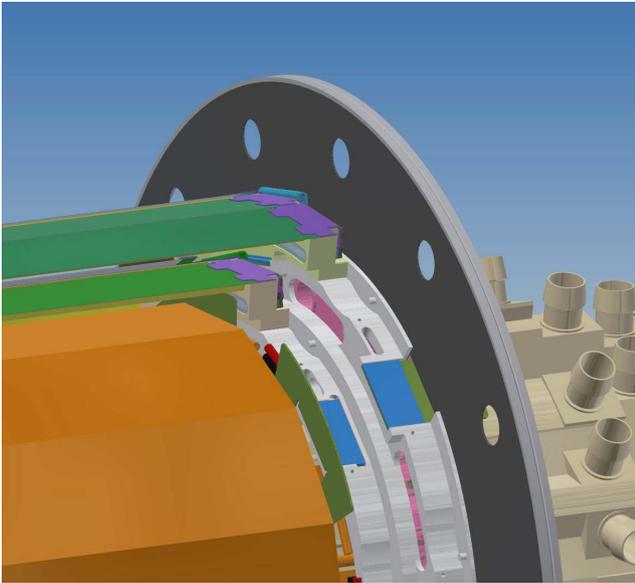


Figure 50: End-ring situation shown with modules inserted in layers 3 and 4.

1136 position, ensuring no accidental contact is made with
 1137 already mounted modules during installation. The final
 1138 mechanical connection is done with screws. This
 1139 also secures the contact through the end-ring interposer
 1140 which provides the further electrical connection from
 1141 the module, via the front-end flexprints, to the front-
 1142 end boards, from where the steering and control of the
 1143 MUPIX sensors is handled and where the signal pro-
 1144 cessing is done.

1145 The outer layer end-rings provide conduits for the
 1146 helium gas flow between layers 3 and 4 and to the mod-
 1147 ule end-pieces for the gas flow in to the v-fold channels.
 1148 At the upstream end, the inner and outer end-rings are
 1149 rigidly connected to the beampipe. At the downstream
 1150 end, the end-rings are supported by bearings and con-
 1151 nected via a small spring tension such that the down-
 1152 stream end-rings can move along the beam direction to
 1153 accommodate thermal expansion of the ladders.

1154 7.4. Pixel Tracker construction and Quality 1155 Control

1156 The production workflow of the pixel detector parts
 1157 consists of manufacturing steps and quality control points,
 1158 shown in Figure 51. The manufacturing steps make
 1159 use of custom-made tooling for careful picking and ac-
 1160 curate placing of parts. To protect parts from dam-
 1161 age and contamination, manufacturing will take place
 1162 in controlled environments, e.g. cleanrooms of suitable
 1163 levels, and standard ESD protection procedures will be
 1164 in place. Polyimide expands when exposed to humidity.
 1165 All manufacturing steps crucial to defining tolerances
 1166 will be carried out in environments with strict temper-
 1167 ature and humidity control and material will be stored
 1168 therein for proper equilibration prior to use. Raw parts
 1169 are either obtained from suppliers (e.g. MUPIX, HDI,

interposer, etc.) or made in-house using custom tool- 1170
 ing (e.g. polyimide folds) or CNC machines (e.g. end- 1171
 pieces). 1172

Quality control takes place before and after every 1173
 manufacturing step. Tests include (but are not lim- 1174
 ited to): visual inspection, dimension control, electri- 1175
 cal testing, and gas leak testing. All components and 1176
 their test results are tracked and documented in a pro- 1177
 duction database. Raw parts will be acceptance tested 1178
 upon receipt. In case of the MUPIX chips, electrical 1179
 testing will take place on the wafer, and on single die 1180
 after dicing, using appropriate probe cards. Thanks to 1181
 the modular design of the process, full electrical test- 1182
 ing of all intermediate products is possible and foreseen. 1183
 This includes the possibility to check sensor response 1184
 using lasers or lab-grade radioactive sources. 1185

1186 7.4.1. Inner Pixel Layers: Ladder and Module 1187 Production

The full inner pixel production and assembly takes 1188
 place at Heidelberg. The small nature of this detec- 1189
 tor part (18 ladders with 6 chips per ladder) makes a 1190
 manual procedure a cost-effective choice. 1191

Chips are positioned relative to each other and to 1192
 the interposer flexes on a custom jig. The interposer 1193
 flexes define the position of a ladder on the endrings. 1194
 The positioning is done by moving the chips with a 1195
 sliding block and fixating each chip at the desired po- 1196
 sition by vacuum (Figure 52). While the position of the 1197
 first chip is defined by a stop edge, following chips are 1198
 placed using a micrometer screw and by monitoring the 1199
 chip-to-chip gap with a microscope¹⁷. 1200

Epoxy (Araldite 2011) is applied to the chips and 1201
 the interposer flexes manually in small dots. The HDI is 1202
 aligned to the chips and flexes by fiducial marks on both 1203
 parts under the microscope. Weights ensure flatness 1204
 and a uniform distribution of glue. A finished prototype 1205
 ladder on the jig is shown in Figure 53. Prototype 1206
 construction has demonstrated a placement precision of 1207
 $\sigma < 5 \mu\text{m}$ and an average glue thickness of $(5 \pm 4) \mu\text{m}$. 1208

After curing, connections between the chips and the 1209
 HDI and between the interposer flexes and the HDI 1210
 are made using SpTAB bonding. From this point on, 1211
 the ladder is electrically fully functional. Each ladder 1212
 undergoes a basic functionality test including powering, 1213
 configuration and the readout of each MUPIX chip. 1214

Ladders that pass all QA checks are mounted into 1215
 half-shells on custom assembly tools (Figure 54). These 1216
 tools, for layer 1 and layer 2, accommodate the module 1217
 endpieces and are designed such that each facet can be 1218
 brought into the horizontal position for ladder place- 1219
 ment. The ladders are glued consecutively to the poly- 1220
 imide flap of the previously positioned ladder. Again, 1221
 weights ensure flatness and a uniform glue distribution. 1222
 At the same time, the ladders are attached to the PEI 1223
 endpieces by clamping them to a stack comprising the 1224

¹⁷Dino-Lite AM4515T8-EDGE, resolution of 1.5 μm

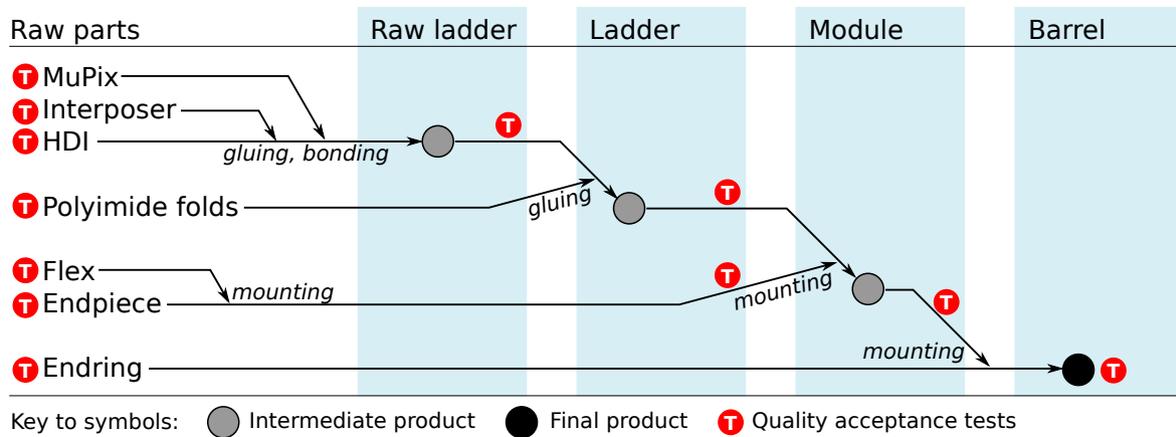


Figure 51: Module manufacturing workflow and quality points. Only main steps are shown.

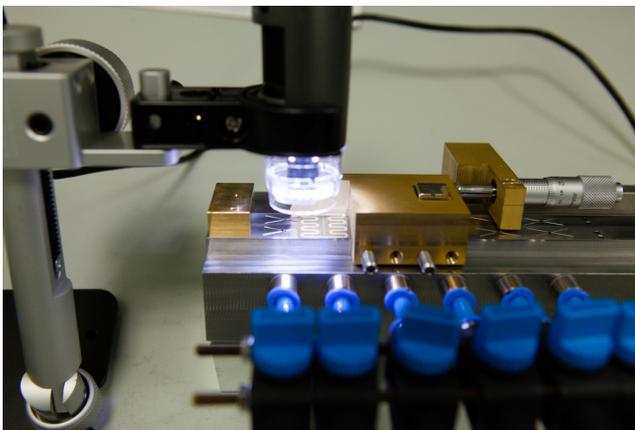


Figure 52: Assembly tool for the inner tracking ladders. Brass sliding block in the middle is guiding a prototype chip into position. Brass stop edge to the left. Micrometer screw to the right. Microscope to monitor position at the top.



Figure 53: Prototype ladder for the inner pixel layers after gluing on mounting tool.

1225 end of the ladder, the interposer and the endpiece flex
 1226 held by a carbon fibre bracket.

1227 **7.4.2. Outer Pixel Layers: Ladder and Module**
 1228 **Production**

1229 Ladder assembly for layers 3 and 4 of the MUPIX
 1230 tracker takes place at the Oxford Physics Microstruc-
 1231 ture Detector (OPMD) Laboratory. To make a ladder,
 1232 18 (17) chips are positioned on a vacuum jig using a 4-
 1233 axis gantry positioning system, integrated with vision
 1234 and electro-valve controls, and custom built tooling (see
 1235 Figure 55). A positioning accuracy within 10 microns
 1236 (see Figure 56) is achieved. After this interposer flex
 1237 circuit is added, located by the jig, glue is deposited
 1238 by a commercial machine vision guided liquid dispens-
 1239 ing robot and the HDI is glued to the chips using a
 1240 counter-jig. Connections between the sensor chips and
 1241 the HDI circuits are made using SpTAB bonding. The
 1242 completed assembly is reinforced with two V shaped,
 1243 folded polyimide support structures glued to each lad-

1244 der. The liquid dispensing robot is used to accurately
 1245 apply the required epoxy to achieve 5 micron thick glue
 1246 layers to adhere sensor chips to the flexprints and poly-
 1247 imide V-folds to the ladders.

1248 The polyimide V-folds are repeatably aligned and
 1249 joined to the ladders using a custom jig with linear
 1250 rails and micrometer adjusters. Semi-automated non-
 1251 contact metrology of components and completed lad-
 1252 ders is performed with an optical probe on a coordinate
 1253 measuring machine.

1254 After testing, MUPIX ladders are shipped to Liv-
 1255 erpool, for the assembly into modules. Upstream and
 1256 downstream module endpieces are mounted to a custom
 1257 jig that defines the overall length of a module. Ladders

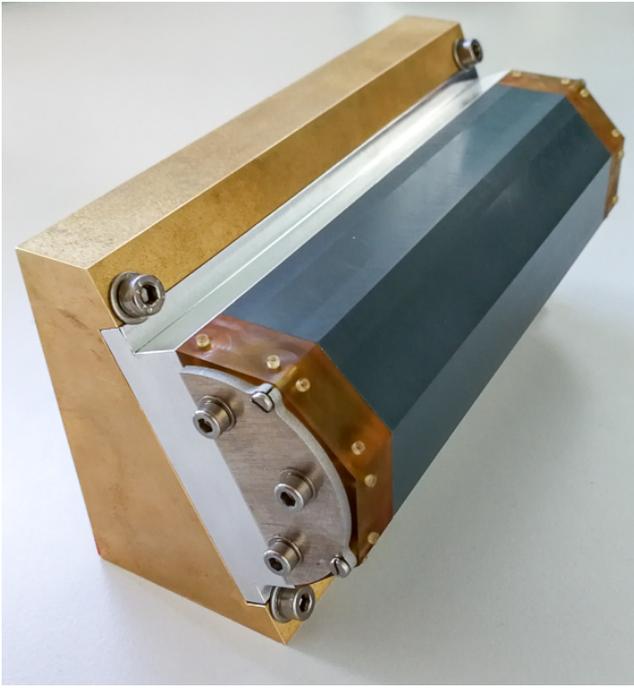


Figure 54: Assembly tool for layer 2 modules. Tilting of the full tool and sliding of the grey block allows to bring every facet into the horizontal position.



Figure 55: Robotic gantry (upper figure) for placement of 17 or 18 MUPIX chips on the vacuum jig (lower figure).

1258 are positioned and glued onto the endpiece. Glue is ap-
 1259 plied manually to the surface of the endpiece and inside
 1260 the v-shaped cut-out in the endpiece, as well as to the
 1261 underside of the end of each ladder and the outside of
 1262 the polyimide v-channels. Weights are used to ensure
 1263 flatness and a uniform distribution of glue. After four
 1264 ladders are assembled into a module, the v-channels
 1265 on the inward facing side of the module are sealed with
 1266 additional adhesive and electrical connections are made
 1267 by fixing a stack of the ends of the four ladders, four
 1268 interposers and the endpiece flex with a single carbon
 1269 fibre bracket. Modules are checked for gas flow and
 1270 leaks and for electrical conformity.

1271 7.5. Prototyping and System Tests

1272 A programme of manufacturing thermo-mechanical
 1273 prototype modules for both the inner and outer layers
 1274 of the MUPIX tracker has been used to develop and
 1275 commission the assembly tooling and processes. At the
 1276 same time the built modules are intended to provide a
 1277 testbed, called the *thermo-mechanical mockup* (TMM),
 1278 to develop and demonstrate the helium cooling concept
 1279 for the MUPIX tracker. Modules for the TMM provide
 1280 a close match to the final detector in terms of their
 1281 mass and materials used and provide the means to dis-
 1282 sipate heat loads, matching those in the real detector
 1283 into the structure. Circuitry to monitor temperatures
 1284 is also incorporated. Modules are built out two types
 1285 of ladders:

1286 Silicon heater ladders closely match the material
 1287 stack of the final detector. Silicon heater chips (Fig-

ure 57) have been manufactured at the Max-Planck
 Halbleiterlabor in Munich using sputtered aluminium
 on silicon without a passivation layer. A meander with
 $R = 3.24 \Omega$ allows heat to be generated in the chip
 in the range of 1 to 1.6 W with similar voltages as for
 MUPIX chips. An additional meander with $R \approx 1000 \Omega$
 is used as a resistance temperature detector (RTD)
 to measure the temperature in situ. The chips are
 thinned to 50 μm thickness. Ladders are fabricated us-
 ing adapted versions of the HDI with the same stack
 as foreseen for the detector (Figure 58). Connections
 are made with SpTAB bonding. The manufacturing
 steps needed and tooling used are the same as for de-
 tector fabrication, providing the ideal test bed to de-
 velop, commission and qualify the tooling and processes
 for the final detector production.

Tape heater ladders are simpler objects, based
 around an aluminium-polyimide laminate (Figure 59)
 resistive heating circuit that has the same shape as the
 HDI plus interposer flex assembly in the final detector.
 Laser cutting and etching are used to manufacture the
 tape heater flexes in sizes corresponding to inner lad-
 ders ($R \approx 0.5 \Omega$) and outer ladders ($R \approx 3.7 \Omega$).
 To create a more realistic mechanical model and material
 budget, 50 μm thick stainless steel dummy chips can be
 attached if needed for specific test purposes. This more

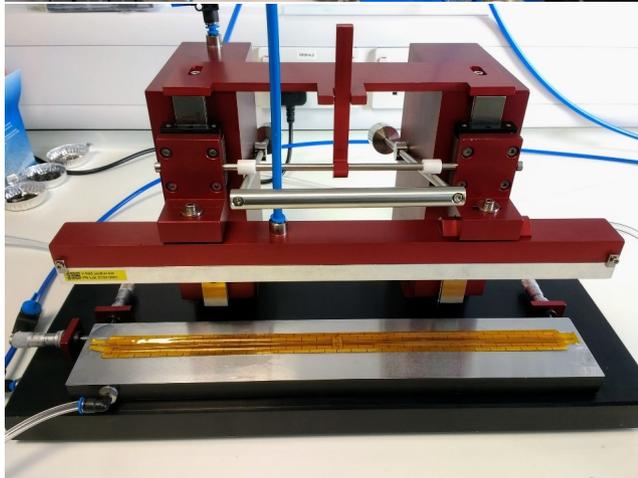


Figure 56: Glue dispensing robot (upper figure) and custom tooling for the gluing of v-channel reinforcements (lower figure).

1314 cost-effective option is used for simpler manufacturing
1315 tests and to instrument most of the full TMM.

1316 The TMM is assembled by assembling the silicon
1317 heater and tape heater ladders into modules and barrels
1318 using the same mechanical components as are use in the
1319 final detector. With the heating capabilities and all the
1320 cooling facilities in place, realistic measurements of the
1321 cooling and mechanical stability will be possible. Tests
1322 stands for intermediate and final assemblies have been
1323 developed in preparation for the final testing of detector
1324 assemblies. All manufacturing steps are taking place at
1325 the locations foreseen for detector fabrication.

1326 An example of ladders manufactured for the TMM
1327 is shown in Figure 60.

1328 7.6. Pixel Tracker Cooling

1329 The full pixel detector will dissipate about 4.55 kW
1330 of heat¹⁸ in a *conservative scenario* assuming 400 mW/cm².
1331 The latest chip versions have shown a heat dissipation
1332 below 250 mW/cm². This heat load is used for our
1333 most *realistic scenario*. Table 6 shows expected heat
1334 load in each layer of the tracker under these two sce-

¹⁸Throughout this section, heat from chips and losses in conductors inside the HDI are taken into account, summing up to the heat density used in the scenarios.

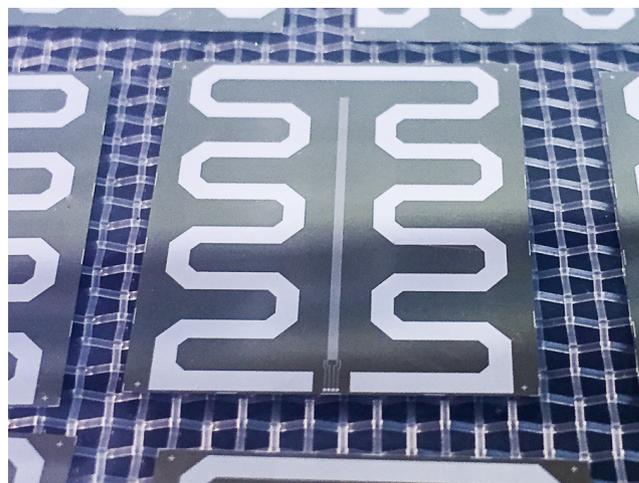


Figure 57: Silicon heater chip. The large meander for heating the chip and a narrow meander used as an RTD can both be seen. Contact pads are arranged on the bottom edge corresponding to the final chip connection locations.



Figure 58: HDI for silicon heaters, layer 1 and 2. Six silicon heaters can be mounted on the back side.

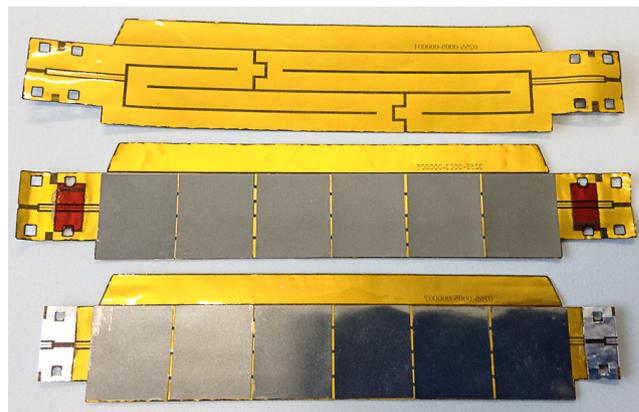


Figure 59: Tape heaters for layer 1 and 2. Top to bottom: bare heater with meander, stiffener attached to match final dimensions, dummy chips glued on. Large contact pad pair on both ends used for powering. Chip size 20 × 23 mm².

1335 narios. The cooling system must keep the maximum
1336 temperature, anywhere in the pixel detector, safely be-
1337 low 70 °C, given by the glass-transition temperature of
1338 the adhesives used for construction.

1339 We use gaseous helium at ambient conditions¹⁹ as
1340 coolant. The helium is distributed in separate circuits,
1341 serving different parts of the detector separately. The

¹⁹This means temperatures above 0 °C and the absolute pressure around 1 bar.

Mu3e technical design

Detector Part	Area [cm ²]	250 mW/cm ² [W]	400 mW/cm ² [W]
layer 1	192	48	77
layer 2	240	60	96
layer 3	1632	408	652
layer 4	2016	504	807
Recurl Station (2×)	3648	912	1459
total	11376	2844	4550

Table 6

Heat dissipation of the pixel detector for a power consumption of 250 mW/cm² (realistic scenario) and 400 mW/cm² (conservative scenario).

No.	Description	#	Inlet			Outlet	
			\dot{m} g/s	Δp mbar	v m/s	\dot{m} g/s	Δp mbar
1	Gap flow vertex detector	1	2.0	+40	10	2.0	-40
2	Gap flow b/w SciFi and L3	1	6.9	+25	10	0	0
3	Gap flow b/w SciTile and L3	2	5.7	+28	10	0	0
4	Gap flow b/w L3 and L4	3	7.6	+25	10	0	0
5	Flow in V-folds L3	3	1.3	+90	20	1.3	-90
6	Flow in V-folds L4	3	1.5	+80	20	1.5	-80
7	Global flow, $D \approx 300$ mm	1	4	+0.04	var.	45	-0.04
Total		14	56		56		

Table 7

List of helium circuits inside the experiment. Pressures are given relative to ambient in the experiment and were obtained from CFD simulations. Circuits with outlet flows and pressures of 0 vent into the main volume, collected in the global flow outlet. The total flow corresponds to about 20 m³/min under standard conditions. Column # gives number of identical circuit copies in the detector.

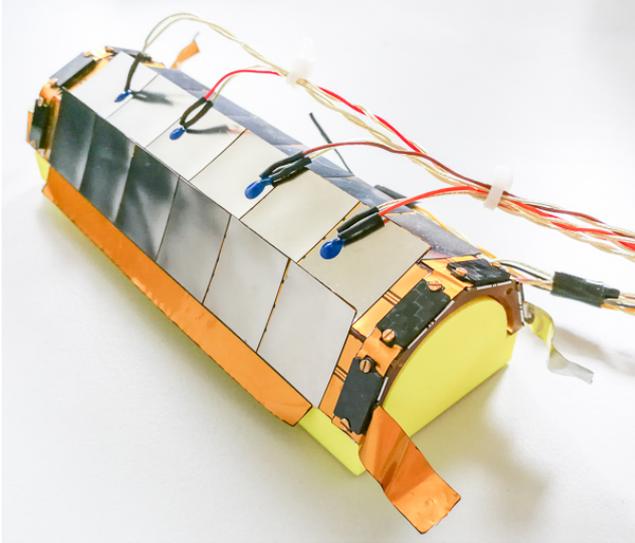


Figure 60: Layer 1 half shell made with tape heaters and stainless steel dummy chips, placed on a handling block (yellow). RTDs attached with conductive glue for temperature profiling in cooling tests.

rectly venting into the global flow. The global flow is constrained by a thin mylar foil (thickness 5 μ m) surrounding the full pixel detector in a conical shape that keeps the helium velocity near constant along z (see Figure 41).

The system described is the result of a process of optimisations through simulation studies using computational fluid dynamics (CFD)²⁰ and verifications in the laboratory [27, 28, 29, 30, 31, 32]. The models used in both simulation and laboratory measurements progressed in detail and the final mock-up models described in section 7.5 match the final detector to a great extent in shape, materials and heat-density. The heat-load density distribution used in the simulations take care of the uneven heat density on the pixel chip. Half of the power dissipation on the chip is expected to be located on the periphery, the remaining half within the pixel matrix, equivalent to 200 mW/cm² and 1730 mW/cm² respectively, for an averaged 400 mW/cm² in the conservative scenario. Simulation results for the pixel tracker are shown in Figure 62, confirming a safe ΔT even in the conservative scenario. In simulations with the realistic scenario the obtained ΔT values have been found to scale down linearly with the reduced

²⁰Autodesk® and ANSYS CFX® CFD software were used.

1342 concept is shown in Figure 61 and the different helium
1343 circuits are listed in Table 7. The flow in the global
1344 circuit increases along z because of other circuits di-

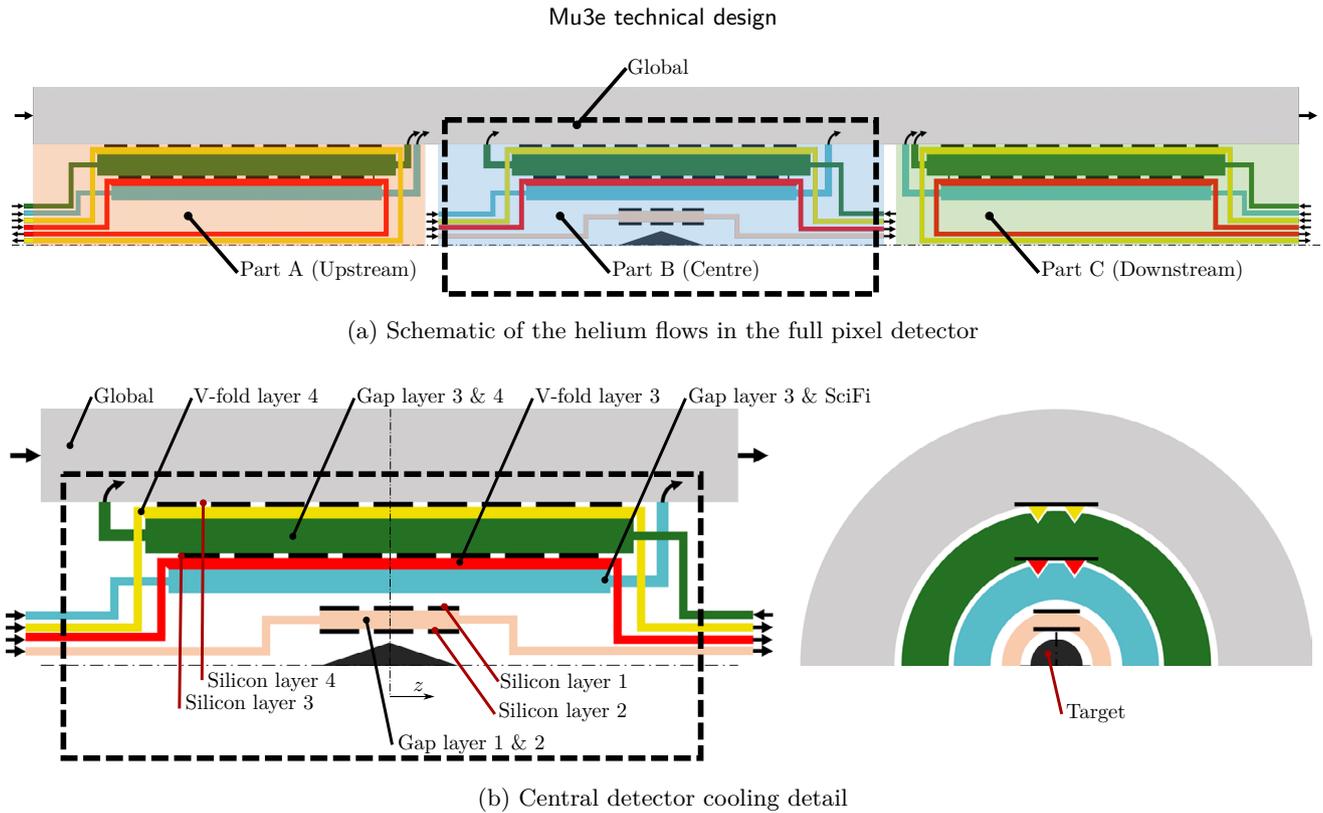


Figure 61: Sketch of the helium cooling system for the pixel detector. (a) shows all volumes with its flow directions in a cut view. The system is cylindrically symmetric around the long dashed-dotted line. Some volumes vent into the global flow inside the experiment, indicated by bent arrows. Every circuit is individually controlled for flow and pressure inside the detector volume. (b) shows a cut in the transverse direction as well. The triangles (in red and yellow) indicate the V-fold channels, which exist in pairs for every ladder.

1369 power dissipation and are therefore not shown.
 1370 The experimental cooling tests were performed inside a cylindrical closed volume with a diameter of
 1371 22 cm and a length of approximately 1 m. Helium was initially provided by compressed gas bottles, limiting
 1372 measurements to a few minutes. This was overcome by using a miniature turbo compressor (described in
 1373 chapter 12) allowing for helium recirculation and hence continuous operation. The agreement between simulation
 1374 and mock-up measurements are good, see Figure 63 for an example comparison for the vertex detector [33].
 1375 Vibrations induced by the helium flows must not damage the structures or have a substantial impact on
 1376 the hit resolution. Such vibrations were studied using a setup based on a Michelson interferometer pointing
 1377 to reflective surfaces on a realistic mock-up. For velocities up to 20 m/s, average amplitudes of 2 μm were
 1378 observed, with peaks of 10 μm [34, 30, 35]. This is well below the single hit resolution of the pixel sensors. An
 1379 excitation spectrum using a speaker showed resonances between 50 Hz to 1000 Hz with no major peaks. No
 1380 damage to the test structures has been observed during these studies.

Table 8

This is a placeholder table for technical reasons and will go away in the final version. Please disregard.

8. MUPIX Pixel Sensor

This section is currently missing and will be handed in later. It will describe the MUPIX sensor in great detail, including its functionalities, properties and results from performance measurements.

9. MuTRiG

A common Application Specific Integrated Circuit (ASIC) has been developed for both the fibre and tile detectors in Mu3e, capable of operating with the rather different conditions of the two systems.

9.1. Introduction

MuTRiG (Muon Timing Resolver including Gigabit-link) is a 32 channel, mixed-signal Silicon photo-multiplier (SiPM) readout ASIC designed and fabricated in UMC 180 nm CMOS technology. It has been developed to read out the fibre and tile detectors in Mu3e, and is designed to achieve the required timing resolution for

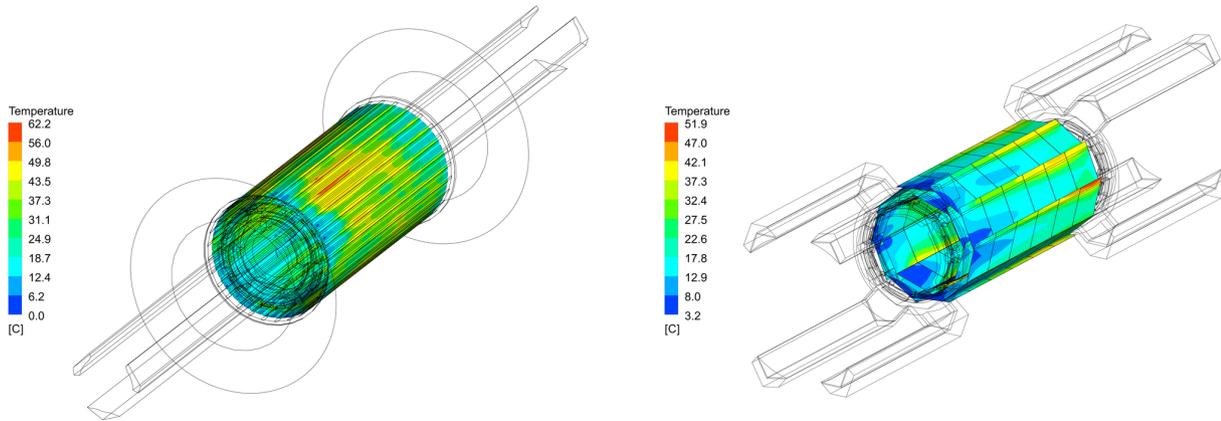
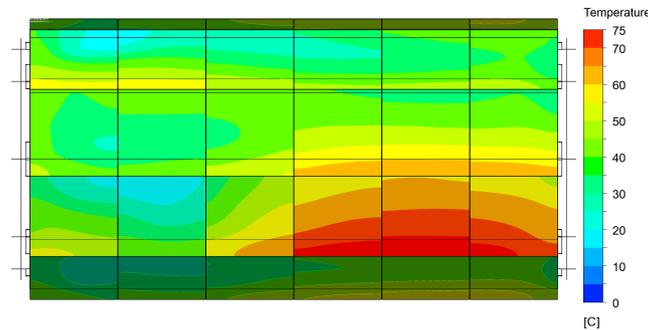
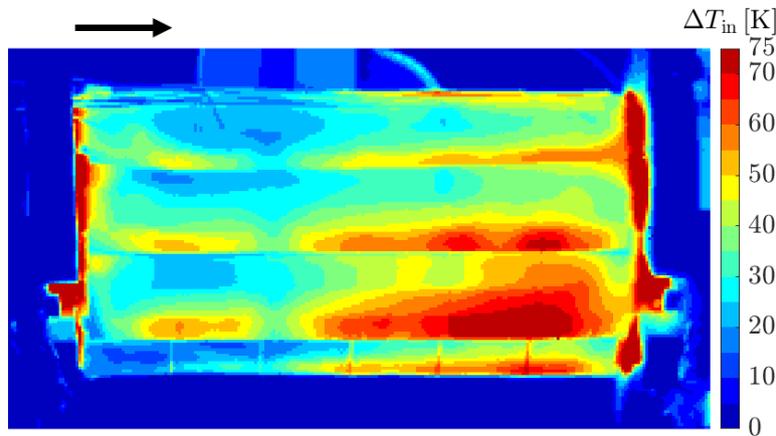


Figure 62: Simulated ΔT distribution of the silicon in the tracking detector for a power dissipation of 400 mW/cm^2 (non-uniform distribution, more heat power at periphery edge). Inlet gas temperature is $T = 0^\circ\text{C}$ Left: full barrel. Right: vertex barrel inside the full barrel.



(a) Simulated temperature on the outer layer of the mock-up.



(b) Measured temperature on the outer layer of the mock-up using an infrared camera.

Figure 63: Temperature obtained by measurement and CFD-simulation. Angle of view of simulation has been carefully matched to the camera view. Cold helium enters from the left. Hot zones on the right of (b) are cable connections from the setup not present in the final detector.

Figure 64: This is a placeholder figure for technical reasons and will go away in the final version. Please disregard.

both systems while keeping up with the high event rate 1409
in the scintillating fibre detector. 1410

9.2. ASIC Description 1411

MuTRiG is an evolutionary development from the 1412
STiCv3.1 chip developed at the Kirchhoff Institute in 1413

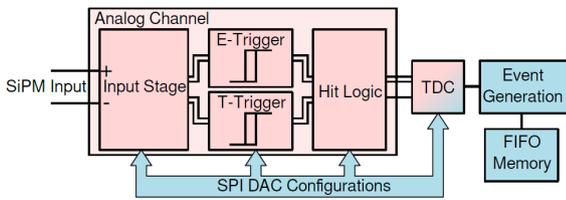


Figure 65: Diagram of a MuTRiG channel. After taking signal from SiPM by the input stage, separate are provided to the T-Trigger and E-Trigger branches for time and energy discrimination respectively. The discrimination signals are encoded in the hit logic module to generate the combined hit signal, and then converted to digital time stamps after the TDC module. The signal is then buffered in the on-chip memories before being transferred out of the chip. The analogue front-end, TDC and digital modules are configured using a Serial Peripheral Interface (SPI) interface

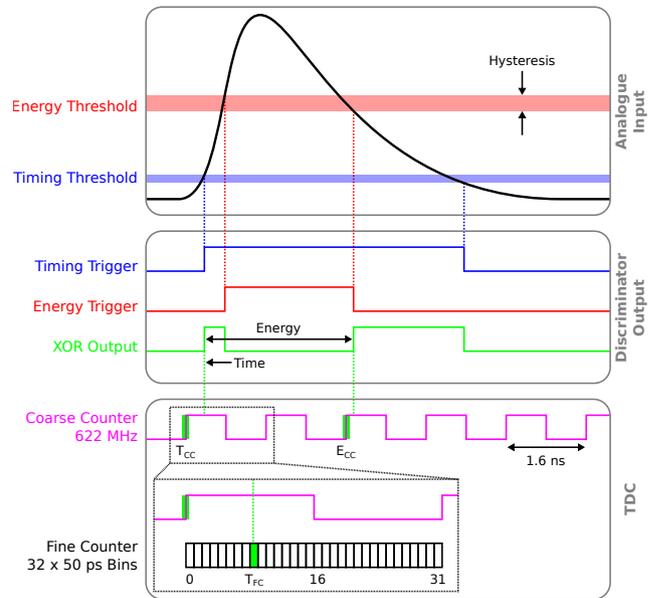


Figure 66: Sketch of the functionality of the MuTRiG chip. The time and energy information of the analogue input signal is obtained via two discriminator units. The discriminator output is processed by a TDC with a 625 MHz coarse counter and a fine counter with a bin size of 50 ps.

1414 Heidelberg for medical applications of SiPMs (EndoTOFPE
1415 US [36]).

1416 The analogue processing building blocks of MuTRiG
1417 inherit from the STiCv3.1 chip, whose satisfactory per-
1418 formance has been validated in several testing condi-
1419 tions. However, the STiCv3.1 chip is only capable of
1420 transferring ~ 50 kHz per channel through the 160 Mbit/s
1421 data link, which is too slow for the Mu3e timing detec-
1422 tors, especially for the fibre detector which is required
1423 to handle 1 MHz/channel event rate to achieve 100%
1424 data acquisition efficiency. The MuTRiG chip extends
1425 the excellent timing performance of the STiCv3.1 chip
1426 with a newly developed fast digital readout for high
1427 rate applications.

1428 Figure 65 shows the channel diagram of the MuTRiG
1429 chip and Figure 66 shows the sketch of the chip func-
1430 tionality. (More details can be found in [37].)

1431 The good timing resolution of MuTRiG derives
1432 from its differential analogue front-end and the 50 ps
1433 binning time-to-digital converter (TDC), which were
1434 inherited from the STiCv3.1 chip. The working princi-
1435 ple of a TDC is shown in Figure 67. At the arrival of
1436 a hit signal over threshold, the TDC module samples
1437 the state of a *coarse-counter*, which is incremented at
1438 625 MHz by a reference clock. A *fine counter* with 50 ps
1439 bins is then used to make a more precise measurement
1440 of the hit time within the 1.6 ns coarse counter bin.
1441 The coarse and fine counter values are then recorded
1442 as the time stamp of the hit signal. The time the sig-
1443 nal drops back below threshold is similarly recorded.
1444 The *Global TimeBase Unit* provides common coarse
1445 and fine counter values to all the channels for time
1446 stamping, as shown in Figure 68. The TDC requires
1447 ~ 30 ns to reset after a hit.

1448 In order to fulfil the high rate data readout, a double
1449 data rate serialiser and a customised low-voltage differ-
1450 ential signalling (LVDS) transmitter were developed to
1451 establish a gigabit data link with the data acquisition

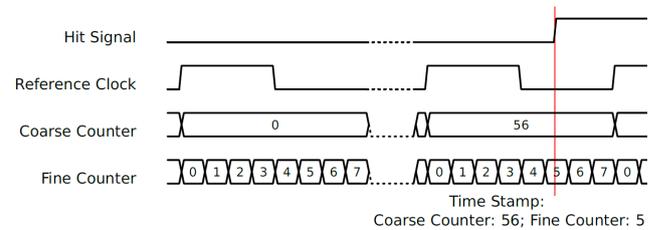


Figure 67: Working principle of the TDC, showing the fine and coarse counters, reference clock and example arrive of a hit signal.

1452 system (DAQ) for data transmission. The event data
1453 from all the channels are buffered and sent out in frames
1454 via the 1.25 Gbps LVDS serial data link. In order to in-
1455 crease the event rate capability of the MuTRiG chip,
1456 the output event structure can be switched from the
1457 standard 48 bits, containing both the time stamps a
1458 hit signal passes above and back below threshold, to
1459 a short event structure of 27 bits, containing only the
1460 first of these times and a 1 bit energy flag of the hit.

1461 A few more new functionalities were implemented in
1462 the digital logic circuit of the MuTRiG chip for conve-
1463 nient and reliable operation of the chip. Table 9 shows
1464 a summary of the major differences in event and data
1465 handling capabilities of the STiCv3.1 and MuTRiG
1466 chips.

9.3. Characterisation Measurement

9.3.1. Rate Limitation Measurement

1467 The event rate limit of the chip is measured by in-
1468 jecting test pulses to multiple channels and measuring
1469
1470

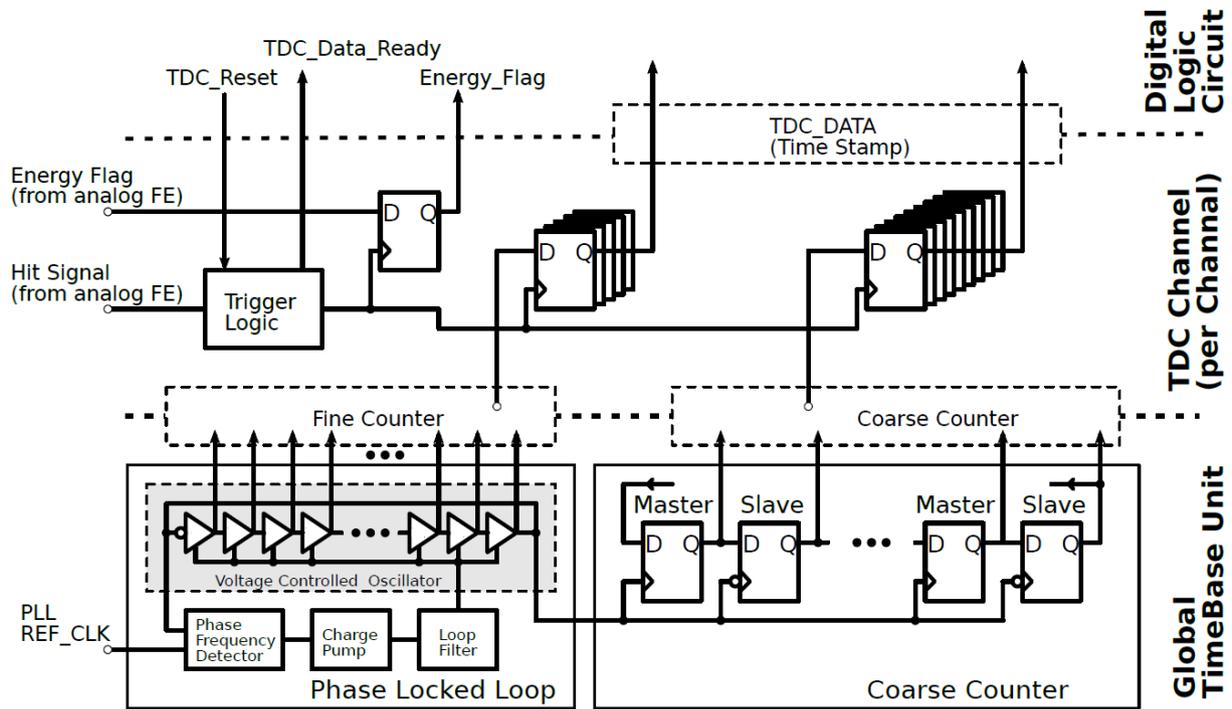


Figure 68: Schematic of the MuTRiG TDC.

	STiCv3.1	MuTRiG
number of channels	64	32
LVDS speed [Mbit/s]	160	1250
8b/10b encoding	yes	yes
event size [bit]		
<i>standard event</i>	48	47
<i>short event</i>	-	26
event rate / chip [MHz]		
<i>standard event</i>	~2.6	~20
<i>short event</i>	-	~38
event rate / channel [kHz]		
<i>standard event</i>	~40	~650
<i>short event</i>	-	~1200
power per channel [mW]	35	35
size [mm x mm]	5x5	5x5
number of PLLs	2	1

Table 9
Comparison of STiCv3.1 and MuTRiG.

1471 the output event rate for a serial data link bit rate of
 1472 1.25 Gbps. Results are shown in Figure 69. For the
 1473 standard event structure configuration of 48 bits, the
 1474 output event rate is limited to 20.24 MHz (on average
 1475 632 kHz/channel) by the bit rate of the serial data link.
 1476 The maximum event rate for the 27 bits short event
 1477 configuration is 25 MHz (781 kHz/channel), 1/5th of
 1478 the system clock frequency(125 MHz).

1479 9.3.2. Jitter Measurement

1480 The jitter found in just the front-end, and in a full
 1481 channel (front-end, TDC and the digital part of the

chip), have been measured. The front-end jitter was
 1482 measured by charge injection over a 33 pF capacitor.
 1483 The time difference between the marker signal from
 1484 the arbitrary waveform generator and the MuTRiG
 1485 timing trigger signal was then measured using a high
 1486 bandwidth oscilloscope. The front-end jitter in five dif-
 1487 ferent cases as shown in Figure 70. The jitter on a full
 1488 channel was measured with input charges of 1 pC and
 1489 an optimised time threshold.
 1490

1491 9.3.3. Test-beam Result

1492 In order to verify the functionality and the timing
 1493 performance of the MuTRiG chip under realistic ex-
 1494 perimental conditions, the MuTRiG chip was tested
 1495 with the Mu3e Tile detector prototype in an electron
 1496 test beam campaign at DESY (Feb. 2018). The setup,
 1497 shown in Figure 71, was the same as a tile detector
 1498 submodule: 16 scintillator tiles arranged in a 4 by 4
 1499 matrix and read out by SiPM photon detectors. Exam-
 1500 ple time-over-threshold spectra and coincidence time
 1501 resolutions are given in Figures 72 and 73. Excellent
 1502 channel-to-channel timing resolutions of <50 ps were
 1503 been obtained over a large chip configuration param-
 1504 eter range, confirming the performance and functionality
 1505 of the chip.

1506 10. The Fibre Detector

1507 To suppress all forms of combinatorial background,
 1508 a very thin detector with good spatial and very good
 1509 timing resolution, very high efficiency, and high rate
 1510 capability is required in the central region of the Mu3e
 1511

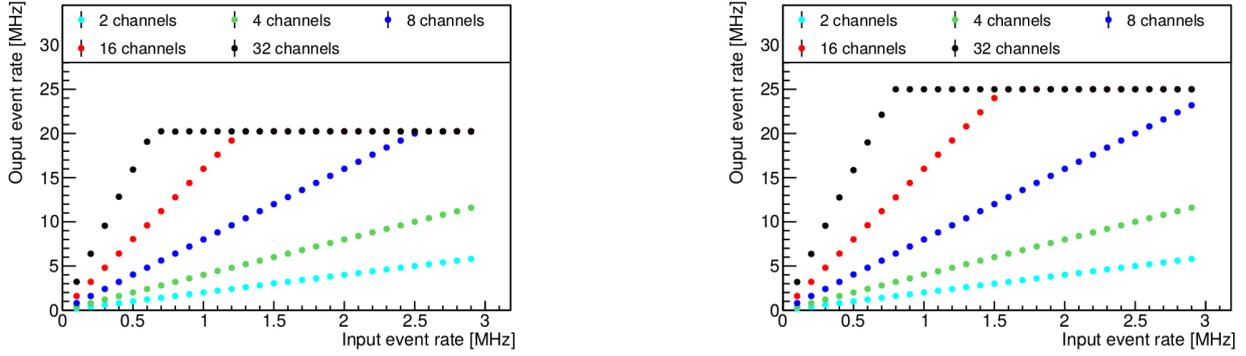


Figure 69: Event rate measurements for the standard output event structure (left) and short output event structure (right).

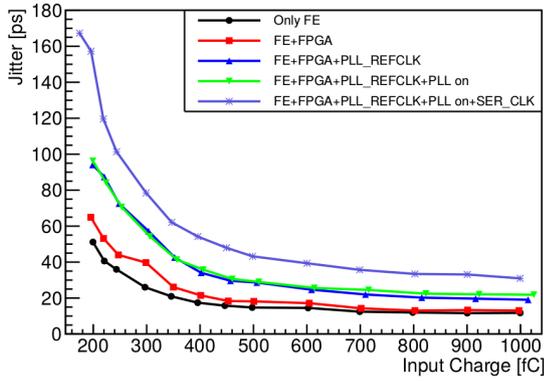


Figure 70: MuTRiG front-end jitter measurement by injecting charge over a 33 pF capacitor.

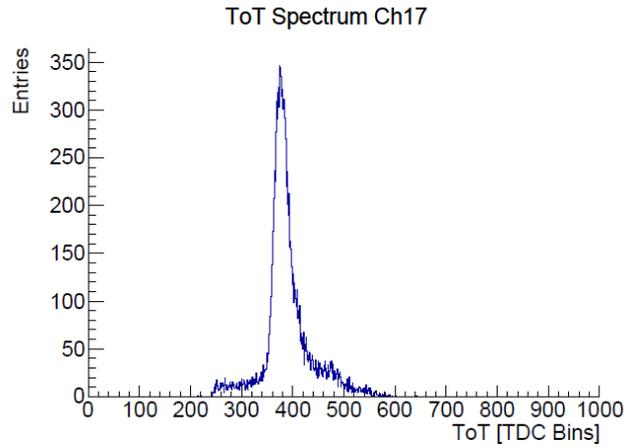


Figure 72: The time-over-threshold (ToT) of minimum-ionising electrons recorded on channel 17.

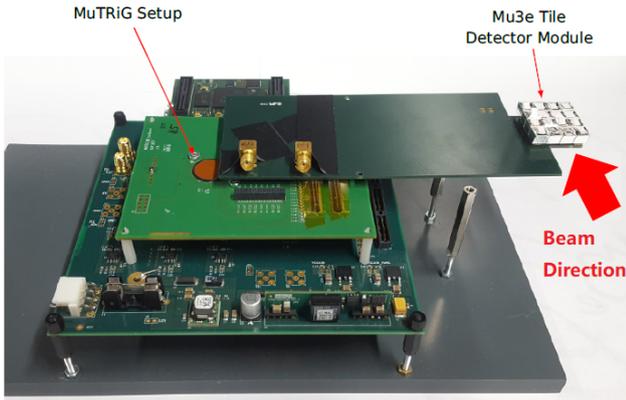


Figure 71: The MuTRiG and Mu3e Tile Detector test beam setup.

constraints in the central part of the Mu3e experiment impose a very compact design on this sub-detector. In addition to timing, the SciFi detector helps resolve the direction of rotation (i.e., the charge) of the recurling tracks in the central region of the Mu3e detector by time of flight measurements.

The SciFi detector is roughly cylindrical in shape, with a radius of 61 mm and a length of about 300 mm (280 mm in the Mu3e acceptance region). It is composed of 12 SciFi ribbons, each 300 mm long and 32.5 mm wide²¹. The width of the ribbons matches the size of the photo-sensor (see below). The detector is located just inside the outer silicon pixel double-layer.

To a SciFi ribbon consists of three layers of scintillating fibres that are staggered in order to assure continuous coverage and high detection efficiency. Figure 75 shows a full size SciFi ribbon prototype. 250 μm diameter round multicladd fibres from Kuraray, type SCSEF-78MJ, were selected. Both ends of the SciFi

²¹This particular value is set by the size of the photo-sensor: the radius of a circle inscribed inside a regular dodecagon with side 32.5 mm, i.e., the size of the photo-sensor, is indeed 61 mm.

apparatus. With this in mind, a thin Scintillating Fibre (SciFi) detector with a time resolution of a few 100 ps, an efficiency in excess of 95 %, a spatial resolution around 100 μm, and a thickness of $X/X_0 < 0.2\%$ has been developed. Figure 74 shows the SciFi detector inside the Mu3e experiment. In particular, the space

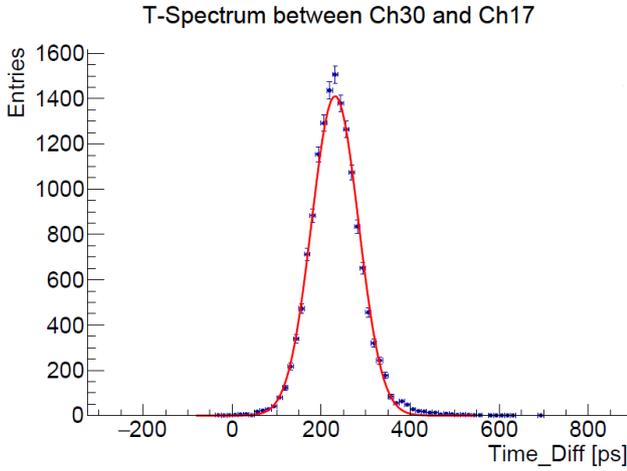


Figure 73: Coincidence timing spectrum between channel 30 and 17.



Figure 75: Full size SciFi ribbon prototype with preliminary holding structure. The SciFi ribbon is formed by staggering three layers of round scintillating fibres.

1536 ribbons are coupled to silicon photomultiplier (SiPM)
 1537 arrays. After careful evaluation the 128-channel Hama-
 1538 matsu S13552-HRQ SiPM array, that has also been
 1539 used in the LHCb experiment, was selected. The SiPM
 1540 arrays are read out with a dedicated mixed-mode ASIC,
 1541 the MuTRiG (chapter 9).

1542 By far the largest source of background to the $\mu \rightarrow$
 1543 eee search comes from the accidental combination of
 1544 positron tracks from muon decays, in which two muons
 1545 decay very closely in space, such that the decay vertices
 1546 cannot be resolved, with at least one decay positron
 1547 undergoing Bhabha scattering and ejecting an electron
 1548 from the target, thus mimicking the topology of a single
 1549 three-prong decay. Such backgrounds can be efficiently
 1550 suppressed by timing. Figure 76 shows the background
 1551 suppression power of the SciFi detector as a function of
 1552 the detector time resolution. Exploiting the fibre detec-
 1553 tor alone, with an estimated time resolution of 250 ps
 1554 and a 90 % overall efficiency, leads to a suppression of
 1555 the accidental background of $\mathcal{O}(3 \cdot 10^{-2})$. Combining
 1556 the fibre and tile (see chapter 11) timing detectors the
 1557 background is further suppressed to $\mathcal{O}(1.4 \cdot 10^{-2})$. For

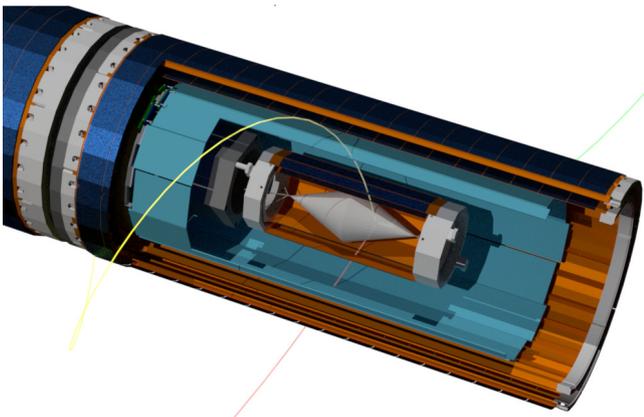


Figure 74: Open view of the central part of the Mu3e detector. The SciFi ribbons are depicted in light blue.

1558 this study, we simulated a Bhabha electron/positron
 1559 pair plus a Michel positron emerging from the same
 1560 vertex and distributed in a 50 ns time window, assum-
 1561 ing a beam intensity of 10^8 stopping μ^+ per second.
 1562 The three outgoing tracks are required to pass the se-
 1563 lection criteria described in chapter 22.

1564 Figure 77 shows the time difference (time of flight)
 1565 between two consecutive SciFi detector crossings of re-
 1566 curving track candidates. The correlation between the
 1567 time difference and the reconstructed trajectory length
 1568 allows one to determine the sense of rotation of the
 1569 track (and thus the charge) and/or to reject mis-reconstructed
 1570 tracks with confused recurring track segments.

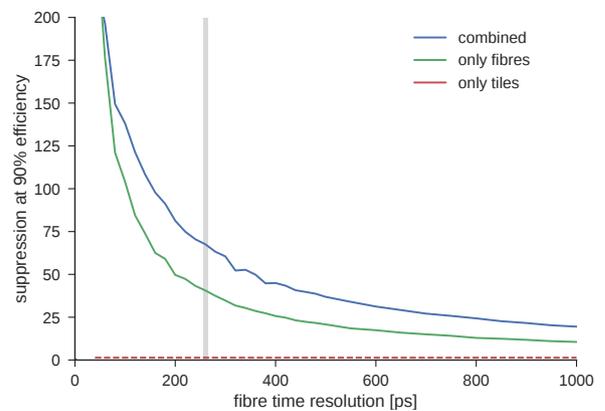


Figure 76: Suppression of Bhabha e^+/e^- pairs plus Michel e^+ accidental background as a function of fibre detector time resolution if only the fibre detector (green) is used or both timing detectors (blue) are used. A time resolution of 60 ps for the tile detector and a working point with a 90 % overall signal efficiency are assumed. The vertical line (in grey) corresponds to a 250 ps time resolution for the fibre detector.

10.1. Scintillating Fibre Ribbons

Three considerations determine the SciFi detector location. Firstly, no material should be placed outside of the fourth silicon pixel layer, where the main momentum measurement is performed. Secondly, it has to be in close proximity to a pixel layer, as the track finding algorithm accounts for multiple Coulomb scattering only in the tracking layers. And thirdly, with larger the radius the SciFi detector occupancy is reduced along with the resulting detector pile-up. The best performance is obtained with the SciFi detector positioned just inside the third silicon pixel layer.

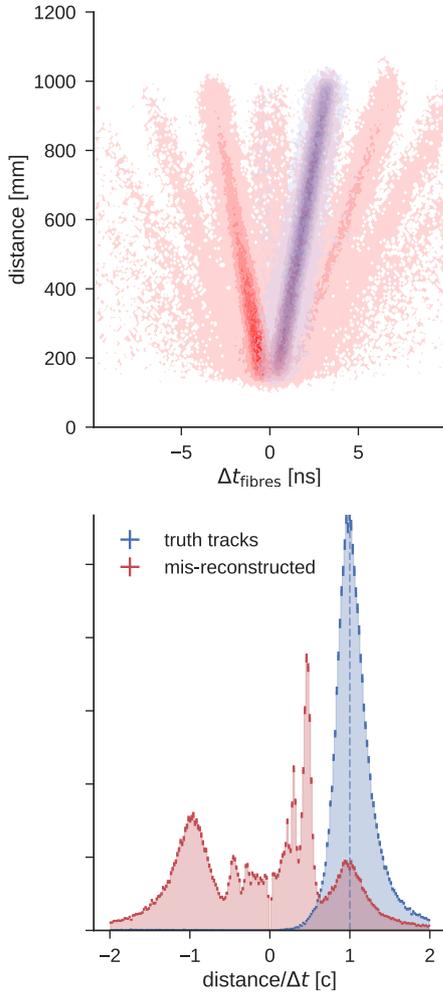


Figure 77: (top) Correlation between the time difference between two consecutive crossings of the fibre detector and the length of the trajectory of a recurring track. The different branches correspond to the combination of different track segments. The correctly reconstructed tracks with the correct charge assignment are shown in blue, while tracks with wrong charge assignment and/or mis-reconstructed tracks are shown in red. (bottom) Speed $v = \text{track length}/\Delta t \times c$ of recurring tracks. The different branches in the top plot correspond to the peaks in the bottom spectrum. Track candidates with $\Delta t < 0$ ($v < 0$) have a wrong charge assignment.

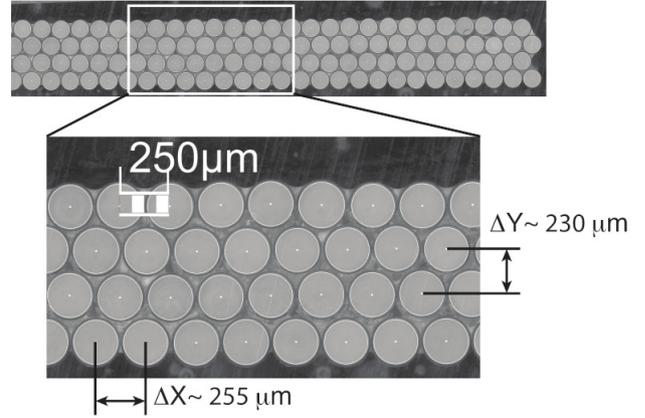


Figure 78: Front view of a SciFi ribbon prototype. A good uniformity can be achieved by this ribbon construction technique. Note that the photograph shows a four-layer SciFi ribbon, while in Mu3e three-layer ribbons are used.

characteristic	value
cross-section	round
emission peak [nm]	450
decay time [ns]	2.8
attenuation length [m]	>4.0
light yield [ph/MeV]	n/a (<i>high</i>)
trapping efficiency [%]	5.4
cladding thickness [%]	3 / 3
core	Polystyrene (PS)
inner cladding	Acrylic (PMMA)
outer cladding	Fluor-acrylic (FP)
refractive index	1.59/1.49/1.42
density [g/cm^3]	1.05/1.19/1.43

Table 10

Properties of the 250 μm diameter round multi-clad Kuraray SCSF-78MJ scintillating fibres as quoted by the manufacturer.

Each SciFi ribbon is formed by staggering three layers of 250 μm diameter round fibres (there are 128 fibres in a layer) with a length of 300 mm. After careful evaluation Polytec EP 601-Black epoxy was selected (this is a two component, low viscosity, black-coloured adhesive) for the assembly of the final SciFi detector. Figure 78 shows the cross-section of a fibre ribbon prototype. As can be observed, the fibres in a layer are separated by $\sim 255 \mu\text{m}$ centre to centre with a very good uniformity and the separation between the layers is $\sim 230 \mu\text{m}$, which gives an overall thickness of approximately 700 μm for a three-layer ribbon.

10.1.1. Scintillating Fibres

The constraints on the material budget, the occupancy, and position resolution require the use of the thinnest available scintillating fibres. In extensive measurement campaigns, a detailed comparison was undertaken of different types of 250 μm diameter round scintillating fibres produced by Kuraray (SCSF-78, SCSF-

1602 81 and NOL-11) and Saint-Gobain (BCF-12), as well
 1603 as square cross-section fibres by Saint-Gobain (BCF-
 1604 12). Scintillating fibre ribbon prototypes coupled to
 1605 SiPM arrays have been tested in test beams at the
 1606 CERN PS (T9 beamline) and PSI (π M1 beamline) and
 1607 with ^{90}Sr sources. The detailed results of these studies
 1608 are reported in [38, 39, 40, 41]. Based on their per-
 1609 formance with respect to light yield and time resolu-
 1610 tion, round double-clad SCSF-78MJ fibres from Ku-
 1611 raray were chosen. Table 10 summarizes the charac-
 1612 teristics of these fibres. Novel NOL fibres, based on
 1613 Nanostructured Organosilicon Luminophores, give the
 1614 best performance, but will only become commercially
 1615 available in the years to come and will be considered
 1616 for future SciFi detector upgrades.

10.1.2. Number of SciFi Layers

1617 A critical point of optimization is the number of
 1618 staggered fibre layers. More layers lead to an improved-
 1619 timing resolution and a higher detection efficiency but
 1620 reduces the momentum resolution of the pixel tracker
 1621 due to multiple Coulomb scattering. Since the partic-
 1622 les cross the SciFi ribbons at an angle, more layers
 1623 lead also to a larger cluster size (i.e., the number of
 1624 channels in the SiPM array excited by the scintillating
 1625 light) and therefore to a larger occupancy.

1627 Using the physical characteristics of the SciFi rib-
 1628 bions extensive simulation studies were performed on
 1629 the impact of this sub-detector on the momentum res-
 1630 olution, efficiency and track reconstruction (details on
 1631 the complete detector simulation, reconstruction algo-
 1632 rithm and event selection can be found in chapters 18,
 1633 19 and 22).

1634 The amount of multiple Coulomb scattering gener-
 1635 ated by the fibre detector is shown in Figure 79.
 1636 Note that a ribbon of three layers of $250\ \mu\text{m}$ round fi-
 1637 bres corresponds to $X/X_0 \approx 0.2\%$. Multiple Coulomb
 1638 scattering affects the momentum resolution (Figure 80)

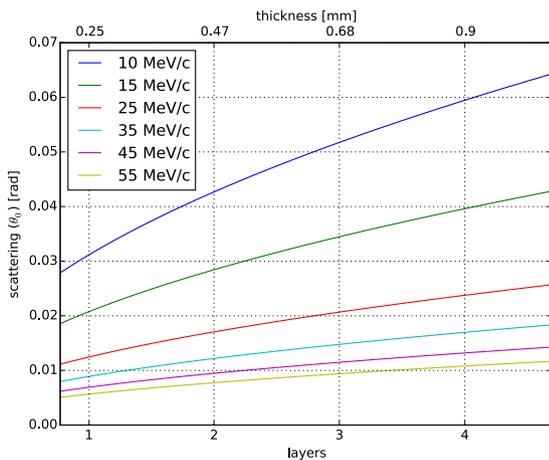


Figure 79: Multiple Scattering θ_0 depending on elec-
 tron/positron momentum and fibre ribbon thickness.

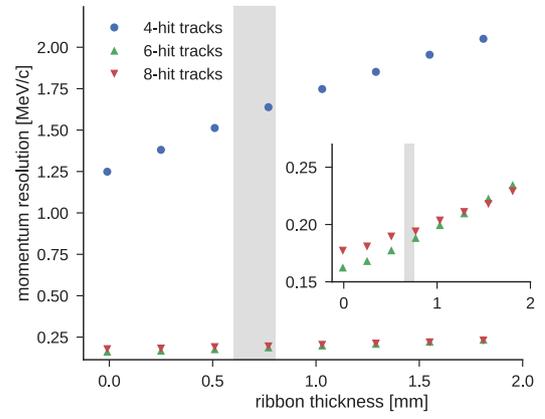


Figure 80: Momentum resolution for short (outgoing only)
 and long (outgoing and recurling) tracks as a function of fibre
 ribbon thickness using simulated Michel decays. The high-
 lighted region corresponds to a three-layer SciFi ribbon thick-
 ness of ~ 0.7 mm. The momentum resolution of long (6- and
 8-hit) tracks is improved over short (4-hit) tracks due to re-
 curling (more measured points).

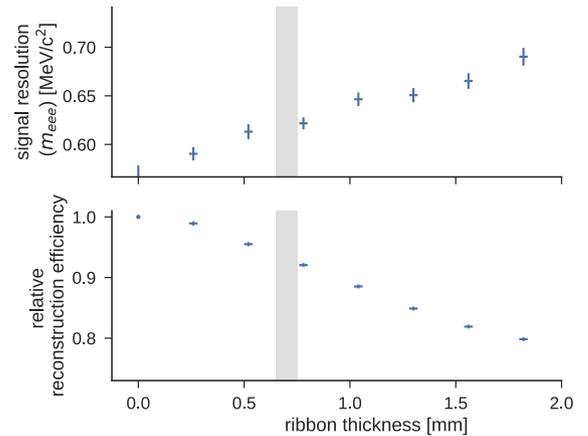


Figure 81: (top) Signal resolution in terms of the invariant
 mass of the three tracks of a candidate m_{eee} decay and (bot-
 tom) loss in reconstruction efficiency as a function of the fi-
 bre ribbon thickness. The highlighted region corresponds to a
 three-layer SciFi ribbon thickness of ~ 0.7 mm.

1639 and thus the $\mu \rightarrow eee$ signal invariant mass resolution
 1640 and reduces the overall reconstruction efficiency (Fig-
 1641 ure 81). More fibre layers also lead to a larger occu-
 1642 pancy in the SciFi detector.

1643 As a compromise between these constraints, ribbons
 1644 consisting of three staggered layers of $250\ \mu\text{m}$ diame-
 1645 ter round fibres are chosen. With a thinner detector
 1646 it would be challenging to fulfill the efficiency require-
 1647 ments and the time resolution would not be sufficient
 1648 to effectively reject accidental backgrounds, reliably de-
 1649 termine the sense of rotation of tracks and reject mis-
 1650 reconstructed track candidates.

10.2. Silicon Photomultiplier Arrays

The light produced in the scintillating fibres is detected in SiPM arrays at both fibre ends. Acquiring the signals on both sides increases the time resolution (two time measurements instead of one), helps to distinguish between noise and signal and increases the detection efficiency of the whole system (because of the noise rejection). Moreover, by taking the mean time of the two time measurements, the timing measurements is made independent of the hit position (assuming that light propagates at the same speed to both fibre ends) and thus no position correction is necessary.

The Mu3e fibre detector is read out with Hamamatsu S13552-HRQ SiPM arrays, with a high quenching resistance. The segmentation of the sensor is obtained by arranging the individual SiPM pixels into independent readout columns (channels). Each channel consists of 104 pixels, each measuring $57.5 \mu\text{m} \times 62.5 \mu\text{m}$, arranged in a 4×26 grid. The sensitive area of one channel is therefore $230 \mu\text{m} \times 1625 \mu\text{m}$. The pixels are separated by trenches of the fifth generation Hamamatsu low-crosstalk development (LCT5). A $20 \mu\text{m}$ gap separates the array's columns, resulting in a $250 \mu\text{m}$ pitch. Each sensor comprises 64 such channels, which share a common cathode. Two sensors, separated by a gap of $220 \mu\text{m}$, form the 128 channel device shown in Figure 82. The overall current consumption of one array is expected to be below 1 mA even for heavily irradiated sensors. The sensors are delivered wire-bonded on a PCB with solder pads on the backside. The sensors are covered with a $105 \mu\text{m}$ thick protective layer of epoxy resin. Table 11 summaries the most important features of the sensor.

This sensor was developed for the LHCb experiment and matches the requirements of the Mu3e fibre detec-

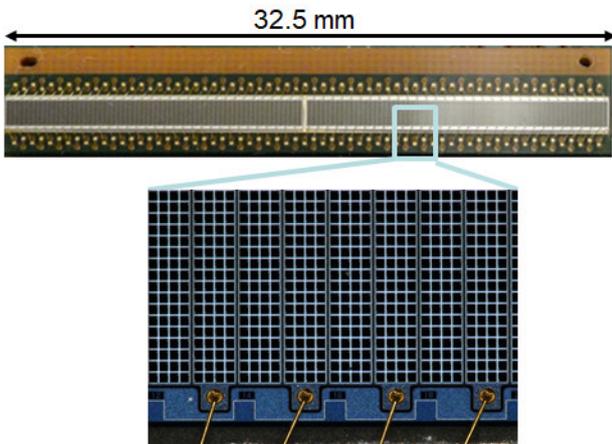


Figure 82: Picture of a Hamamatsu S13552-HRQ SiPM column array including a close view showing the pixel structure of the sensor.

characteristic	value
breakdown voltage	52.5 V
variation per sensor	± 250 mV
variation between sensors	± 500 mV
temperature coefficient	53.7 mV/K
gain	$3.8 \cdot 10^6$
direct crosstalk	3 %
delayed crosstalk	2.5 %
after-pulse	0 %
peak PDE	48 %
max PDE wavelength	450 nm
mean quench resistance R_Q	490 k Ω at 25 °C
recovery time τ_{recovery}	(68.9 ± 2.1) ns
short component τ_{short}	< 1 ns
long component τ_{long}	(50.1 ± 4.1) ns

Table 11

SiPM array ((model S13552-HRQ) characteristics at $\Delta V = V_{\text{op}} - V_{\text{breakdown}} = 3.5$ V and $T = 25$ °C from [42].

tor. The photon detection efficiency (PDE²²) of up to 50 %, single photon detection capabilities and very fast intrinsic time response (single photon jitter of approximately 200 ps) are the key features for the use in the Mu3e fibre detector. The SiPM arrays are read out with a dedicated mixed-mode ASIC, the MuTRIG (see chapter 9). The high gain ($> 10^6$) allows for the use of the MuTRIG without any pre-amplification. Typical dark-rates are around 100 kHz at room temperature per SiPM array channel for unirradiated sensors. In contrast to LHCb, where the SiPM arrays are operated around -40 °C, the Mu3e sensors are being operated at a temperature close to 0 °C, but in a less intense radiation field. The moderate cooling of the detector is required to further reduce the dark count rate and mitigate the radiation damage effects.

Figure 83 shows the I-V curves for one SiPM array for each channel of the sensor. All breakdown voltages are comprised within ± 0.25 V of the central value of 52.5 V. The best performance is obtained for an operational voltage (V_{op}) 3.5 V above the breakdown voltage ($V_{\text{breakdown}}$), but the sensor can also be operated at higher voltages for an increased gain. Since all channels share a common cathode, the sensor is usually operated at a common voltage for all channels. The performance of the photo-detector can be further improved by adjusting V_{op} individually for each channel. The MuTRIG readout ASIC allows for the fine tuning of the bias voltage around a common value for each individual channel of the sensor.

The fibre ribbons are coupled directly to the surface of the SiPMs on both sides. Figure 84 shows a possible mapping of the SciFi ribbon on the SiPM array. As can be seen, no one-to-one matching is possible between the fibres and the SiPM columns because of the

²²With contributions from quantum efficiency and geometrical fill factors.

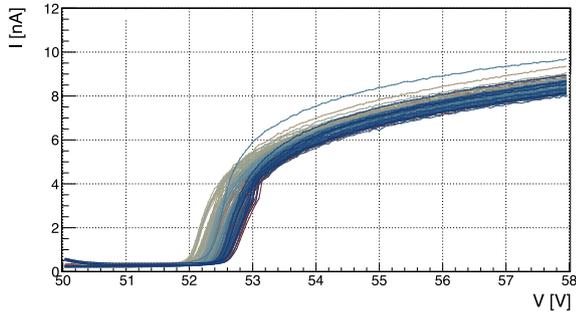


Figure 83: I-V curves for each channel of the SiPM array. All breakdown voltages are comprised within ± 0.25 V of the central value of 52.5 V.

one for timing (a time stamp is generated) and a high one for hit selection (single flag).

The analog signals from each SiPM array (128 channels) are digitised by one SciFi module board (SMB) hosting four MuTRiG ASICs. Figure 85 shows the first version of the SMB. The space limitations in the Mu3e setup require a very compact design of the board. The ASICs are wire bonded directly to the board. The final version of the board will measure 26 mm \times 45 mm and is currently under development. The electrical connection between the SiPM sensors and the readout electronics is realised through flex-print circuits. A 128-channel SiPM array is soldered to a support PCB with an embedded flex-print, which continues to a second PCB hosting the MuTRiG ASICs. In addition to the MuTRiG ASICs, the SMB hosts the clock and reset distribution circuits, components for the control of the MuTRiG, LDOs for power distribution, and temperature probes. In total 24 such SMBs are needed, one per SiPM array. Finally all SMBs are connected to front-end FPGA boards (see section 17.2) via micro twisted-pair cables.

stagging of the fibres. To ease detector assembly and maintainability, the coupling is realised by only mechanical pressure without the use of optical interfaces.

10.3. SciFi Readout Electronics

The Mu3e scintillating fibre detector requires the digitization of the crossing time information at a single photon level. That leads to very high rates per SiPM channel coming from the particles crossing the SciFi ribbons (~ 200 kHz signal rate) and the dark noise (~ 1 MHz for irradiated sensors). The latter is reduced by clustering during the real-time processing of the data.

For the readout of the 3072 SiPM channels we use the mixed-mode MuTRiG ASIC with 50 ps TDC time binning (see chapter 9 for a detailed description of the ASIC). Each ASIC comprises 32 fully differential input analogue channels, therefore four MuTRiG ASICs are required for the readout of one SiPM array. Although the ASIC has a fully differential input, single ended signals are used, because the SiPM array channels share a common cathode. When operated with the SiPM arrays, the signal is compared to two thresholds: a low

10.3.1. Power requirements

The power requirements of the MuTRiG ASICs are given in chapter 9. The powering of one SciFi front-end board requires 2 V at 2.5 A, 3.5 V at 0.1 A, and a bias line (around 55 to 57 V) for the SiPM array. Each SciFi front-end board generates around 5 W of thermal output, which has to be cooled.

10.4. SciFi Detector Performance

Figure 86 shows the light yield in a cluster excited by a minimum-ionizing particle crossing a three-layer SCSF-78MJ fibre ribbon prepared with clear epoxy. A cluster is defined as the sum of all consecutive SiPM channels with an amplitude larger than a specific threshold (in this case 0.5 photo-electrons) and a cluster mul-

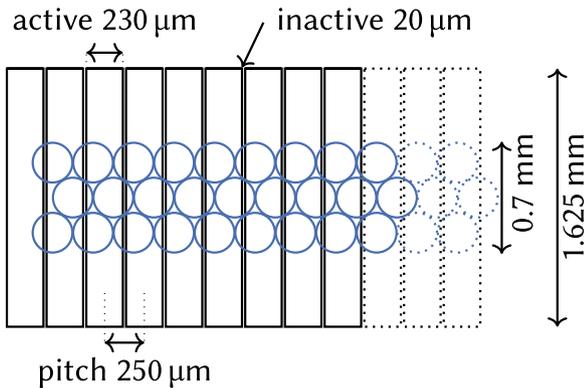


Figure 84: Mapping of the SciFi ribbon on the SiPM array. No one to one matching is possible between the fibres and the SiPM columns.

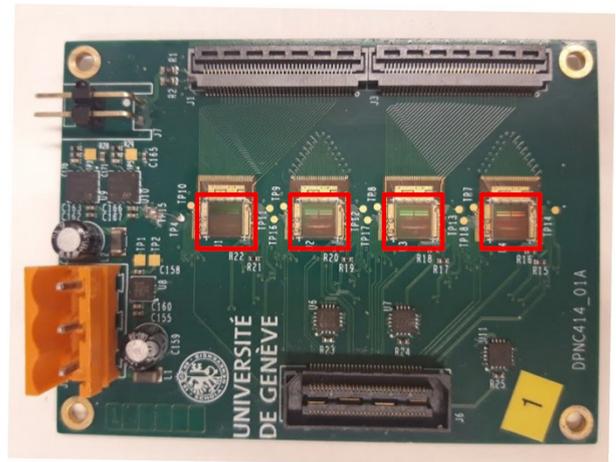


Figure 85: First version of the SciFi front-end board hosting 4 MuTRiG ASICs (outlined in the red boxes) wired bonded directly on the board.

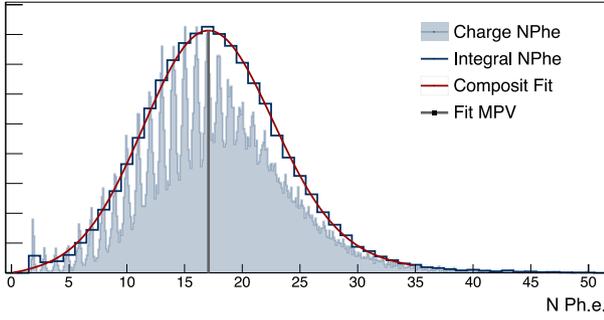


Figure 86: Light yield of a cluster (see text) for a m.i.p. crossing a three-layer SCSF-78MJ fibre ribbon prepared with clear epoxy. The integral NPhe is obtained by integrating the charge in a region of ± 0.5 ph.e. around each peak (integer). A convolution of a Gaussian and of a Landau is used to fit the data and the MPV of the spectrum is marked with the vertical line.

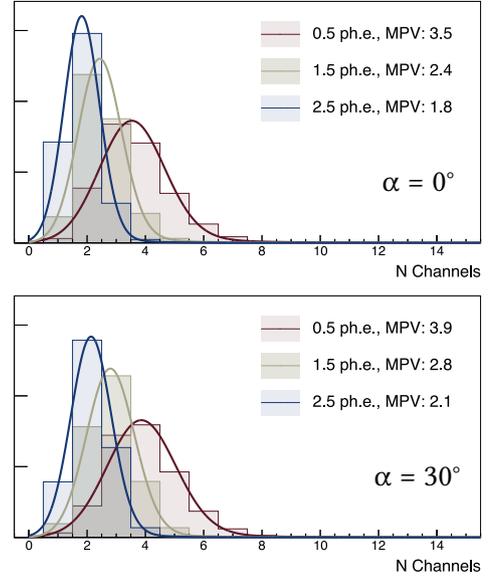


Figure 87: Cluster size for a particle crossing the ribbon at two different angles and different thresholds. Electrons from a radioactive ^{90}Sr source are used for this measurement. An angle of $\alpha = 0^\circ$ describes a perpendicular crossing.

tiplicity of at least two adjacent SiPM channels above the same threshold. The number of photo-electrons (ph.e.) is defined by the charge sum of all channels in a cluster at one side of the SciFi ribbon matched to a crossing track. The light yield is measured with respect to the centre of the fibre ribbon (i.e., 150 mm from the edge). A convolution of a Gaussian and of a Landau distribution is used to fit the data. The fit provides also the most probable value (MPV) for the number of detected ph.e., which is of about 17 for this configuration. This ph.e. spectrum, however, is not accessible in the experiment since the MuTRIG provides only the timing information and no charge information. Test-beam data were recorded using a fast pre-amplifier and read-out digitizing electronics based on the DRS4 ASIC. The recorded waveforms were then processed using timing algorithms close to the MuTRIG functioning (i.e., 0.5 ph.e. low threshold leading edge discriminator).

The cluster size distribution for the same SciFi ribbon is shown in Figure 87. Typical cluster sizes are around 3.5 for a threshold of 0.5 ph.e., for a particle crossing the ribbon at 0° (i.e., perpendicularly to the ribbon). The cluster size can be reduced by increasing the detection threshold to e.g., 1.5 ph.e. or higher. The figure shows also cluster sizes for particles crossing the ribbon at an angle of 30° , which is close to the mean crossing angle in Mu3e of 25° ²³. A larger crossing angle increases the average cluster size.

The detection efficiency of the SciFi detector depends on the applied thresholds, minimal cluster multiplicity and the requirement of time matched clusters at both SciFi ribbon ends. For the selected working point, which requires a threshold of 0.5 ph.e., with a minimal cluster multiplicity of two and a 5σ timing cut on the matched clusters, where σ is the intrinsic time resolution of the SciFi detector, the detection efficiency is around 95%. Without the timing cut, the detection

efficiency increases close to 100%. It should be noted that the cluster matching and the timing cut can only be applied in the offline analysis of the SciFi data and can be tuned to optimize the detection efficiency.

Finally, an example of the timing performance of the SciFi detector is shown in Figure 88. This measurement has been performed using the MuTRIG evaluation board, shown in Figure 71. The measurement has been performed using a four-layer SciFi ribbon with a ^{90}Sr source requiring a minimal cluster multiplicity of two neighbouring channels with an amplitude of at least 0.5 ph.e. Similar results have also been obtained with the analogue electronics (DRS4-based DAQ) men-

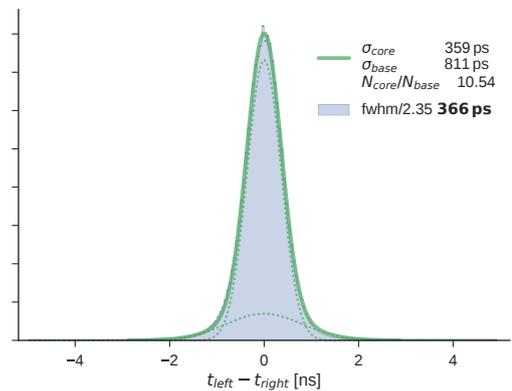


Figure 88: Time resolution of a 4 layer SCSF-78MJ SciFi ribbon extracted from clusters with at least 2 active columns. No channel by channel time offset correction has been applied.

²³Due to spiralling tracks in the magnetic field

1828 tioned above and particle beams [40]. The spread of
 1829 the time difference distribution from the two ribbon
 1830 sides $\sigma(t_{\text{left}} - t_{\text{right}})$ corresponds to twice the intrinsic
 1831 detector resolution (mean time). For example, the
 1832 FWHM/2.35 of the distribution obtained in this mea-
 1833 surement is 366 ps implying a resolution on the mean
 1834 time around 200 ps. For a three-layer ribbon as used in
 1835 Mu3e, the time resolution is slightly worse, at around
 1836 250 ps.

10.5. SciFi Detector Mechanics

1837 Figure 89 shows the overall structure of the SciFi
 1838 detector. The detector is composed of 12 SciFi ribbons,
 1839 300 mm long and 32.5 mm wide. The ribbons are
 1840 staggered longitudinally by about 10 mm (Figure 91)
 1841 in order to minimise dead spaces between the ribbons
 1842 and to provide sufficient space for the spring loading of
 1843 the ribbons. To avoid sagging and to compensate for
 1844 the thermal expansion the ribbons are spring loaded on
 1845 one side of the structure (6 ribbons on one side and the
 1846 other 6 on the other side).

1848 A detailed study to determine the effects of the
 1849 thermal expansion and sagging has been performed. A
 1850 thermal expansion coefficient for the 300 mm long SciFi
 1851 ribbon of $(65 \pm 16) \cdot 10^{-6}/\text{K}$ has been measured. There-
 1852 fore, for a 50 °C thermal excursion, an elongation of the
 1853 ribbons of around 1 mm is expected. This elongation
 1854 effect can be compensated by spring-loading the ribbons
 1855 as mentioned above. Figure 90 shows the sag of a
 1856 three-layer 300 mm long and 32.5 mm wide SciFi ribbon
 1857 as a function of the temperature for different values of
 1858 the applied tension. Figure 90 also shows that a tension
 1859 of 8 N is required to prevent sagging over the whole
 1860 temperature interval and to guarantee the correct po-
 1861 sitioning of the detector.

1862 To ease the sub-detector installation, the SciFi ribbons
 1863 are assembled in modules. Each module consists
 1864 of two SciFi ribbons, as shown in Figure 91.

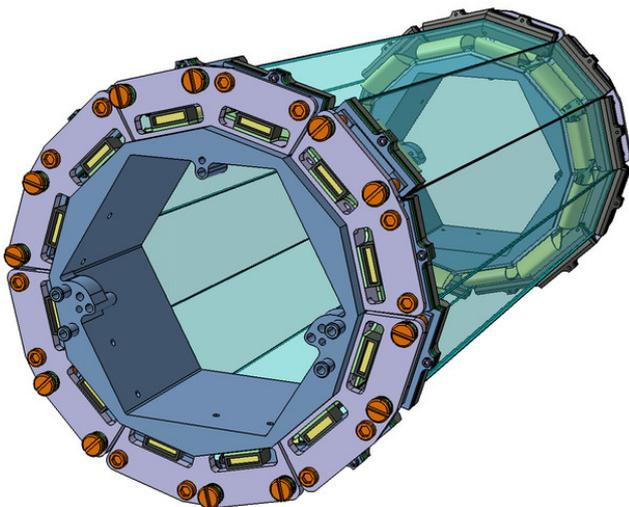


Figure 89: Overall structure of the scintillating fibre detector.

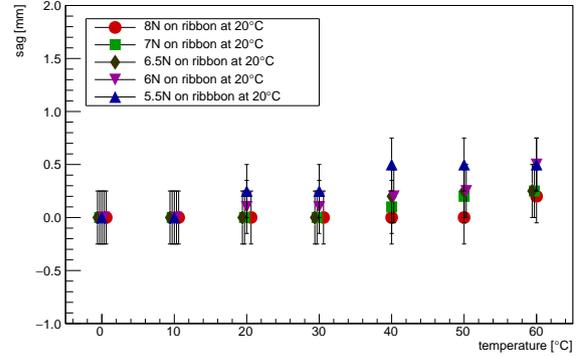


Figure 90: Sag of the SciFi ribbon as a function of the temperature for different values of the applied spring tension.

1865 The SciFi ribbons are coupled to the SiPM arrays by
 1866 simple mechanical pressure (no grease or other optical
 1867 interface). Each SiPM sensor is connected to a front-
 1868 end digitizing board via a flex-print circuit. Figure 92
 1869 shows an expanded view of the assembly structure: the
 1870 SciFi ribbons are attached to the SiPM arrays, which
 1871 in turn are supported by stiffeners fixed to L-shaped
 1872 supports, where the assembly is also spring loaded. The
 1873 same L-shaped supports are also used to mount the
 1874 SciFi front-end boards.

1875 The L-shaped supports are fixed to a hollow do-
 1876 decagonal prism as shown in Figure 93, 45 mm tall with
 1877 an outer diameter of 100 mm, which also provides the
 1878 necessary cooling for the front-end electronics. Two
 1879 such cooling structures are attached to the beam pipe
 1880 on each side of the Mu3e detector and connected to
 1881 the pipes of the Mu3e cooling system. This cooling
 1882 structure is created by 3D printing in aluminium with
 1883 inner piping for the circulation of the coolant. Each
 1884 MuTRiG ASIC generates about 1 W of thermal out-
 1885 put, therefore around 50 W has to be dissipated on
 1886 each side of the SciFi detector. Since the SiPM arrays
 1887 are in thermal contact with the L-shaped supports, they
 1888 are cooled by the same cooling structure. The goal is
 1889 to cool the SiPM arrays down to 0 °C.

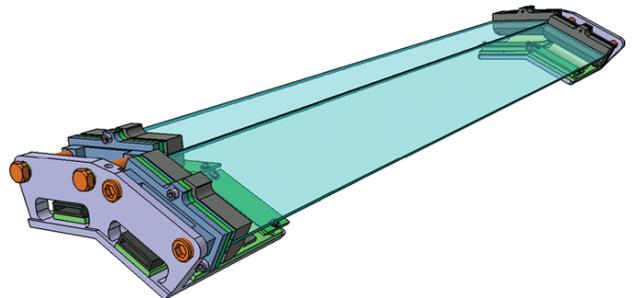


Figure 91: A fibre module consists of two SciFi ribbons with the associated support structure. The ribbons are staggered longitudinally to minimise dead spaces between the ribbons and are spring loaded alternately on opposite sides of the structure.

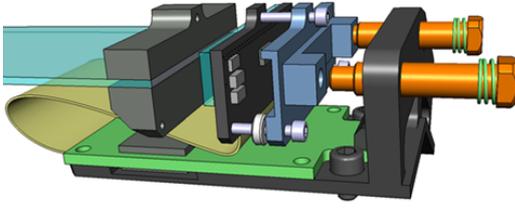


Figure 92: Expanded view of the SciFi support structure, showing all the elements of the detector: SciFi ribbon, SiPM sensor, SciFi front end board and the L-shaped support structure.

11. Tile Detector

The tile detector aims at providing the most precise timing information of the particle tracks possible. As it is located at the very end of recurling particle trajectories, there are no constraints on the amount of detector material; the placement inside the recurl pixel detectors however implies very tight spatial constraints. The detector consists of plastic scintillator segmented into small tiles. Each tile is read out with a silicon photomultiplier (SiPM) directly attached to the scintillator. The main goal of the tile detector is to achieve a time resolution of better than 100 ps and a detection efficiency close to 100% in order to efficiently identify coincident signals of electron triplets and suppress accidental background.

11.1. Detector Design

The tile detector is subdivided into two identical stations – one in each recurl station. Each tile detector segment has the shape of a hollow cylinder enclosing the beam-pipe. The length of a segment is 34.2 cm along the beam direction (z direction) including the endrings, while the outer radius is 6.4 cm, which is limited by the surrounding pixel sensor layers. The detector in each recurl station is segmented into 52 tiles in z direction

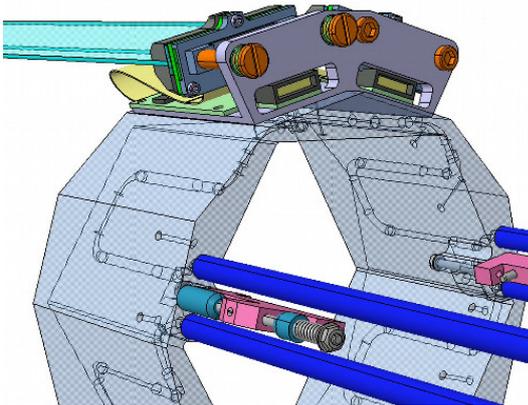


Figure 93: Support structure of the SciFi detectors, which serves also as cold mass for the dissipation of the heat generated by the SciFi front-end electronics and the cooling of the SiPM arrays.

and 56 tiles along the azimuthal angle (ϕ direction). This is the highest feasible channel density, considering the space requirements for the readout electronics. The high granularity is essential in order to achieve a low occupancy as well as a high time resolution.

The technical design of the tile detector is based on a modular concept, i.e. the detector is composed of small independent detector units. The base unit of the tile detector, referred to as *sub-module*, is shown in Figure 96a. It consists of 32 channels arranged in two 4×4 arrays. The tiles are made out of Eljen technology EJ-228 plastic scintillator and have a size of $6.3 \times 6.2 \times 5.0 \text{ mm}^3$, see Figure 94. The edges of the two outer rows of an array are bevelled by 25.7° , which allows for seven base units to be arranged approximately in a circle.

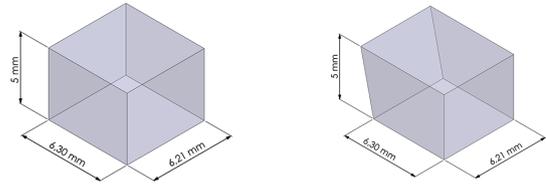


Figure 94: Tile scintillator geometry: (left) central tile, (right) edge tile.

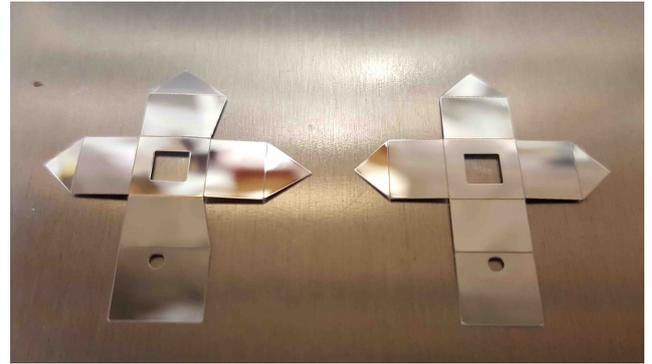
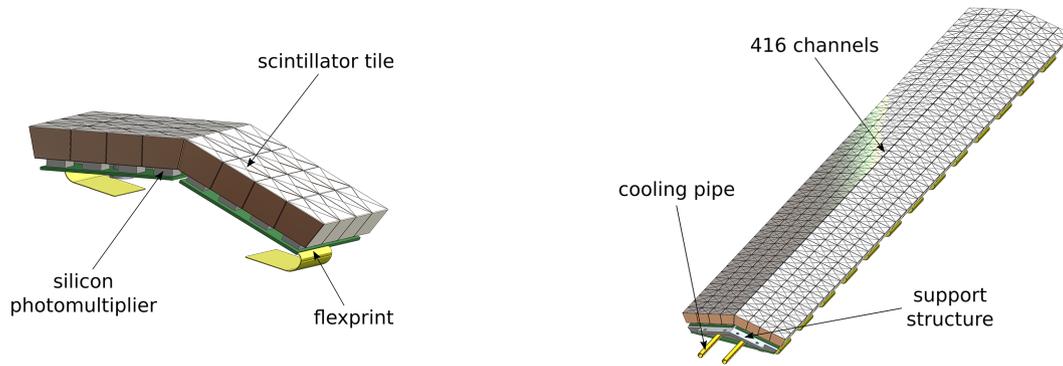


Figure 95: Individual ESR reflective foils for two types of scintillator tiles: (left) edge tile, (right) central tile.

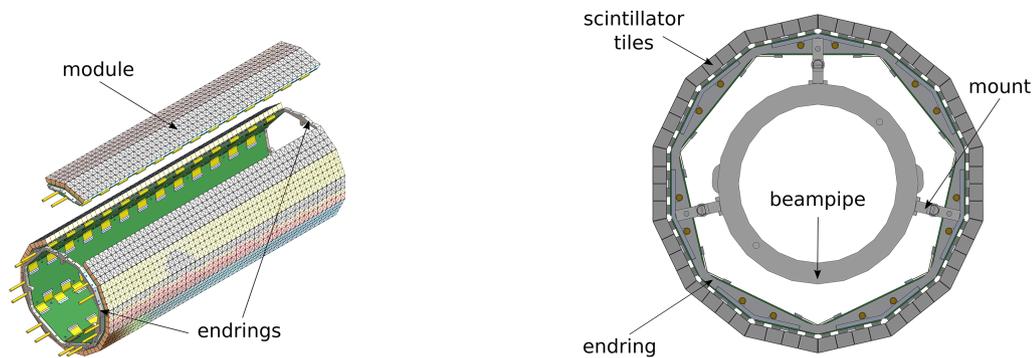
The individual tiles are wrapped with Enhanced Specular Reflector (ESR) foil. In order to increase the light yield and optically isolate the channel, the foil is designed to cover the entire tile except for an opening window of the size of the SiPM surface, as can be seen in Figure 95. Every tile is read out by a $3 \times 3 \text{ mm}^2$ SiPM with 3600 pixels, which is glued to the bottom $6.3 \times 6.2 \text{ mm}^2$ side of the tile. The SiPMs are soldered to a printed circuit board (PCB), which is connected via a flexible PCB (flexprint) to one of the ASICs on the readout board, the Tile Module Board (TMB).

A tile *module* is comprised of 13 sub-modules, and contains a total of 416 channels. A CAD rendering of such a module is shown in Figure 96b. The sub-modules



(a) The tile detector base unit consisting of 32 scintillator + SiPM channels. The sensors are mounted on a flex-rigid PCB. CAD rendering.

(b) Module (416 channels) of the tile detector consisting of 13 base units, which are mounted on a support structure. A copper pipe for cooling liquid is placed inside the support structure to cool the readout chips and SiPMs. CAD rendering.



(c) Full tile detector (CAD rendering, exploded view).

(d) Full tile detector (front view). The detector modules are mounted on two endrings connected to the beampipe. CAD rendering.

Figure 96: CAD rendered views of the tile detector.

1944 are mounted on a water-cooled aluminium support structure and are read out by 13 MUTRIG ASICs assembled
 1945 on one TMB, which collects the analog signals of the SiPMs and forwards the digitised signals to the front-
 1946 end FPGAs. The subsequent data transmission is discussed in chapter 17. The heat of the readout chips
 1947 is dissipated via liquid cooling through a copper tube, with an outer diameter of 2.5 mm and an inner diame-
 1948 ter of 2.0 mm, which is placed in a U-shaped groove on the bottom side of the support structure.
 1949

1950 Figure 96c shows an exploded view of a full tile detector recur station, which consists of seven modules.
 1951 The modules are assembled on two endrings, which in turn are mounted on the beam pipe, as shown in Fig-
 1952 ure 96d.
 1953

1954 Based on previous studies [43], the best timing resolution is achieved with the plastic scintillator BC418
 1955 (equivalent to EJ-228), which has both a high light yield and a fast response time, and therefore is cho-
 1956 sen as the baseline material for the tile detector. This scintillator has a nominal light output of about 10 200
 1957 photons per MeV, a rise time of 0.5 ns and a decay time of 1.4 ns. The emission spectrum of the scintil-
 1958 lator peaks at a wavelength of 391 nm, which roughly matches the maximum spectral sensitivity of the SiPM.
 1959 This allows the direct read-out of the scintillation light
 1960
 1961
 1962
 1963
 1964

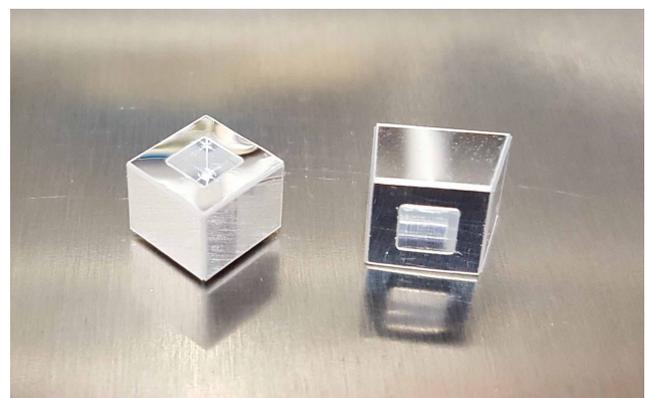


Figure 97: Individual tiles wrapped with ESR reflective foil.

1965 photons per MeV, a rise time of 0.5 ns and a decay time of 1.4 ns. The emission spectrum of the scintil-
 1966 lator peaks at a wavelength of 391 nm, which roughly matches the maximum spectral sensitivity of the SiPM.
 1967 This allows the direct read-out of the scintillation light
 1968
 1969

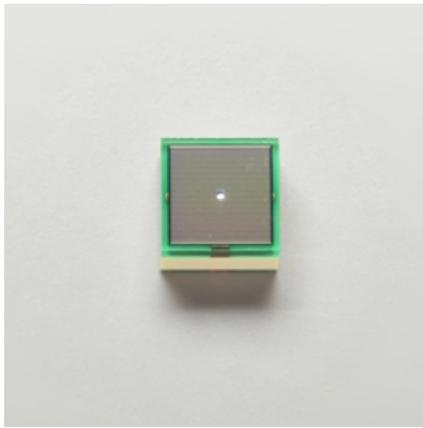


Figure 98: Hamamatsu MPPC S13360-3050VE.

without the need of an additional wavelength shifter.

Different SiPM types have been compared in simulation studies in order to find the best suited device for the tile detector. Based on the simulation studies, a $3 \times 3 \text{ mm}^2$ SiPM with $50 \mu\text{m}$ pixel size is chosen as the baseline photo-sensor. A respective SiPM from Hamamatsu (MPPC S13360-3050VE, see Figure 98) has been successfully tested in the tile detector technical prototype (see section 11.5).

11.2. SiPM Radiation Hardness

Ionising radiation can have a large impact on the SiPM characteristics and performance. The most prominent effect caused by irradiation is a strong increase in the SiPM dark-rate. Furthermore, there are several studies (e.g. [44, 45]), which have observed a slight decrease in the detection efficiency after exposure of the SiPM to radiation. A possible explanation for this effect is the progressively larger amount of pixels in a permanent off-state [45]. Both an increasing dark-rate and a reduced signal amplitude directly influence the time resolution of the sensor. The exact amount of signal degradation caused by radiation depends on the particle energy and type, as well as the specific SiPM device.

During the data taking period of phase I of the Mu3e experiment, the SiPMs will be exposed to a total radiation dose of about $10^{10} \text{ e}^+/\text{mm}^2$. So far, no conclusive experimental data of the SiPM signal degradation is available for the given irradiation dose, particle type and energy. First studies of the radiation damage in SiPMs using a ^{90}Sr source indicate that the degradation of time resolution during the Mu3e phase I is of the order of a few percent. However, more detailed studies are required in order to precisely predict the SiPM performance over phase I runtime and to obtain a comprehensive picture of the radiation effects. These studies will be performed in parallel for the tile and fibre SiPMs.

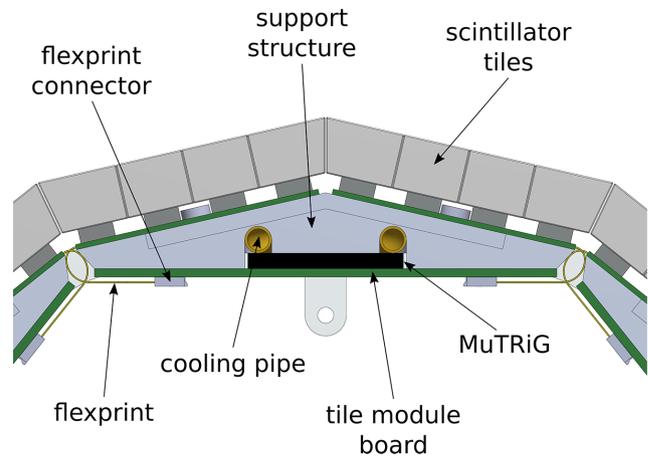


Figure 99: Tile detector with readout electronics. The tile module is divided into a PCB hosting the MuTRiG chips and 2×13 PCBs hosting the SiPMs. The SiPM boards are connected to the MuTRiG board via flex cables. The tile readout board is placed on the cooling structure, connecting the tile sub-modules to the front-end FPGA readout board.

11.3. Tile Readout

The tile detector will use the same MuTRiG ASIC as the fibre detector, see chapter 9 for details. The output signals of 32 tile SiPMs are connected via a flexible printed circuit board to a MuTRiG chip. The arrangement of the SiPMs and the readout electronics around the cooling structure is shown in Figure 99. The MuTRiG will be operated in two-threshold mode (see Figure 66), allowing for time-walk correction. The data are then forwarded via the TMB, mounted on the detector module, to the FPGA front-end boards similar to those planned for the pixel detector, see chapter 17.

11.4. Assembly Tools and Productions steps

As a first step, the SiPMs are sorted by breakdown voltage and preselected in groups of 32 SiPMs with a spread of the breakdown voltage smaller than 100 mV. This will allow the operation of each sub-module with the same operating High Voltage (HV).

The tiles are manufactured in the Kirchhoff-Institute for Physics in Heidelberg. The scintillator material is mounted on a vacuum plate, where the full matrix is milled from the top, only leaving a 0.5 mm base. The plate is flipped by 180 degrees on to an ice-vice, which freezes the matrix to mill off the base, as sketched in Figure 100. Using this method, a relatively fast production rate with very high accuracy of several micrometers is achieved.

After cutting the tiles to the required shape, the tiles' length and width are measured using a digital micrometer before wrapping them with the reflective foil. In order to wrap the tiles, a semi-automatic tool was designed that allows for an easy wrapping of such small

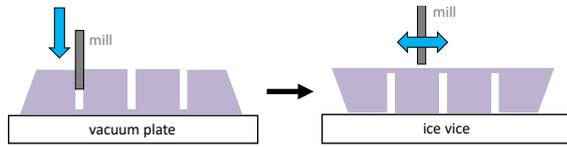


Figure 100: Tile milling procedure: (left) milling the matrix shape on a vacuum plate, (right) flip the matrix, freeze on the ice-vice, and mill from top.

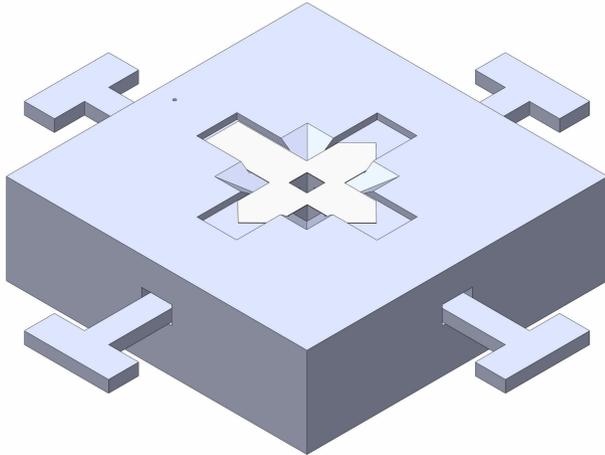


Figure 101: Sketch of the tile wrapping tool with a foil on top.

2041 tile sizes. A sketch of the wrapping tool is presented in
 2042 Figure 101. The foil is placed into a dedicated groove
 2043 on top of the tool; then the tile is placed onto the foil.
 2044 By pushing the tile down into a customised funnel,
 2045 the foil side walls are folded around the tile. Using the
 2046 side rods of the tool, the wrapping is folded like an
 2047 envelope and a small sticker is placed on top to close
 2048 it. The resulting wrapped tiles are shown in Figure 97.

2049 In the following step, the tiles must be glued to the
 2050 SiPMs. This is done on matrix level in order to avoid
 2051 tolerance issues. A gluing tool was designed with the
 2052 emphasis of allowing a small degree of freedom with
 2053 respect to the height of the individual tiles in order
 2054 to compensate different SiPM heights due to soldering
 2055 paste and tolerances of the SiPM manufacturing. The
 2056 scintillator tiles are manually arranged inside the tool
 2057 and are pressed from the back side and the top such
 2058 that half of the tiles' height is outside of the tool as
 2059 shown in Figure 102a. The matrix board is mounted
 2060 on a pedestal and the glue is dispensed onto the SiPMs.
 2061 At this stage, the tool is pressed onto the SiPMs as
 2062 shown in Figure 102b, where the x - y position is set
 2063 using alignment pins. After a curing time of 24 hours,
 2064 the outer wall of the gluing tool is taken out (see Fig-
 2065 ure 102c) and the gluing tool can be removed.

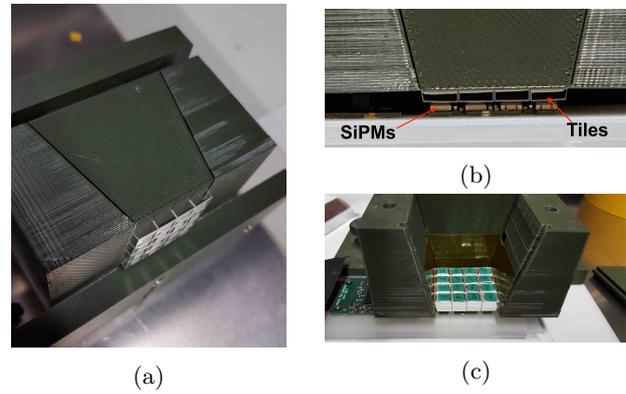


Figure 102: Gluing tool design to glue a 16 channel matrix on one side of tile matrix board: (a) the tools with 16 tiles pressed before gluing, (b) tiles pressed on SiPMs during the gluing stage, (c) glued tile matrix after curing.

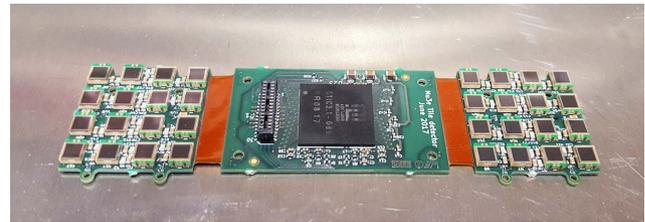


Figure 103: Tile matrix board assembled with SiPMs and a BGA packaged STiC 3.1 ASIC.

11.5. Technical Prototype

2066 A technical prototype of the tile detector has been
 2067 developed and tested. The goal of this prototype was to
 2068 evaluate the detector performance and cooling concept,
 2069 develop production tools and finalize assembly proce-
 2070 dures. This detector has a similar design to the one de-
 2071 scribed in section 11.1, with a few modifications in the
 2072 sub-module layout that were done in a later stage based
 2073 on the experience from this technical prototype. For
 2074 this prototype, the endrings, the cooling support struc-
 2075 ture and the tile matrix readout board were produced.
 2076 At the time of production, the MuTRIG ASIC was not
 2077 available. Therefore, a BGA packaged STiC 3.1 was
 2078 used, which has the same front-end as the MuTRIG
 2079 ASIC. In addition, a first version of the TMB, which
 2080 allows the readout of a full module, was produced. In
 2081 Figure 103, a tile matrix board assembled with SiPMs
 2082 and a BGA-packaged STiC 3.1 ASIC is shown. In this
 2083 design, eight digital temperature sensors were placed
 2084 between the SiPMs and used for monitoring.

2085 The scintillator material was manually cut in the
 2086 workshop of the Kirchhoff-Institute for Physics in Hei-
 2087 delberg, with a tolerance of 180 μm for two different tile
 2088 geometries, as presented in Figure 94. The tiles were
 2089 individually wrapped with ESR reflective foil that was
 2090 designed in a way to maximize the light yield while at
 2091 the same time minimizing optical cross-talk between
 2092 the channels. The foils were cut to the desired shape
 2093

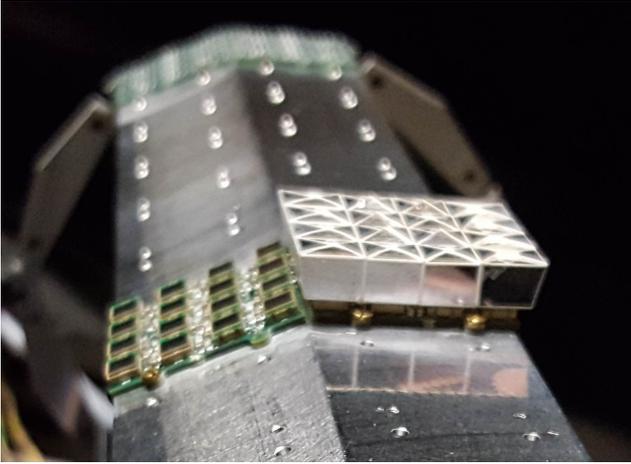


Figure 104: First half-assembled sub-module mounted on the cooling structure.

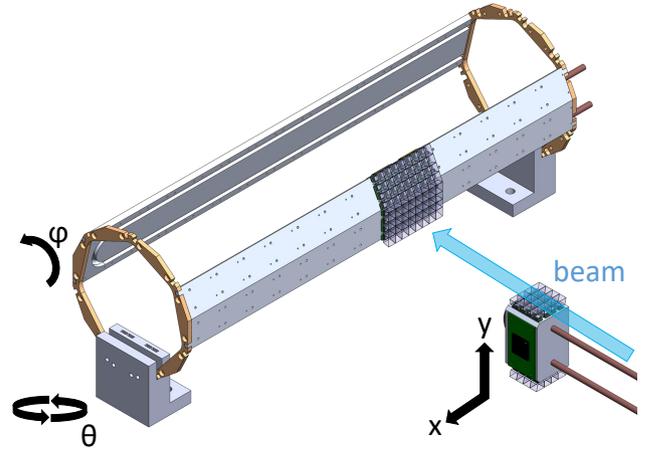


Figure 105: Schematic drawing of the test-beam setup at DESY, which includes three sub-modules.

2094 using a laser cutter. For this prototype, an additional
 2095 hole on the top side was added in order to monitor the
 2096 gluing quality as shown in Figure 95.

2097 In total, three sub-modules consisting of 96 chan-
 2098 nels, were assembled and tested in test-beam condi-
 2099 tions. In Figure 104, the first half of a sub-module
 2100 assembled on the cooling structure is presented.

2101 11.5.1. Prototype Performance

2102 In order to evaluate the detector performance, the
 2103 timing and detection efficiency were measured with an
 2104 electron beam at the DESY test-beam facility. A schematic
 2105 view of the test setup is shown in Figure 105. For the
 2106 measurements, one sub-module array of 4×4 scintil-
 2107 lator tiles was positioned in parallel to the beam and
 2108 served as a reference, such that the incident particles
 2109 traversed four tiles in a row for each electron event. The
 2110 other two sub-modules were assembled on the cooling
 2111 structures and used as devices under test (DUTs). The
 2112 devices under test could be rotated in ϕ and θ with
 2113 respect to the beam and were read out using the proto-
 2114 type TMB board. The reference detector and the proto-
 2115 type TMB board were connected with 50 cm cables to
 2116 a test FPGA board, which merged the data from the
 2117 three ASICs. During the test-beam, both the reference
 2118 matrix and all the channels of DUT₀ were calibrated,
 2119 while for DUT₁ only a single row was optimized.

2120 Figure 106 shows a typical time-over-threshold (ToT)
 2121 spectrum. Several distinct features are visible: The
 2122 most prominent feature is the peak at a ToT of about
 2123 610 CC bins (coarse counter bins), in the following re-
 2124 ferred to as Landau peak. This peak originates from
 2125 electrons which fully traverse the tile. The second peak
 2126 at a ToT of 210 CC bins originates from cross-talk be-
 2127 tween neighbouring scintillator tiles. This can be shown
 2128 by selecting hits where at least one direct neighbour in
 2129 the rows above or below the selected tile has a large
 2130 signal with an energy deposition in the Landau peak.
 2131 The corresponding events are shown by the red curve in

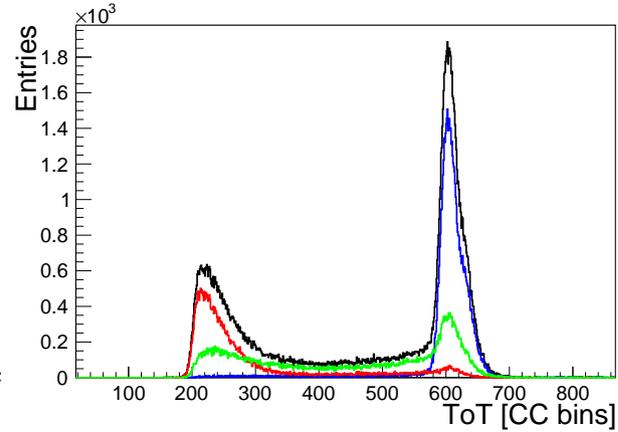


Figure 106: Energy deposition in a scintillator tile (black). The spectrum is composed of the Landau peak (blue), a plateau arising from edge effects (particles grazing the tile, green) and a peak from optical cross-talk (red).

2132 Figure 106. The green line refers to a plateau arising
 2133 from edge effects, where particles pass only partially
 2134 through the tile. The large plateau and gap between
 2135 the two peaks indicate the excellent light collection and
 2136 low optical cross-talk between tiles, which shows the
 2137 benefit of the individual tile wrapping.

2138 11.5.2. Detection Efficiency

2139 The detection efficiency is determined using elec-
 2140 trons which traverse all four tiles of a certain row. Such
 2141 events are selected by requiring at least three hits in the
 2142 row, two of which must be in the first and last tile. The
 2143 detection efficiency ε is then given by the probability
 2144 to detect a hit in the remaining channel of the row with
 2145 an energy deposition above the cross-talk level.

2146 Due to the large light yield, which guarantees the
 2147 signal to be well above the detection threshold, the
 2148 efficiency is expected to be $\varepsilon \approx 100\%$. The result-
 2149 ing efficiency can be seen in Figure 107. An efficiency

2150 between $\varepsilon = 93.8\%$ and $\varepsilon = 98.7\%$ is achieved. In
 2151 a small fraction of the events, a hit prior to the expected
 2152 event was observed, which screens the expected
 2153 hit thus causing an inefficiency in the channel. Correcting
 2154 for this screening effect leads to an efficiency above
 2155 99%. The remaining inefficiency can presumably be
 2156 attributed to edge effects and misalignment of the tiles
 2157 and inefficiency of data acquisition. For a better efficiency
 2158 estimation, the measurement will be repeated
 2159 using a tracker.

11.5.3. Time Resolution

2160 The detector was optimized for timing measurements by fine-tuning the SiPM bias voltage and the
 2161 timing thresholds. In order to evaluate the time resolution, a channel-to-channel time delay calibration was
 2162 performed. These time delays are arising from different path lengths of the signal lines on the PCB and
 2163 can vary up to 600 ps. When measuring the timing using threshold discrimination, an additional time delay
 2164 caused by time walk effects needs to be corrected. For this correction, a tight ToT cut is applied on the
 2165 reference channels in order to minimize time walk effects from the reference side.

2173 In order to estimate the time resolution of a single channel, coincidence time distributions between at least
 2174 three channels are used. The channel time resolution can then be extracted by:

$$\begin{aligned}
 \sigma_{i,3}^2 &= \sigma_i^2 + \sigma_3^2, \quad i = 1, 2 \\
 \sigma_{1,2}^2 &= \sigma_1^2 + \sigma_2^2 \\
 \sigma &= \sigma_3 = \frac{1}{\sqrt{2}} \sqrt{\sigma_{3,1}^2 + \sigma_{3,2}^2 - \sigma_{1,2}^2}
 \end{aligned} \tag{5}$$

2178 where $\sigma_{1,2}^2$, $\sigma_{1,3}^2$ and $\sigma_{2,3}^2$ are the three widths extracted from the coincidence time distribution between
 2179 different pairs of channels.

2181 The internal channel resolution, calculated with Equation 5 using channels in the same sub-module, is presented in Figure 108 for the DUTs. For these results,

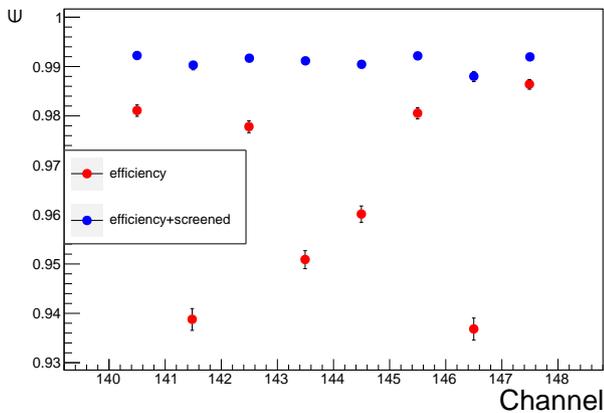


Figure 107: Efficiency calculated for the reference sub-module before and after the correction of the screening effect.

2184 runs with tracks parallel to the DUTs are used in order
 2185 to have at least three channel hits for the same electron
 2186 event within a sub-module matrix by requiring events in
 2187 the Landau distribution. A similar average resolution
 2188 was measured both for the reference sub-module and
 2189 for the two DUTs, where the average time resolution
 2190 measured is 46.8 ± 7.6 ps. However, when repeating
 2191 the same calculation using channels from different sub-
 2192 modules, an additional jitter between the sub-modules
 2193 is observed. The extra jitter between the reference sub-
 2194 module and the DUTs of 45.5 ± 3.2 ps leads to a worse
 2195 time resolution as shown in Figure 108 (blue). The
 2196 main contribution to this arises from non-optimal design
 2197 of the test board used for the read out of all sub-
 2198 modules.

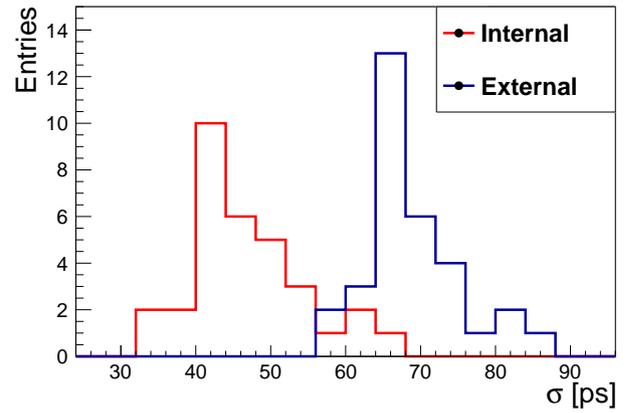


Figure 108: DUT channel resolution: (red) internal, (blue) external.

2199 The expected event multiplicity during phase I of
 2200 the experiment is presented in Figure 109a. While the
 2201 average cluster size is ≈ 2 , also cluster sizes higher than
 2202 9 can be observed. In order to evaluate the time resolution
 2203 as a function of cluster size, a run with 0° incident
 2204 angle was used, where the electron can pass through
 2205 four channels in the reference matrix and up to four
 2206 channels in DUT₀. The time resolution is evaluated
 2207 using an even-odd analysis. For a given electron track,
 2208 all hits are grouped into 'odd' or 'even' based on their
 2209 channel position and the time difference is defined by:

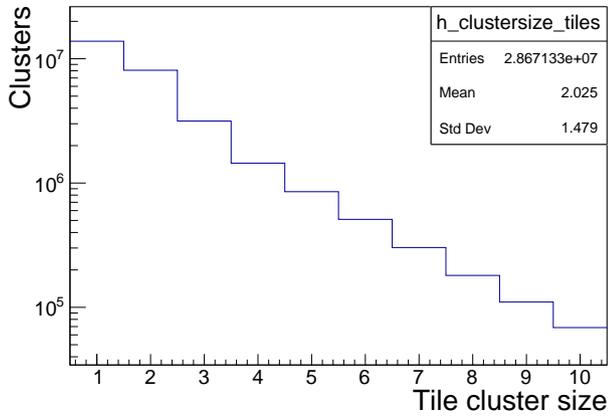
$$\Delta t_{\text{even-odd}}(N_{\text{hits}}) = \frac{1}{N_{\text{hits}}} \left\{ \sum_{i=1}^{N_{\text{even}}} t_{2i} - \sum_{i=1}^{N_{\text{odd}}} t_{2i-1} \right\} \tag{6}$$

2211 where N_{hits} is the sum of all hits. In order to avoid the
 2212 additional jitter between the reference and the DUT,
 2213 the sums in Equation 6 can be arranged such that the
 2214 subtraction is only done within a sub-module, which
 2215 leads to a requirement for an even total number of hits
 2216 within each sub-module. In Figure 109b, the result for
 2217 the even-odd analysis is shown. For this result only
 2218 a single tower of the reference matrix (meaning four

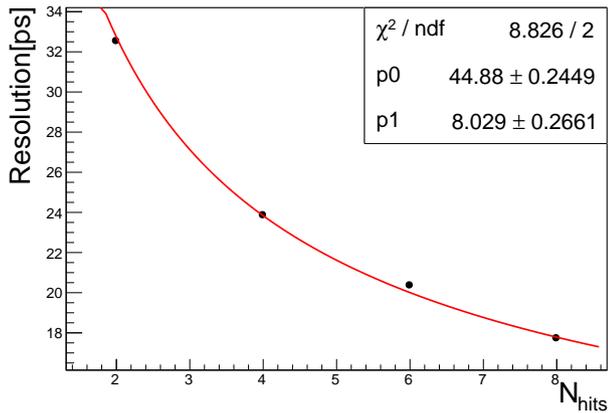
2219 channels) and a single row of DUT₀ were used. The
 2220 average resolution of these channels was measured to be
 2221 45 ± 4 ps, see Figure 108. The resolution as a function
 2222 of clusters is extracted from Figure 109b by fitting it
 2223 with the following function:

$$2224 \sigma_t(N_{hits}) = \sigma_t^{single} / \sqrt{N_{hit}} \oplus \sigma_t^{const} \quad (7)$$

2225 where $\sigma_t(N_{hits})$ is the time resolution for events with
 2226 N_{hits} , σ_t^{single} is the time resolution of a single channel,
 2227 and σ_t^{const} is an additional jitter that can be caused
 2228 by misalignment between the channels. From the fit, a
 2229 single channel resolution of ≈ 45 ps is measured, which
 2230 is in agreement with the value extracted from the single
 2231 channel measurements. In addition, a small misalign-
 2232 ment is also observed. Furthermore, it can be seen that
 2233 a time resolution better than 20 ps can be reached for
 2234 events with high multiplicities.



(a)



(b)

Figure 109: Cluster size impact on time resolution: (a) Simulated phase I cluster size per track. (b) Measured time resolution as a function of number of hits using even-odd analysis.

2235 11.6. Cooling Simulation of the Tile 2236 Detector

2237 To study the feasibility of the cooling system, thermal
 2238 simulations were performed using the CAD imple-

2239 mentation of the technical prototype, while in parallel,
 2240 several measurements of the prototype in the laboratory
 2241 environment were undertaken. After calibrating
 2242 the simulation settings to the laboratory conditions, it
 2243 was shown that the measurements can be reproduced in
 2244 the simulation [46]. The simulation was therefore mod-
 2245 ified to investigate the cooling performance of a full
 2246 module operating at the MuTRIG working power con-
 2247 sumption of 1.2 W. Furthermore, the temperature of
 2248 the water was adjusted to 1 °C to be closer to the oper-
 2249 ating conditions foreseen for the tile detector within the
 2250 experiment, while the environment temperature was in-
 2251 creased to 50 °C in order to subject the system to a
 2252 stress test. The temperature of the SiPMs and the
 2253 MuTRIG ASICs was investigated under these condi-
 2254 tions. In Figure 110, the temperature of the PCBs on
 2255 which the SiPMs are assembled is examined. While the
 2256 temperature on the single PCBs is uniform down to a
 2257 few tenths of a degree, the temperature range across the
 2258 full length of the module spans about 2 °C. Considering
 2259 the SiPM temperature coefficient $\Delta T_{Vop} = 54$ mV/°C,
 2260 these differences can be compensated by adjusting the
 2261 high voltage of the individual SiPMs. Overall, the tem-
 2262 perature is clearly reduced compared to the environ-
 2263 ment temperature, demonstrating the influence of the
 2264 cooling system. Furthermore, the maximum tempera-
 2265 ture of the ASICs can be extracted from the simulation
 2266 as ≈ 42 °C. This is still well within the safe margin of
 2267 operation.

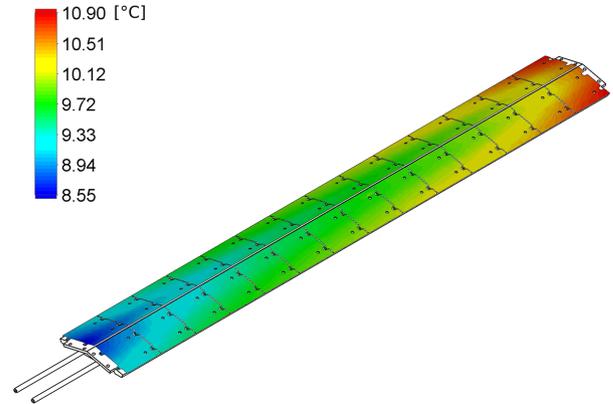


Figure 110: Simulated temperature of the SiPM PCBs. The temperature of the cooling water was set to 1 °C at a flow speed of 1 m/s, while the environment temperature was set to 50 °C.

2268 12. Cooling infrastructure

2269 The detectors, their electronics, the power converters
 2270 and the data acquisition systems are located inside the
 2271 densely spaced Mu3e magnet. The heat they produce is
 2272 transferred to the outside by forced convection cooling.

System	Est. power W
Crate (front end FPGA boards)	2700
DC-DC converters	1500
Copper rods	200
Fibre detector (MuTRiG, SiPM)	120
Tile detector (MuTRiG, SiPM)	420
Total	4940

Table 12

List of systems requiring water cooling inside the experiment, with a conservative estimate of the heat dissipation. All circuits will be run independently.

2273 Except for the pixel sensor chips, we are using water
2274 cooling everywhere. For the pixels, a novel gaseous
2275 helium cooling has been developed.

2276 12.1. Water cooling

2277 Water cooling is used to cool all the front-end elec-
2278 tronics which are located outside the active volume of
2279 the detector, i.e. the front-end ASICs of the timing sys-
2280 tems, the front-end FPGA-boards, the DC-DC convert-
2281 ers, voltage regulators, etc. The anticipated heat load
2282 per source is listed in Table 12 and totals to about
2283 5 kW. To protect the detector from ice buildup, the
2284 water inlet temperature is required to be above 2 °C,
2285 although the helium atmosphere provides a dry envi-
2286 ronment with a dew point below -40 °C. Pipe systems
2287 inside the experiment distribute the water to the heat
2288 sinks, see Figure 111. The FPGA boards are cooled via
2289 a manifold embedded into the circularly shaped crates.
2290 The DC-DC converters for the pixel powering are di-
2291 rectly connected to a cooling loop. Heat dissipation for
2292 the low-voltage power distribution between the DC-DC
2293 converters and the front-end electronics (MuTRiG and
2294 MuPIX ASICs) is a potential issue for the copper rods
2295 around the beam-pipe. Due to this issue active cooling
2296 of them is provided through a dedicated cooling ring
2297 thermally coupled to the rods. The timing detectors
2298 have their own cooling loops to dissipate the heat from
2299 the front-end ASIC and to keep the SiPM at a con-
2300 trolled low temperature. Further details on detector
2301 cooling of the timing systems can be found in chap-
2302 ters 10 and 11, and on cooling of the FPGA boards
2303 inside the crate in chapter 17.

2304 Chilled water will be used from the PSI main supply
2305 via heat exchangers. Additional chillers are in place for
2306 circuits requiring lower set temperatures. The timing
2307 detectors will receive their independent chilled water
2308 loops for enhanced control of their temperatures.

2309 12.2. Helium cooling

2310 All MuPIX chips of the pixel tracker are cooled by
2311 gaseous helium of $T_{\text{He,in}} \gtrsim 0^\circ\text{C}$ at approximately am-
2312 bient pressure. Assuming a maximum power consump-
2313 tion of the pixel sensors of 400 mW/cm² the helium gas
2314 system is designed for a total heat transfer of 5.2 kW,

2315 which increases the averaged gas temperature by about
2316 18 °C.²⁴ For this, the helium cooling system has to pro-
2317 vide a flow of about 20 m³/min (equal to 56 g/s of he-
2318 lium) under controlled conditions split between several
2319 cooling circuits (see section 7.6).

2320 A process flow diagram for the helium plant is shown
2321 in Figure 112. Helium is pumped using miniature turbo
2322 compressors run at turbine speeds of up to 240 krpm.
2323 These units provide compression ratios up to ≈ 1.2 at
2324 mass flows in the range up to 25 g/s, depending on sup-
2325 plier and model. The energy consumption of the com-
2326 pressors for the full system is estimated to be around
2327 6 kW in total. The helium circuits are designed with
2328 minimised pressure drops for a most economic system
2329 layout. The combination of a compressor and a valve
2330 for every circuit allows the control of the mass flow and
2331 the pressure differential applied individually. Compact,
2332 custom made Venturi tubes will be used to monitor
2333 the mass flows of every circuit. Leaks lead to losses
2334 and will contaminate the helium with air. In addition,
2335 outgassing organic residues from electronic components
2336 and adhesives need to be removed. Hence a cold trap
2337 is included in a by-pass configuration to keep the he-
2338 lium pure enough. An expansion volume will be present
2339 to compensate for the compression and expansion of
2340 the gas volume during ramp-up and ramp-down of the
2341 gas flows. A low pressure drop shell-and-tube heat ex-
2342 changer is used to remove the heat from the helium.

2343 13. Mechanical Integration

2344 The detector is maintained at its nominal position
2345 inside the magnet by a removable frame called the *de-*
2346 *detector cage*. The cage also carries infrastructure such as
2347 crates for the power converters and the front-end FPGA
2348 boards, and provides support for all cabling and piping.

²⁴The pixel detector consists of 2844 chips (108 in the vertex detector, 3×912 in the outer layers), giving about 1.14 m² of active instrumented surface (20×20 mm² active area per chip, neglecting the chip periphery) or about 1.3 m² including chip peripheries. The conservative (optimistic) scenario leads to about 5.2 kW (3.3 kW) of dissipated heat. The specific heat capacity of gaseous helium is 5.2 kJ/(kg K).

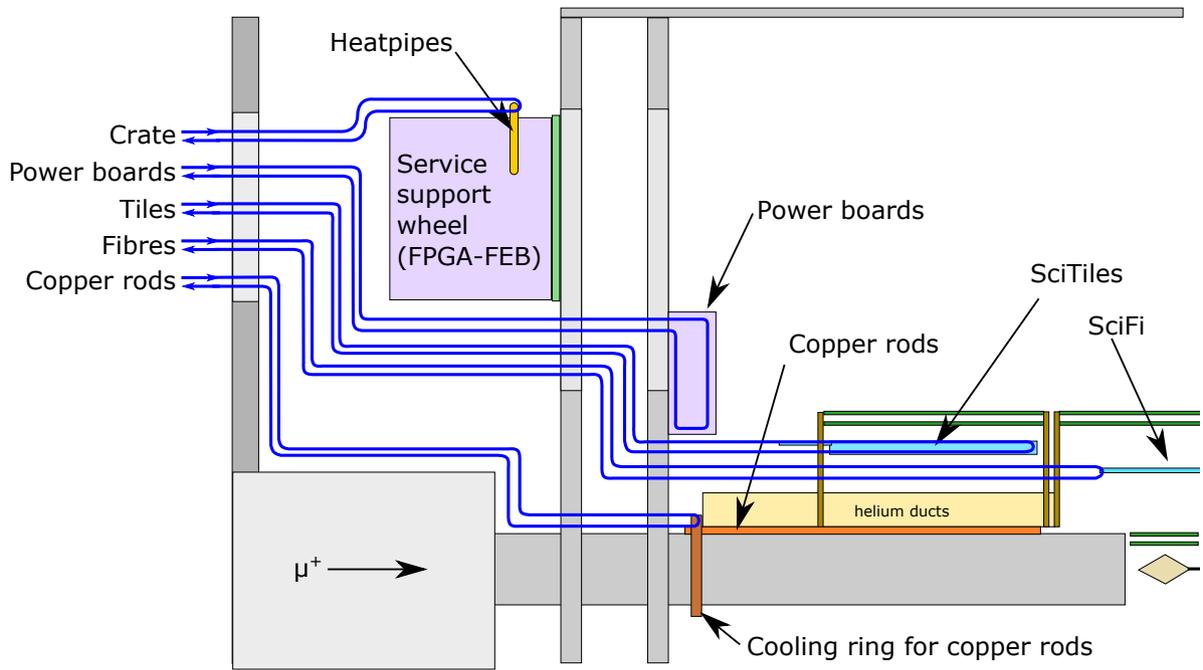


Figure 111: Schematic view of the water cooling topology for one quadrant of the experiment inside the magnet.

13.1. Detector Cage and Rail System

The detector cage has the shape of a hollow cylinder with its axis horizontal, as shown in Figure 113. At each end, a ring frame made of pairs of glass-fibre reinforced polymer wheels has a clamp at its centre for the beam-pipe. Aluminium struts connect the two ring frames and form the cylinder. Gliders on the wider struts (at the 3- and 9 o'clock positions) guide the cage on the rail system inside the magnet.

To compensate for possible thermal expansion in the x (horizontal, perpendicular to the beam-pipe) direction, the gliders on the left rail are floating whilst on the other rail they are kept at a defined position. In the y (vertical) direction the position is defined by the top surface of the rail. The z position is kept fixed by screws.

The clamps in the centre of the rings at either end hold the two beam-pipes in position and take all the weight of the detector. Mechanisms to fine-adjust the beam-pipe pointing angles are built into the clamps. Finite element simulations were performed to test the sturdiness of the design. Load tests have been carried out on a full-scale mock-up, confirming the simulation results of a deflection of 0.3 mm under a typical detector load of 10 kg at the beam-pipe tips. The connection of the beam-pipes to the beam line is described in chapter 5.

13.2. Mechanical support of detector stations

The detector components are mounted on the beam-pipes, see Figure 114. As shown in the previous chap-

ters, both pixel and timing detectors follow a barrel concept. They are mounted on pairs of end rings, supported on the beam-pipes. Whilst the recur stations have their support on one beam-pipe, the central barrel has one mechanical support on the upstream beam-pipe and the other on the downstream beam-pipe. To compensate for any tilt of the end rings and movements due to thermal expansion, the detector mounts are spring-loaded at one end.

Detectors can be mounted and dismantled in sequence from inner to outer without the need to retract the beam-pipes. For example to mount the central barrels, the vertex half-shells of layers 1 and 2 will be installed first, followed by the fibre ribbons. Finally, the pixel modules for layers 3 and 4 will be mounted. For this sequence, the cage can be placed on a special extraction cart on wheels. It has the same rail system as that inside the magnet. For better access, the cart has rollers allowing the rotation of the cage around its own z -axis in a safe manner.

The beam-pipes also provide support for other services. The copper bars to supply power to the central detectors (section 14.4) are glued onto the beam-pipe with a custom procedure to ensure proper electrical insulation, and manifolds for the helium cooling system are attached to the ends of the beam-pipes.

13.3. Supply systems and cable routing

Service support wheels (SSW) are situated outside either end of the detector cage. They are loosely coupled to the cage in the z direction and have their own gliders to decouple mechanical forces from the cage.

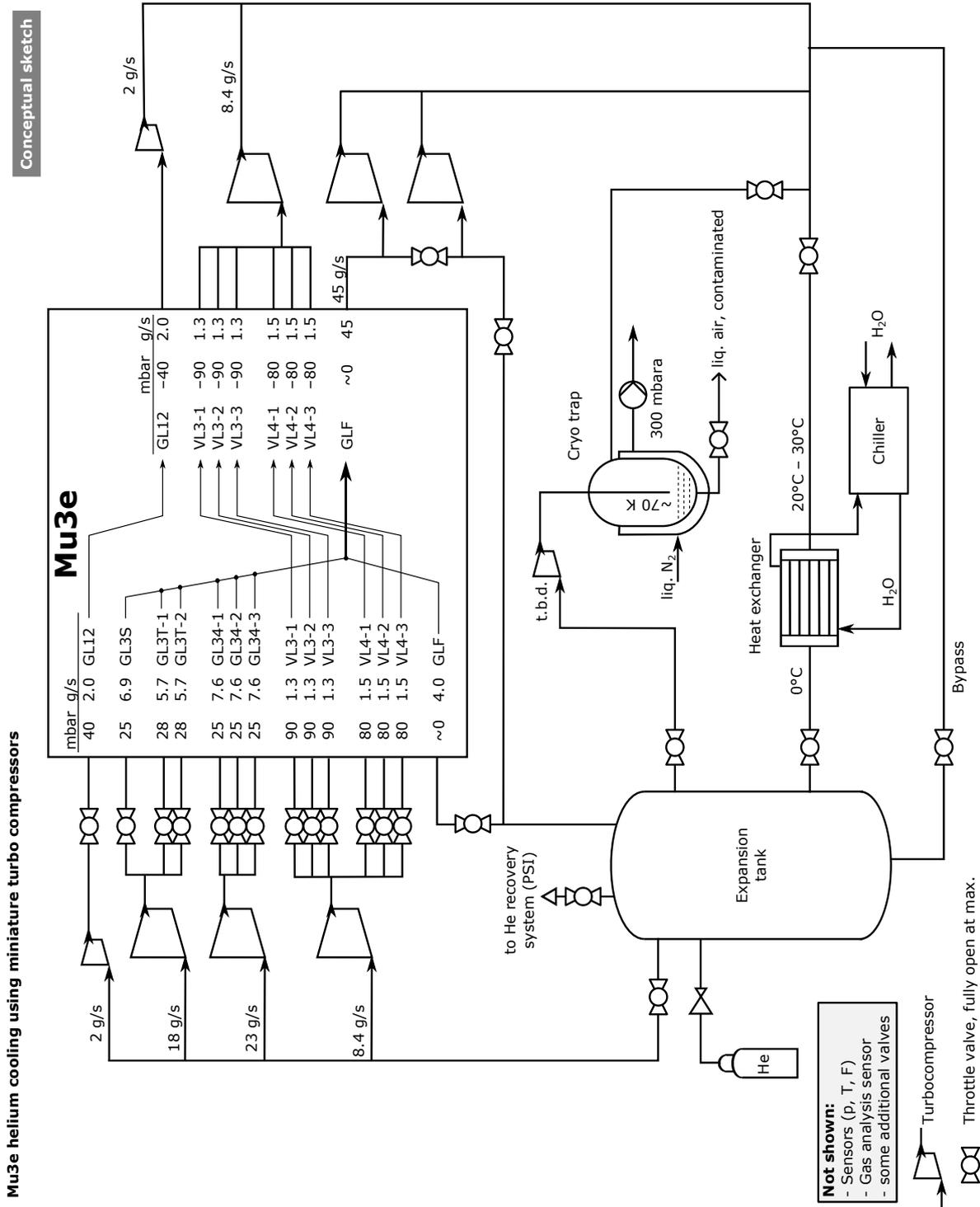


Figure 112: Conceptual process flow diagram of the Mu3e helium cooling infrastructure. Miniature turbo compressors in the circuit may be implemented using multiple units operated in parallel or in series, depending on needs.

2411 The SSWs hold crates for the front end boards, patch
 2412 panels for the power connections and routing for the
 2413 cooling pipes (water and helium). The DC-DC con-
 2414 verter boards (low voltage supply) and the bias voltage
 2415 generators are mounted on the inner side of the glass-
 2416 fibre wheels. All services have connections at the out-

ward facing planes of the SSWs. Figure 116 shows a
 conceptual view.

Services have to be routed from the inside to the
 outside of the experiment through flanges sealing the
 internal dry helium atmosphere from the ambient envi-
 ronment. Four identical flange plates are mounted on

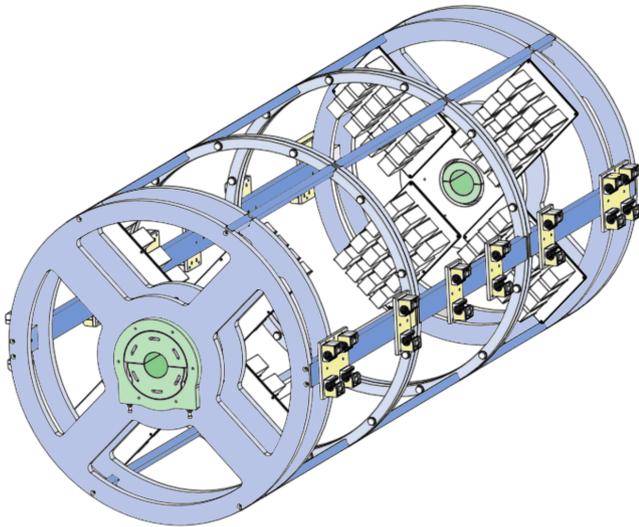


Figure 113: Detector cage structure consisting of two ring frames (light blue) connected by struts (dark blue). The clamps holding the beam-pipes are inside the ring pairs at either end (shaded green). The gliders (yellow) allow the cage structure to be moved into the magnet on the rail system.

four turrets at the end plates of the magnet, two at either end. Ports for all media are present and provide suitable connectors. For the power connections, sealed heavy-duty double-sided 56 pin connector assemblies are used²⁵. Tubes for the helium and water coolants are welded into the flange and will use industry standard fluid connectors. The fibre bundles are sealed with epoxy into brackets that are sealed with an O-ring to the flange. A drawing is shown in Figure 115.

13.4. Access to the Mu3e detector

Extracting the experiment from the warm bore of the magnet requires an orchestrated procedure, which essentially looks as follows:

1. Detach the beam line, secure cables and hoses. Temporarily remove beam line parts as needed to make space.
2. Move the magnet into the extraction position.
3. Open the magnet doors. Remove access plates from the helium sealing plate.
4. Disconnect all cables and hoses through access holes.
5. Safely remove the sealing plates, secure cables and hoses while doing this.
6. Place extraction cart in front of experiment. Engage rail coupling. Carefully remove experiment, guided by the rails.

For detector insertion, the procedure is reversed. The extraction cart is the same as described in the previous

²⁵Supplier: Souriau-Sunbank

section. Guide pins and clamps help to safely couple the cart to the rail system in front of the magnet.

For servicing the detector, a protective tent will be available that can be used either inside the area for quick work, or outside the area in a secure space. External crane attachment points are provided for transferring the experiment to outside of the beam area.

14. Power Distribution and Cabling

With a power consumption from the pixel tracker, the SiPM readout electronics, front-end board, and step-down converters (see Table 12) of up to 10 kW, the Mu3e detector needs a robust but also compact power-distribution system. The conceptual design for such a system is shown in Figure 117. Power supplies located on the lower infrastructure platform deliver 20 V DC, a voltage high enough to allow for a compact and flexible set of power cables, which are brought into the experiment through a high-density power connector. From there, the power is distributed to either the front-end board crates with embedded buck converters, or to the power boards which step down the voltage for the MUPIX chips, and the tile and fibre readout boards. In addition, separate power is provided to the slow control systems which need to run when the main detector power is switched off.

14.1. Power Partitions and Grounding

The Mu3e experiment is divided into 112 detector partitions, which also act as independently controlled power partitions (see Table 13). The DC power supplies for these partitions will be the TDK-Lambda GENESYS low-voltage power supply, which are known to be reliable, for example they are being used in the MEG experiment. Each supply can provide up to 90 A / 2700 W, which is distributed to several power partitions via a power relay bank. A massive common return line per supply minimizes the voltage drop. Each power supply output is floating, and the return line is referenced to the common ground inside the experimental cage. Slow control systems such as the alignment system, environment monitoring, the controller boards regulating the detector power, and all safety critical systems are powered separately. This enables the powering of all diagnostic tools of the experiment prior to the turn on of the high-power detector electronics.

This powering scheme means that care has to be taken to not introduce ground loops when connecting the various detector partitions to e.g. a slow control bus or a high-voltage input. To avoid this all data connections to the outside go via optical fibres, the readout is therefore fully electrically decoupled.

14.2. DC-DC conversion

Switching power converters will be used to step down the 20 V to the voltages needed by the detector and

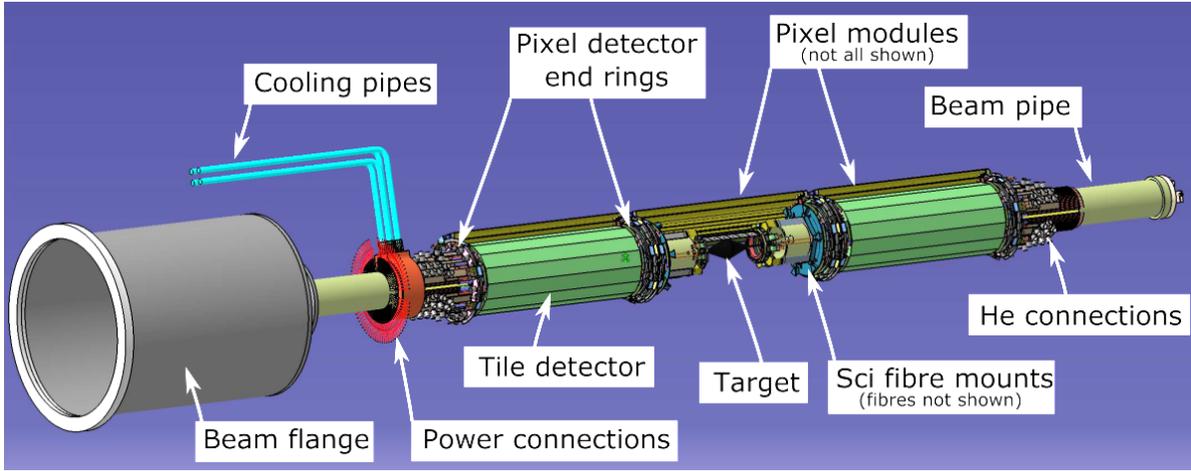


Figure 114: The Mu3e experiment mounted on the beam-pipes. Not shown are the detector cage and supplies. Some parts have been partially removed for visibility. LV: low voltage power.

Partition type (ASIC)	#partitions	#ASICs/partition	Maximum power per partition [W] Excluding	Including DC-DC	Total Power including DC-DC losses [W]
Pixel(MuPIX)					
layer 1	4	12	19.2	25.6	102
layer 2	4	15	24.0	32	128
layer 3	3 × 12	32, 36	51.2, 57.6	68.3, 76.8	2660
layer 4	3 × 14	36	57.6	76.8	3230
Fibre(MuTRiG)					
	12	8	9.6	12.8	153
Tile(MuTRiG)					
	14	13	15.6	20.8	291
Front-end board					
	8	14 boards	266	350	2800
Total					9370

Table 13

Power partitions for the Mu3e detector ASICs and electronics inside the magnet bore. The high-power elements on the front-end board are the Arria V FPGA, clock chip, and the transceivers. A respective maximum power consumption of 1.2 W and 1.6 W for the MuTRiG and MuPIX chips is assumed. The upper limits on the power figures are driven by the cooling system, and depend on power losses in the entire power distribution system. For the total power budget, a 75% efficiency of the DC-DC converters is assumed.

electronics (Table 14) Typical efficiencies are of the order of to 70% to 90%, depending on the current and the voltage step. Compact high-power converters typically used for FPGA boards such as the LTM4601 (Analogue Devices) have a ferrite core inductor, with is incompatible with the high magnetic field environment of the experiment. Mu3e has selected the following solution: a commercial synchronous buck converter combined with a custom air coil, where the coil properties and the switching frequency are optimized for the required output voltage and current. As they are mounted outside the active area of the detector, these converters don't have to be radiation hard.

14.2.1. Front-end board converters

The front-end boards with an Arria V FPGA, and the LVDS and optical transceivers (section 17.2) require

several DC voltages at typical currents of 1-3 A. Three switching DC-DC converters will generate 1.1, 1.8, and 3.3 VDC with Peak-Peak ripple below 10 mV (see Table 14). Passive filters and active filtering with devices such as the LT3086 (Analogue Devices) further reduce the voltage ripple, and allow intermediate voltages to be generated. The switching converters on the front-end board are based on a compact TPS548A20 synchronous buck converter with integrated switches (Texas Instruments), combined with single layer cylindrical air coils. Figure 118 shows a stand alone 2x4 cm 1.8 V prototype, which has demonstrated good performance at operating conditions. The converter embedded on the front-end board will have a similar footprint, with an additional copper shielding box covering the coil to reduce EMI and improve mechanical stability [47].

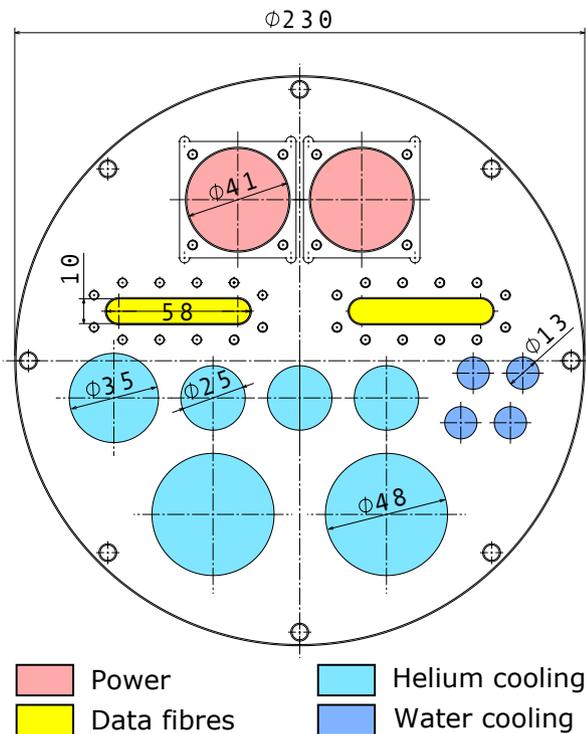


Figure 115: Drawing of the cabling flange. Additional ports will be added for auxiliary use. Dimensions in mm.

14.2.2. Power boards

With currents potentially up to 30 A and very few options for additional filtering further down the line, the requirements for the active detector DC-DC converters are more challenging. The TPS53219 buck controller and CSD86350Q5D power MOSFET switch from Texas Instruments were identified as meeting these requirements. A first prototype was developed (see Figure 119). This board has space for various input and output filter configurations, and has dimensions close to the final form factor. The configuration shown, with a toroidal coil in combination with a secondary LC filter, has the best noise figure with a Peak-Peak ripple of approximately 10 mV. The board was stress tested in a magnetic field, and successfully used to power a MUPIX 8 pixel detector during a DESY testbeam campaign.

The final power board has a secondary output filter, and several additional features such as current monitoring, and interface connector for the back plane, and an embedded temperature interlock connected to a temperature diode on the MUPIX sensor [48].

In the experiment, 16 power boards are mounted in a crate on the SSW (see Figures 117 and 116), with a MSCB slave (chapter 16) as controller. This controller adjusts the output voltage, switching frequency, and monitors several parameters. It also interfaces the DC-DC converters with an external interlock system.

14.3. Bias voltage

Bias voltages between 50 V and 120 V are required for the SiPMs used in the fibre tracker and the tile detector as well as for the MUPIX chip. As only moderate currents of few μA per channel are needed, these voltages can be generated with a Cockroft-Walton chain. Converters supplying positive voltages have been developed and optimized in the context of the MEGII experiment. For Mu3e this design is carried over to a new board which will be mounted inside the magnet volume.

The pixel tracker requires a negative bias voltage of up to -100 V for each chip. For economic reasons, a set of four power groups is provided with a common voltage with dedicated current measurements and the possibility to turn off each power group individually. Since voltage generators which run at the high magnetic field are not available commercially, a custom board based on the Cockroft-Walton voltage multiplier design has been created. Figure 121 shows the simplified block schematic of this device. A micro-controller connected to the MSCB slow control system operates the DAC, ADC and switches of the voltage generator. It is capable of generating a bias voltage from 0... -150 V out of a single power supply of 5 V. First tests with a prototype indicated that an absolute voltage accuracy of ± 1 mV at a current of 2 mA can be achieved with a residual ripple below 10 mV. Each channel contains a shunt resistor and an ADC, which can measure the individual current. High voltage CMOS switches operated by the micro-controller can switch off individual channels in case the corresponding pixel chips would have a problem.

Figure 120 shows the top and bottom sides of a prototype of the high voltage board. It has a size of $30 \times 60 \text{ mm}^2$. The Cockroft-Walton chain can be identified on the bottom side of the board. No magnetic components have been used in the design, making it possible to operate the board in magnetic fields of up to 2 T.

14.4. Cabling

The basic concept of the cabling inside the detector is shown in Figure 116. From the power boards, the connections to the detector components are carried out with minimal possible length using solid copper cable of 2.5 mm^2 gauge. Because all connections have to be done outside the detector acceptance, only the space around the beam pipes is left. Copper rods with a cross-section of $5 \times 2.5 \text{ mm}^2$ are used to bridge the connection between the detector endring mount and the outer end of the beam pipe. These rods are individually insulated using a polyimide foil wrap, and held in place by epoxy. The rods are in a densely packed environment, hence the dissipated power will be actively removed using a copper cooling ring (see section 12.1). The cables are connected using screw-mounted copper

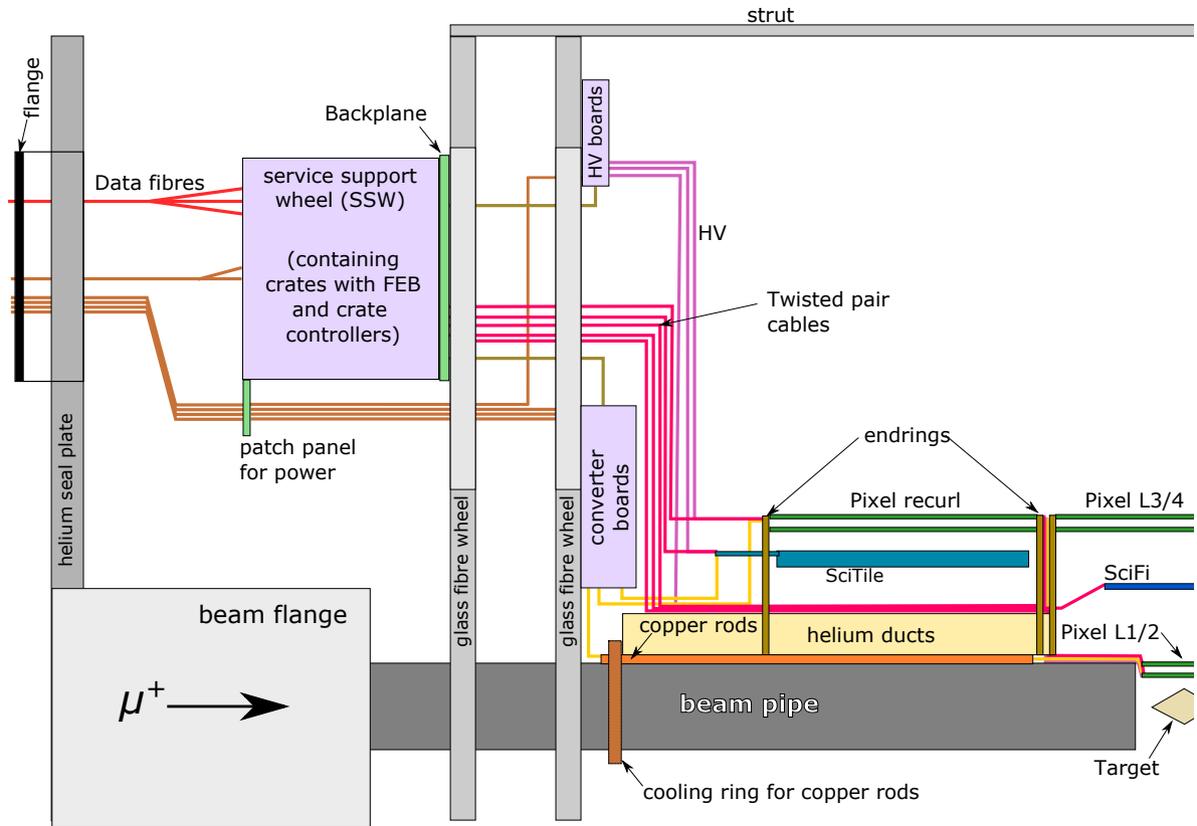


Figure 116: Conceptual view of supply system positioning and cable routing (*rz*-view, not to scale). All supplies can be disconnected for the extraction of the experiment. The feed-throughs on the helium seal plate are gas-tight.

Component	Voltage [V]	Typical current [A]	Min. inductance air coil [μ H]	coil design
Front-end board	1.1	2	2	cylindrical
Front-end board	1.8	1.7	6	cylindrical
Front-end board	3.3	2.2	4	cylindrical
MuPIX partition (layer 1,2)	ca. 2.3	10	0.5	toroid
MuPIX partition (layer 3,4)	ca. 2.3	21	0.4	toroid
Fibre partition	ca. 2.0	7	0.7	toroid
Tile partition	ca. 2.0	9	0.7	toroid
Tile partition	3.3	3	3.3	toroid

Table 14

Specifications for different buck converter channels stepping down the voltage from 20 V with an efficiency $>70\%$. The quoted MuPIX voltage takes into account an anticipated voltage drop of 200 to 300 mV between the converter and the chip.

2620 clamps.

2621 Data cables between detectors and the front-end
 2622 boards are micro-twisted pair wires: AWG 36 wires
 2623 with a Polyimide isolation and an impedance of $90\ \Omega$
 2624 from *Heermann GmbH*. Each bundle of up to 50 pairs
 2625 has a typical outer diameter of 2 mm. The bundles
 2626 are arranged around the water cooling pipes: see Fig-
 2627 ure 122 for a sketch of the arrangement. The data
 2628 cables are attached to the detector elements using sol-
 2629 dered connections on flexible printed circuit boards,

2630 which connect to the PCB or HDI via interposers. The
 2631 attachment to the frontend boards takes place on the
 2632 patch panel of the SSW using zero-force connectors.

15. Clock Distribution

2633
 2634 The precise timing measurement as well as the op-
 2635 eration of many Gbit/s links in the experiment requires
 2636 a very stable clock distribution. In order to ensure syn-
 2637 chronisation between the timestamps of all sub-detectors,
 2638 a global synchronous reset is also required.

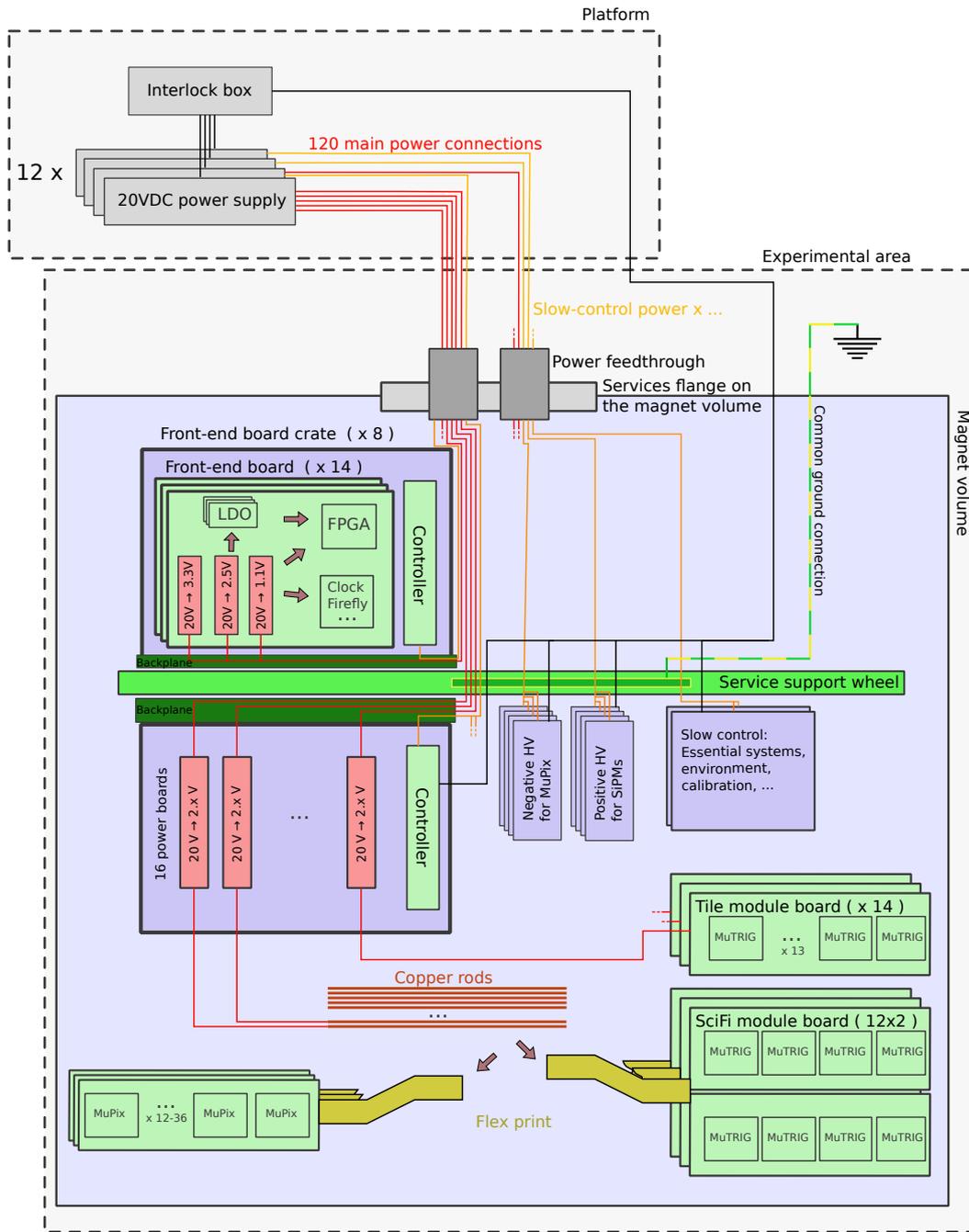


Figure 117: Schematic view of the power distribution inside the detector. Floating 20 VDC supply lines provide up to 12 A of current each (red lines). Custom DC-DC converters on the front-end board and close to the active detector step this 20 VDC down to the required voltages. Separate power is provided to the slow control systems (orange lines), which need to run independently from the main detector power. Note that these services are distributed over the upstream and downstream Service Support Wheel (SSW). This SSW also acts as a common ground plane, with a single ground connection to the outside.

2639 The frequency of the clock distribution system is
 2640 chosen to be 125 MHz; other frequencies can be derived
 2641 locally by phase-locked loops. To meet the timing res-
 2642 olution requirements for all of the detector subsystems,
 2643 the phase stability of the clock distribution has to be
 2644 better than 10 ps over the complete system. The jitter
 2645 requirements of the global reset (\sim half a clock period)

are more relaxed.

The overall block diagram of the clock and reset
 system can be seen in Figure 123. The 125 MHz clock
 is generated by a commercial low-jitter clock oscilla-
 tor on a dedicated board. This board is controlled by
 an FPGA which also controls the reset signal. The
 board provides both clock and reset signals to opti-

2646
 2647
 2648
 2649
 2650
 2651
 2652

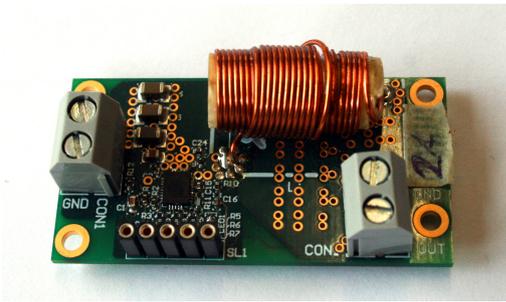


Figure 118: The second prototype for the buck converters for the frontend board. Good performance with efficiencies $>75\%$ in a 0.7 T magnetic field was demonstrated.

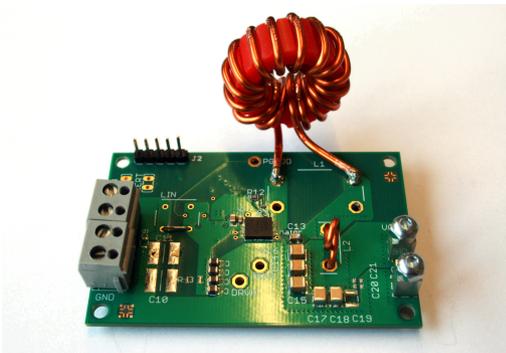


Figure 119: A 4.5 x 7 cm prototype for the power board, with a 0.5 μH toroidal inductor and a secondary LC filter at the output. With an output ripple of 10-20 mV, this has been used to successfully power MUPIX 8 sensors.



Figure 120: Prototype of the high-voltage generator board with top side (upper picture) and bottom side (lower picture).

forward the signals to a jitter cleaner and fan-out chip on the front-end board, which then drives LVDS signals to the FPGA and front-end ASICs. For the filter farm PCs, each FPGA board inside a PC receives the global clock via a Clock Transmission Board (CTB), a small custom board which converts the optical clock signal to an electronic one. Reset and state changes are communicated to the farm via ethernet.

The reset signal is synchronised to the clock and uses 8 bit datagrams in 8 bit/10 bit encoding [49, 50], to induce not only resets but also changes of operation mode and the synchronising of the jitter cleaners. In idle mode, a comma word is sent, allowing for word alignment. Resets of different subsystems and changes between idle and running modes are triggered by sending one of the 256 possible data words.

The front-end boards then have the task of distributing the clock and reset (here the reset is an on/off signal) to all ASICs (MUPIX and MUTRIG). A dedicated jitter cleaner and fan-out component is used, which will also be used to generate the 625 MHz clock needed by the MUTRIG Phase-Locked Loop (PLL).

Slower clocks, required e.g. for slow control and configuration signals, will be generated by clock dividers and/or PLLs in the FPGAs.

15.1. FMC Distribution Board

At the heart of the clock and reset system is the FPGA Mezzanine Card (FMC) distribution board, shown in Figure 124. The distribution board connects to the FPGA development board via an FMC connector [51] which allows access to the 10 Multi-Gigabit Transceiver (MGT) lines the Xilinx Kintex-7 FPGA offers. The low-jitter IC which is used to generate the 125 MHz clock is the Silicon Labs Si5345 which can generate up to 10 any-frequency clock outputs with an ultra-low jitter of 90 fs RMS. The SI5345 also offers in-circuit non-volatile programming which ensures a regular power up with a known frequency. The distribution board uses 8 MGTs for the reset lines and all 10 clock outputs from the clock generator, two of which are used to generate the MGT lines and the remaining 8 are used for the clock lines. The clock and reset lines are routed to the inputs of two optical Firefly transceivers. Such a configuration allows the individual control of the 8 pairs of the clock and reset lines. In the experiment, these can be translated as 8 individually controllable partitions, though only 4 are needed for the phase I Mu3e DAQ. In addition, the distribution board provides an I²C interface which is used to communicate with the active splitting boards, which among many other functions, can provide the ability to disable/enable individual clock and reset lines.

15.2. Active Splitting

The optical splitting of the clock and reset lines is modular in design. It allows the active splitting to be versatile and can be potentially used as a generic active

cal transmitters, which are then passed to a number of bespoke boards. These actively split the signal and supply the clock and reset lines on optical fibres to local clock distribution boards inside the warm bore of the magnet, as well as to the DAQ switching boards (see section 17.4). Inside the magnet, optical receivers

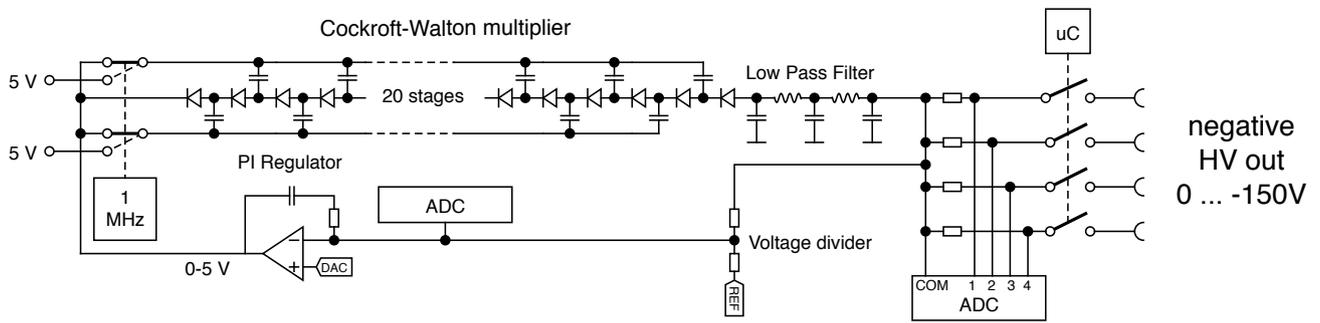


Figure 121: Block schematic of the pixel high voltage generation.

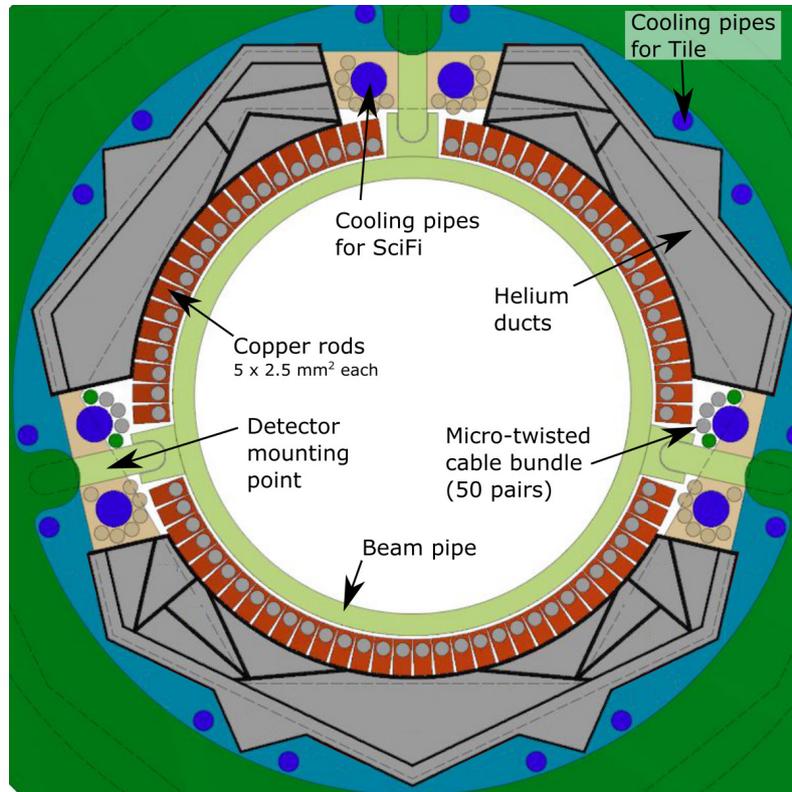


Figure 122: Cross section of a recurl station. The micro-twisted pair cables come in bundles and are shown as circles around the cooling pipes for the fibre detector (the colour code shows detector assignment: green for fibres, grey for vertex layers, brown for pixel outer layers). The helium ducts have separated channels for different destinations. Their cross sections are optimised for minimal pressure drop.

2715 optical splitting solution. The system unit comprises
 2716 one motherboard and 8 daughter boards. The mother-
 2717 board takes 8 optical inputs and electrically routes each
 2718 of the 8 signals to one of the eight daughter boards. The
 2719 daughter board, which connects to the motherboard via
 2720 a high-speed mezzanine connector, creates 36 copies of
 2721 the input signal for a total of 288 optical copies per
 2722 system unit. One system unit is sufficient for all clock
 2723 reset lines required by the Phase 1 Mu3e DAQ. A 3D
 2724 representation of the system can be seen in Figure 125.
 2725

15.2.1. Board designs

2726 The daughter board, shown in Figure 126, utilises
 2727 the OnSemi NB7L1008M fan-out chip; a 1:8 6.5 Gbit/s
 2728 differential fan-out buffer with a random clock jitter <
 2729 0.8 ps RMS. Overall, 5 fan-out chips are used per board,
 2730 creating a total of 40 replicated signals. However, only
 2731 36 are used as the three on-board Firefly transceivers
 2732 have a total of 36 optical transmitters. The 36 optical
 2733 lines are carried by three 12-fibre OM3 MTP cables.
 2734 The board also has a low-noise DC-DC converter with
 2735 power monitoring and is connected to an I²C bus which
 2736 allows this power monitor to be read, in addition to
 2737

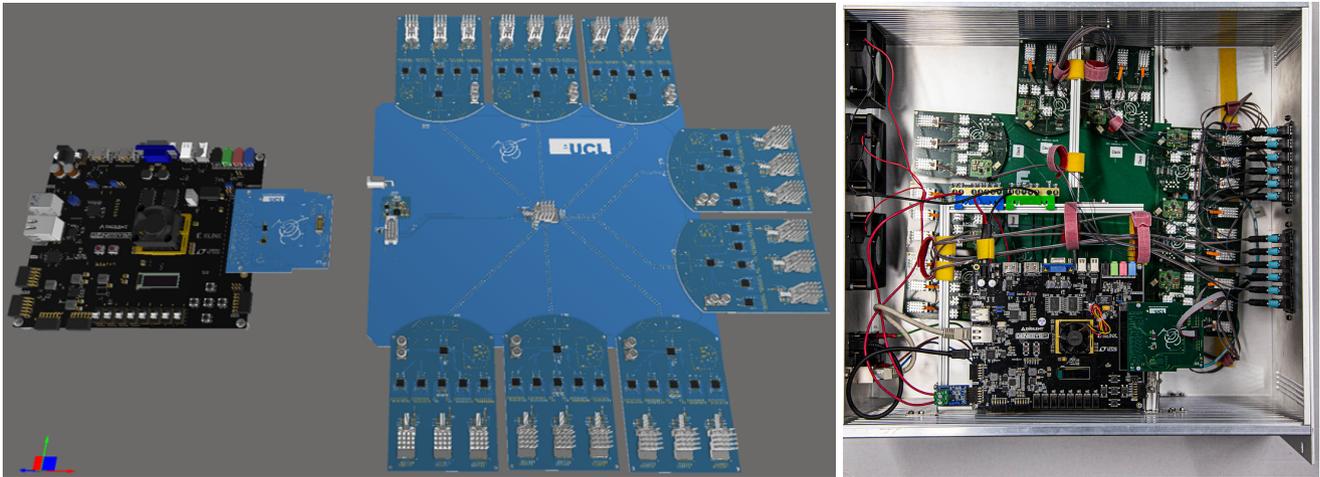


Figure 125: Left: A 3D representation of the full clock and reset distribution system. On the left side is the Genesys 2 board with the clock and reset FMC distribution board. On the right side is the active splitting motherboard with an optical receiver (centre of the motherboard) that accepts the clock or reset lines from the FMC board via an optical fibre. The motherboard electrically routes the 8 signals to the fan-out daughter boards where each board generates 36 optical copies of the routed signal. Right: The full clock and reset system in a 19-inch rack-mountable box.

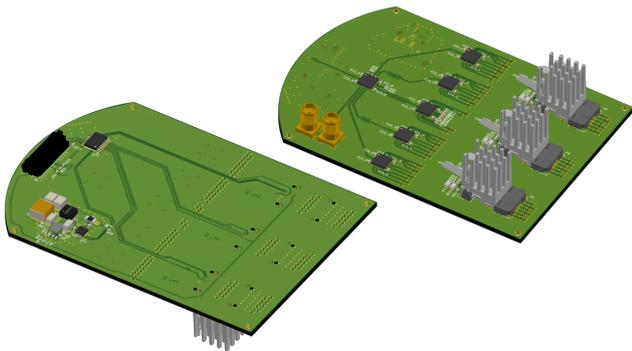


Figure 126: A 3D representation of the clock and reset daughter board. Left: Bottom view of the board showing the mezzanine connector and DC-DC circuitry. Right: Top view of the board showing the fan-out ICs and the three Firefly optical transceivers.

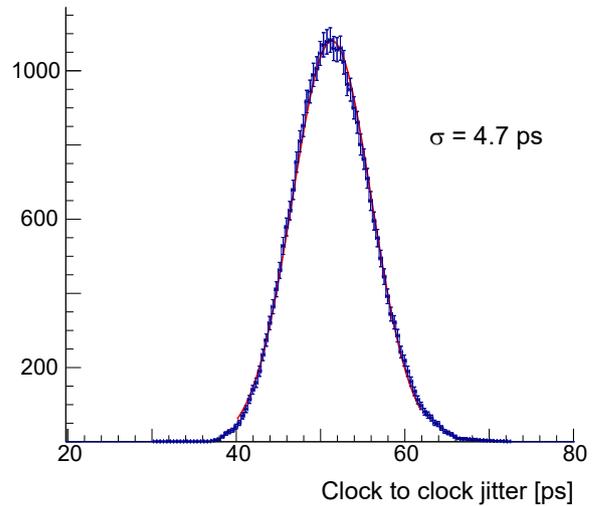


Figure 128: Rising edge time difference between two different clocks distributed via different daughter boards and different optical cable assemblies (leading to the 50 ps offset) as determined via a fast oscilloscope. The fit is a simple Gaussian.



Figure 127: MIDAS page for control and monitoring of the clock and reset distribution system.

16. Slow Control

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The slow control system deals with all “slow” data such as high voltages for the SiPMs and silicon sensors, ambient temperatures and pressures, the beam line magnet settings and parameters of the cooling system. The configuration of the MuPIX and MuTRIG ASICs is handled separately, as described in section 16.2.

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For the slow control parameters it is important to have all data and control functionality in a homogeneous single system. This makes the maintenance of the system much simpler, since only a limited number

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of different hardware standards have to be taken care of. The integration of all data enables us to define control loops between otherwise completely different sub-systems. Examples are regulating or switching off the detector power in the case of overheating of the pixel sensors or irregularities appearing in the helium cooling system, or adjusting the high-voltage on the basis of detector data such as energy spectra or hit rates.

The integration of all systems will be done through the MIDAS DAQ system, and as much as possible combined with the associated MIDAS Slow Control Bus (MSCB) system [54], which is discussed in section 16.1. In addition to the MSCB system, the MIDAS DAQ system receives and sends slow control data to the various layers of FPGAs and GPUs through the main fast data links (chapter 17). The slow control system also contains interfaces to the PSI beamline elements via the EPICS system [55]. This allows monitoring and control of the beamline from the main DAQ system, which has proven very versatile in other experiments using this scheme.

The full state of the system is kept in the MIDAS Online Data Base (ODB), and all slow control data is stored in the history system of the MIDAS system, so that the long term stability of the experiment can be effectively verified. The slow control data is also fed into the main event data stream, to be available for offline analysis.

All data fed into the MIDAS system is accessible by the MIDAS distributed alarm system. This system allows upper or lower limits to be set on all slow control data in a flexible way through the MIDAS web interface. In the event of an alarm, shift crews can be notified through spoken alarm messages and contacted via mobile phones. Scripts can be triggered which put the whole experiment in a safe state in order to avoid damage from excessive temperatures or other dangerous conditions. In addition to this MIDAS-based alarm system, an interlock system that is fully independent from the DAQ handles the most critical parameters of the apparatus (see section 16.3).

16.1. Midas Slow Control Bus

The MSCB system uses a serial differential bus for communication, with two data lines (positive and negative polarity) and a common ground. Over long distances, such as between crates, the physical standard for this bus is RS-485, running at a relatively low speed of 115.2 kbit/s in half-duplex mode. The slow speed makes this bus highly immune against improper termination or electrical interference, while the short commands of the MSCB protocol still allow the readout of many hundreds of nodes per second. This optimised protocol allows the monitoring of many thousands of channels with repetition periods in the 100 ms range, which is more than sufficient.

The MSCB bus uses a single-master, multiple-slave

architecture, where all slave nodes on the bus only have to reply to requests sent by the master node, thus making the bus arbitration very simple. Many devices already exist for this system, such as the SCS-3000 units, as shown in Figure 129. Since the system was developed at PSI, it can be quickly adapted to new hardware.

The MSCB nodes inside the experiment are either dedicated 8-bit microcontrollers or soft-core microcontrollers instantiated on the FPGAs, connected to the RS-485 bus via insulated transceivers to avoid ground loops and noise. These microcontrollers perform local control loops, such as high-voltage stabilisation, power conversion or environmental control, and send measured values to the central DAQ system for monitoring. Custom high-voltage boards mounted inside the magnet have an embedded microcontroller acting as an MSCB node, thus no high-voltage cables have to be fed into the experimental volume (section 14.3). The DC-DC power converters (section 14.2.2) controller board also act as an MSCB node.

A dedicated slow control segment is connected to the environment sensors inside the magnet, monitoring parameters such as the temperature and pressure of the helium flows, the humidity inside the cage, the magnetic field at various positions and the temperature of various detector components. The monitoring data processed by the detector ASICs and the FPGAs will primarily be read out through the main data stream, with the MSCB-based readout as a backup system.

Microcontroller-based bus adapters are used to bridge between each RS-485 segment and optical fibres, which allows us to route all segments from inside the magnet to the outside world via optical fibres, where they are connected to the experiment Ethernet network. In this way, all MSCB nodes can be accessed from any computer connected to the experiment's Ethernet network.

16.1.1. Frontend board control

All front-end boards are connected to the MSCB bus via 3.3 V RS-485 optically isolated transceivers. Since the MSCB protocol is very simple, using only a few bytes for addressing, data and redundancy, its implementation requires less than 700 lines of C code. This makes it possible to run the MSCB core inside a NIOS II soft-processor on every FPGA used in the experiment.

Test implementations have shown that this needs only a few percent of the available FPGA resources, which can be easily accommodated. Having a dedicated slow control link to all FPGAs in the experiment is a powerful tool for debugging and configuration, since this allows the management of the FPGAs even if the optical data links are down.

16.2. ASIC Configuration

The configuration of the pixel detectors is a special case as it requires many millions of parameters, e.g. the tune-DAC values for each pixel. Since this amount of

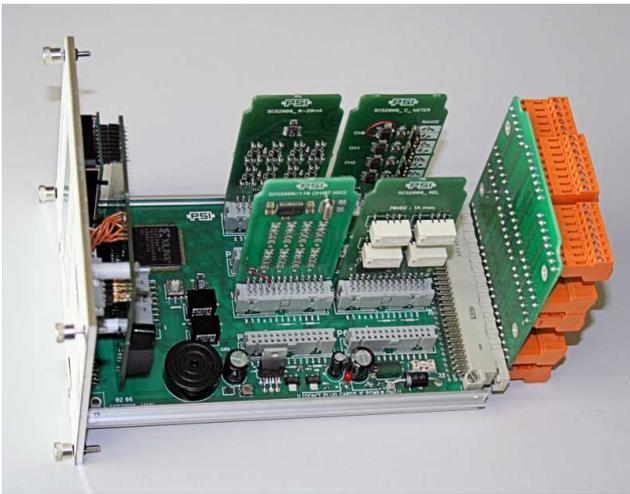


Figure 129: SCS-3000 unit as part of the MSCB slow control system. This unit has 64 input/output channels, which can be configured via plug-in boards as digital or analogue channels. Many plug-in boards exist already such as PT100 temperature sensor readout cards, analogue high resolution inputs (24 bit resolution), valve control outputs and many more.

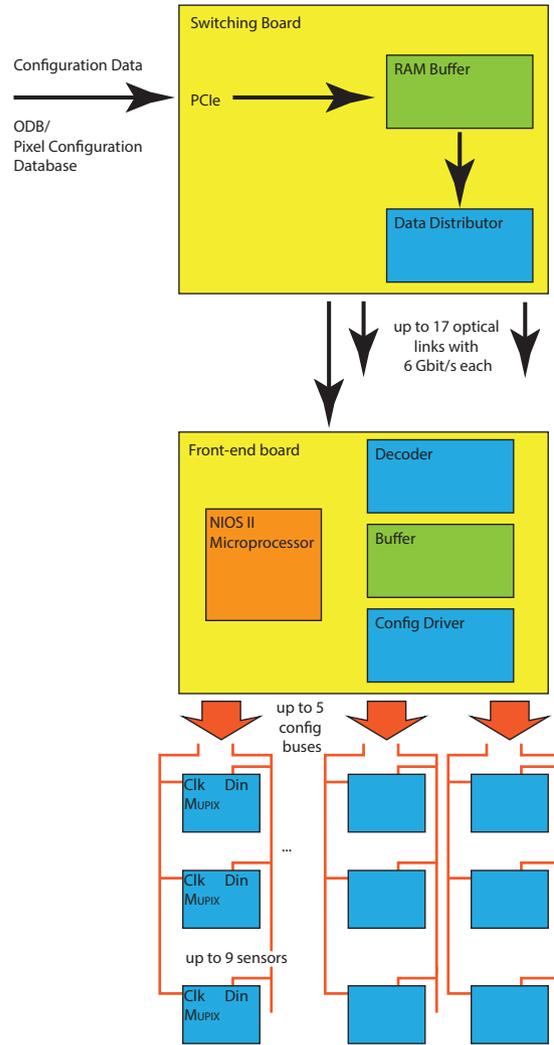


Figure 130: Data flow for the front-end ASIC configuration for the pixel detectors.

2894 data is considerably larger than the total for all other
 2895 systems (~120 MB for the full phase I detector), an
 2896 extension of the slow control system is implemented. A
 2897 dedicated program manages, visualises and exchanges
 2898 the pixel detector configuration parameters between an
 2899 optimised database and the pixel hardware. In this way
 2900 the time required to configure the pixel detectors can
 2901 be minimised, while this program is still connected to
 2902 the main DAQ system. It can be synchronised with
 2903 run starts and stops, and can inject pixel monitoring
 2904 data periodically into the event data stream for offline
 2905 analysis. The regular slow control data stream contains
 2906 a pointer to the relevant state of the pixel configuration
 2907 database.

2908 The configuration of the individual pixel sensors is
 2909 written via a dedicated differential configuration bus
 2910 with up to 9 sensors (one electrical group in the outer
 2911 layers) connected in parallel. This corresponds to ap-
 2912 proximately 20 Mbit of configuration data, which in
 2913 turn dictates the need for configuration speeds above
 2914 10 MHz in order to guarantee fast run starts. Sensors
 2915 on different ladders (different configuration buses) can
 2916 and have to be programmed in parallel. Slow control
 2917 data output from the sensors is sent using the fast
 2918 LVDS data link. As the on-chip memory of the front-
 2919 end FPGA is too small to hold the complete configu-
 2920 ration data for all connected sensors, it has to be
 2921 delivered just in time from the switching boards (see
 2922 section 17.4). Bandwidth is not an issue (a 6 Gbit/s
 2923 optical downlink is available), but the data stream
 2924 has to be synchronised such that no buffering on the
 2925 front-end is required, which necessitates a careful
 2926 interplay between the software driving the data into
 2927 the switching boards, the switching board firmware and the front-

end firmware. An overview of the data flow for the pixel
 configuration is shown in Figure 130.

For the timing detector MuTRIG ASICs, the same
 configuration path is used - the configuration data is
 however much more compact than in the pixel case and
 can be stored in the MIDAS ODB.

16.3. Interlock System

As 10 kW is dissipated in a small volume, contin-
 uously carried away by water and helium cooling sys-
 tems, an additional interlock system fully independ-
 ent from the MIDAS DAQ controls the critical param-
 eters of the experiment. This system returns the exper-
 iment to a safe state in case of an emergency or crit-
 ical failure, and prevents unsafe transitions between
 operating modes requested by the user. For example,
 the detector power can only be turned on when the
 helium and water cooling systems are fully functional.
 The central controller of the interlock system is a
 commercial pro-

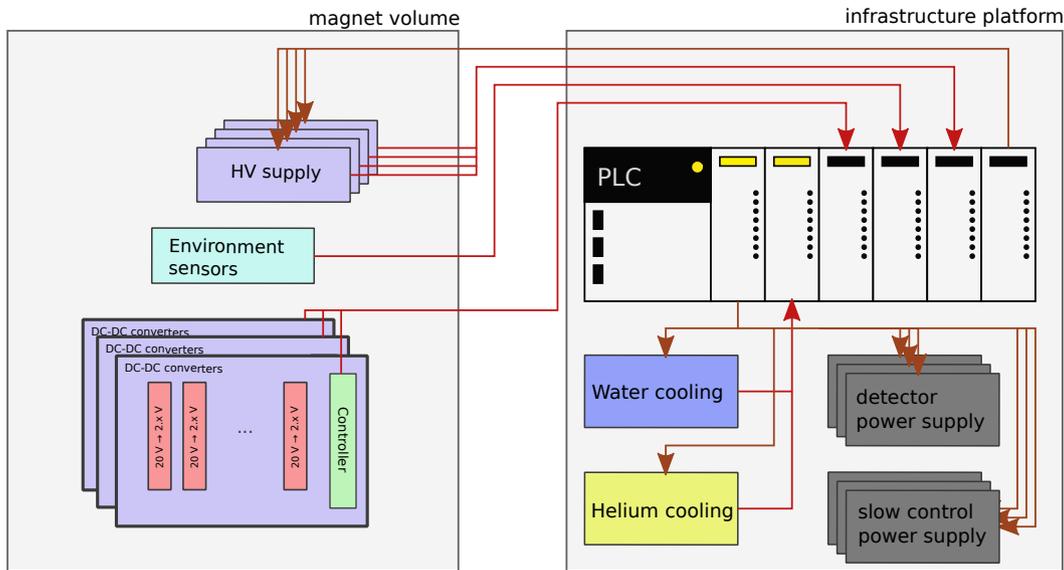


Figure 131: Layout of the Mu3e interlock system, directly interconnecting the safety critical sub-systems of the experiment. The PLC is a Siemens SIMATIC S7-series controller.

2946 grammable Logic Controller (PLC) with fail-safe IO.
 2947 Figure 131 shows a conceptual wiring diagram of this
 2948 system. It is located on one of the infrastructure plat-
 2949 forms, and connected to the subsystems via closed-loop
 2950 electrical circuits, which are decoupled from the detec-
 2951 tor and other slow control power circuits. This system
 2952 is designed as an additional safeguard; during normal
 2953 operation all transitions are instigated by the MIDAS
 2954 DAQ system.

2955 17. Data Acquisition

2956 The Mu3e data acquisition (DAQ) system works
 2957 without a hardware trigger on a push basis, i.e. the de-
 2958 tector elements continuously send zero-suppressed hit
 2959 information. The DAQ consists of three layers, namely
 2960 front-end FPGAs, switching boards and the filter farm.
 2961 The topology of interconnects is such that every farm
 2962 PC receives the complete detector information for a cer-
 2963 tain time slice. See Figure 132 for an overview of the
 2964 readout scheme.

2965 Hits in all subsystems are timestamped and the
 2966 front-ends ensure that time-ordered information is for-
 2967 warded to the rest of the readout system. At the in-
 2968 put to the farm PCs, data from several timestamps is
 2969 merged to form overlapping reconstruction frames, as
 2970 shown in Figure 133. In this scheme, the latency of in-
 2971 dividual detector elements is not critical, as long as the
 2972 latency differences do not exceed the buffering capacity
 2973 at each step.

2974 17.1. Bandwidth Requirements

2975 The bandwidth requirements of the data acquisi-
 2976 tion are largely determined by the expected detector
 2977 occupancy, as all the Mu3e subdetectors produce zero-
 2978 suppressed output.

Occupancies have been estimated with the full simu-
 2979 lation for a rate of muons stopping on target of $1 \cdot 10^8$ Hz,
 2980 and pessimistically estimating the beam-related back-
 2981 ground by assuming another $0.9 \cdot 10^8$ Hz of muons stop-
 2982 ping along the last metre of beam line.
 2983

2984 17.1.1. Front-end bandwidth requirements

2985 The pixel sensors contain electronics for hit detec-
 2986 tion, as well as time and address encoding. The hits
 2987 are then serialised and sent to the front-end FPGA
 2988 board via a 1250 Mbit/s low voltage differential sig-
 2989 nalling (LVDS) link.

2990 The sensors at the centre of the innermost layer have
 2991 the highest occupancy, about 1.3 MHz/cm^2 or 5.2 MHz
 2992 per sensor. The protocol implemented in the MUPIX 8
 2993 prototype and all subsequent chips allows a maximum
 2994 of 74% of the available time slots for sending hit in-
 2995 formation. With 8 bit/10 bit encoding, this leads to a
 2996 maximum hit bandwidth of 740 Mbit/s, equivalent to
 2997 $23 \cdot 10^6$ 32 bit hits per link per second. This gives a
 2998 safety factor of four even for the busiest sensors, which
 2999 will use three parallel links. The total bandwidth re-
 3000 quirements for the phase I pixel detector up to the
 3001 front-end boards are shown in Table 15.

3002 The average occupancy determines the bandwidth
 3003 requirements, but fluctuations are also modelled in the
 3004 simulation in order to optimise the system design. In
 3005 particular, online buffer sizes must be large enough to
 3006 allow the latency required to absorb the highest ex-
 3007 pected peaks in hit rate.

3008 The MUTRIG ASIC foreseen for both timing de-
 3009 tectors will also output zero-suppressed hit data with
 3010 timestamps over a 1250 Mbit/s LVDS link. The av-
 3011 erage hit rate per channel of the fibre detector is esti-
 3012 mated from the simulation as 620 kHz, with a hit size of

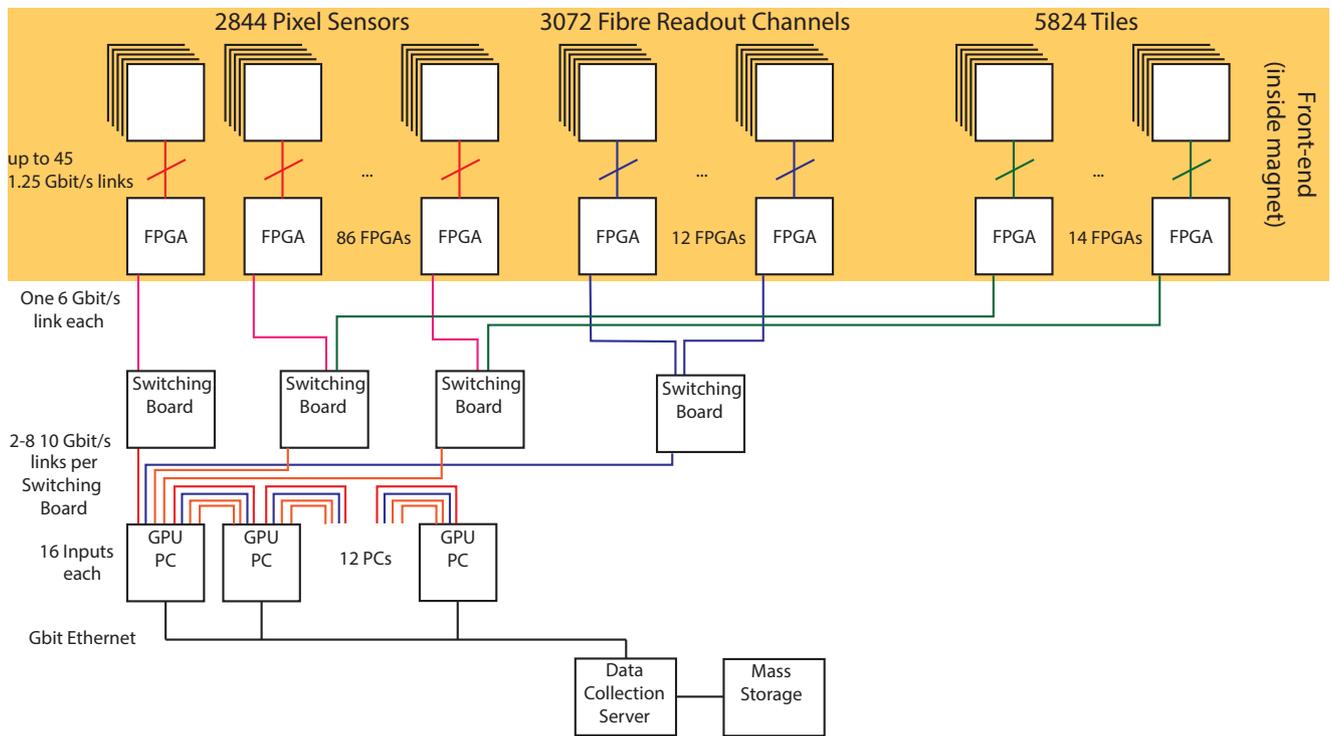


Figure 132: Overall Mu3e readout scheme.

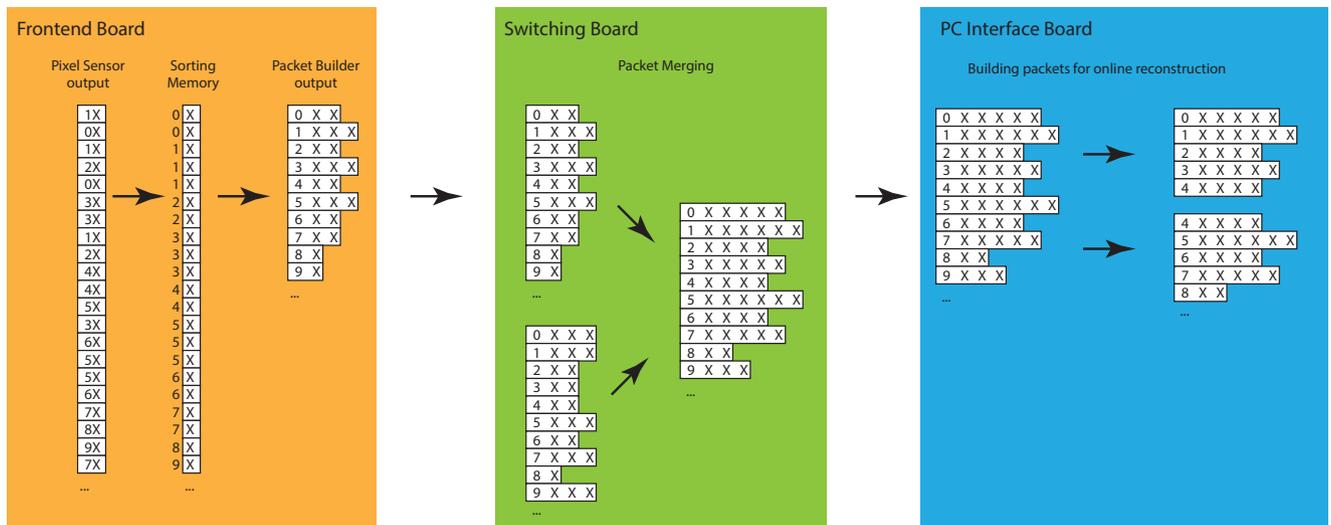


Figure 133: Schematic flow of pixel time information through the Mu3e readout system. Numbers stand for hit timestamps, X stands for the remaining hit information (address, charge).

3013 28 bits [41]. With 32 channels per ASIC, this uses about
 3014 700 Mbit/s of the link bandwidth, limiting the accept-
 3015 able dark count rate to roughly 300 kHz per channel.

3016 The tile detector, operating at a relatively high thresh-
 3017 old and an expected total hit rate of roughly 180 MHz,
 3018 will contribute very little to the overall bandwidth re-
 3019 quirements and is very far from saturating single chan-
 3020 nel limits.

17.1.2. Optical link bandwidth requirements

3021 The hits are collected on a front-end FPGA and
 3022 transmitted off the detector using optical links. The
 3023 corresponding bandwidth requirements are listed in Ta-
 3024 ble 16. For the fibre detector, clustering is assumed to
 3025 take place on the front-end FPGA, although unclus-
 3026 tered data could be sent out using twice the number of
 3027 front-end boards with two optical links each.
 3028

3029 Four switching boards will collect the data from the
 3030 front-ends, one for the central pixel detector, one each
 3031 for the up- and downstream recurl stations (pixels and

	Sensor Chips	Max Hits /Chip/s 10^6	Average Hits /Layer/s 10^6	Chip→FPGA link capacity Mbit/s needed/available	Chip→FPGA total in Layer Gbit/s needed/available	Front-end FPGAs
Layer 1	48	5.2	194	281/3750	10.5/180	} 8
Layer 2	60	5.2	195	281/3750	10.5/225	
Layer 3	408	1.2	266	65/1250	14.4/510	
Layer 4	504	1.2	248	65/1250	13.4/630	
Recurl IU	408	0.15	41	8.1/1250	2.2/510	12
Recurl OU	504	0.14	44	7.6/1250	2.4/630	14
Recurl ID	408	0.11	28	5.9/1250	1.5/510	12
Recurl OD	504	0.10	29	5.4/1250	1.6/630	14
Total	2844		1045		56.4/3825	86

Table 15

Pixel front-end readout requirements (10^8 muon stops/s). The recurl station layers are labelled by inner/outer (I/O) and up- and downstream (U/D). The rates include protocol overhead and 8 bit/10 bit encoding, and assume 32 bit hit size.

Subdetector	Maximum rate/FPGA MHz	Hit size Bits	Bandwidth needed Gbit/s	FPGAs
Pixels	58	48	4.6	86
Fibres	28	48	2.3	12
Tiles	15	48	1.2	14

Table 16

FPGA bandwidth requirements. For the fibre detector, clustering in the front-end FPGA is performed. For the bandwidth, 75 % protocol efficiency and 8 bit/10 bit encoding are assumed. The pixel hit size assumes, conservatively, that the full hit and address information including time is transmitted for each hit. This can be reduced by time-grouping hits and encoding parts of the address in the link.

	Rate MHz	Bandwidth Gbit/s
Central Pixels	905	58
Upstream Recurl	85 + 106	12
Downstream Recurl	58 + 73	8.4
Fibres	337	21.5
Total	1564	100

Table 17

Switching board bandwidth requirements. 48 bit hit size and 75 % protocol efficiency are assumed.

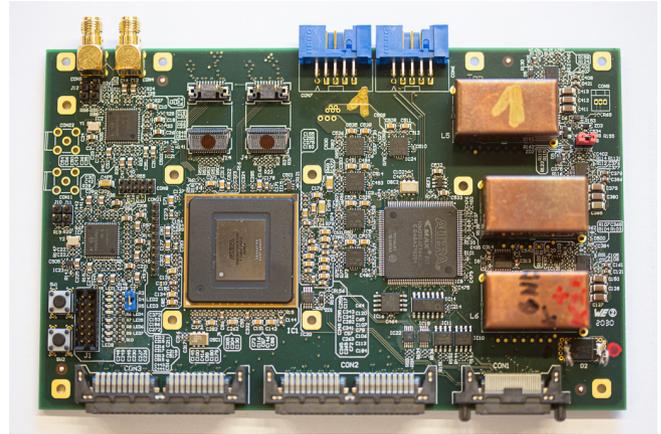


Figure 134: Prototype front-end board based on an Intel Arria V FPGA. The FPGA in the centre left is surrounded by connectors to the crate backplane (leading to the detector ASICs) at the bottom, a Intel MAX10 CPLD for configuration and monitoring in the centre right, clocking circuitry at the the left, two connectors for Firefly optical transceivers on the top left, blue JTAG connectors for programming on top and the DC/DC converter circuitry on the right. The copper boxes contain and shield the air coils.

3032 tiles) and one for the fibre detector. The corresponding
 3033 bandwidths passing through these boards are listed in
 3034 Table 17.

17.2. Front-end FPGA Boards

3035 The front-end boards have to collect the data sent
 3036 from either the MUXIP or the MUTRIG chip, sort
 3037 and package it, and then forward it to the switching
 3038 boards on a fast optical link. In the case of the fibre
 3039 MUTRIG data, preliminary clustering will be ap-
 3040 plied in order to reduce the data rate taken up by dark
 3041 counts. In addition, the boards have to provide the
 3042

sensors with control signals and monitor the environment. The space constraints inside the magnet necessitate small, highly integrated boards incorporating FPGAs and optical modules with a small footprint and limited power consumption. A working prototype can be seen in Figure 134.

The boards feature an Intel Arria V FPGA (5AGXBA7E) for data processing as well as a flash-based Intel MAX10 FPGA (10M25SAE144C8G) for configuration and monitoring. For the optical data transmission we use Firefly transceivers by Samtec (ECUO-B04-14), each of which provides four transmitting and four receiving links at up to 14 Gbit/s in a very small footprint (20.3 mm × 11.25 mm) and a power consumption of roughly 1 W. A single link per board is sufficient for the bandwidth requirements of phase I; we nevertheless foresee the option to install two Fireflies and thus obtain 8 outgoing links. The incoming links are used for the clock and reset distribution (see chapter 15) as well as the slow control and pixel configuration. Clocks received by the Fireflies are conditioned by two Si5345 jitter attenuator/ clock multiplier chips and forwarded to the FPGAs as well as the detector ASICs. The front-end firmware receives detector data, performs time-sorting and multiplexes the data from all connected ASICs to an optical link. Synchronisation and run transitions are controlled by the reset link, as described in section 17.6.2.

The boards are connected to a backplane, which forwards the detector signals and provides control and monitoring signals via a separately powered crate controller. The boards are cooled by a custom-made aluminium cooling plate connected to the water-cooled frame of the crate via a heat pipe.

17.2.1. Slow-control and configuration integration

For slow control and pixel configuration data, two paths are foreseen. Firstly, surplus bandwidth on the optical links to and from the switching board can be used, which is especially useful for large volume data such as pixel tune values. Secondly, a separate differential line for use of the MSCB protocol (see chapter 16) is foreseen for monitoring the status of optical links, switching power, etc.. The interface to MSCB and the slow control-related tasks on the FPGA will be implemented in a NIOS II soft processor core [56] on the FPGA [57].

The FPGA firmware can be updated by writing a Serial Peripheral Interface (SPI) flash memory from either the optical slow control link or the MSCB connection via the MAX10 FPGA. On power-up or a reconfiguration command, the MAX10 then reprograms the Arria V FPGA.

17.3. Read-out Links

Electrical links are used between the detector ASICs and the front-end FPGAs, all other data links are optical. The data links are complemented by a (smaller) number of slow control links in the opposite direction [58].

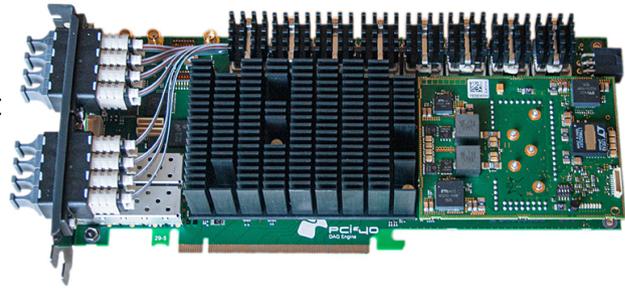


Figure 135: PCIe40 board as developed for the LHCb and ALICE upgrades [61, 62] and employed as switching board in Mu3e. The large Arria 10 FPGA with two PCIe Gen3 8 lane interfaces is complemented by 48 fast optical receivers and 48 fast optical transmitters.

The data from the MUPIX and MUTRIG chips will be transmitted to the front-end FPGAs via LVDS links at 1250 Mbit/s. The link is physically implemented as a matched differential pair of aluminium traces on the sensor HDI, followed by a micro twisted-pair cable connected to the detector side of the backplane, see section 7.1.2.

There are two types of optical high speed data links. The first one goes from the front-end FPGAs to the switching boards, the second from the switching boards to the FPGA PCIe boards in the event filter farm PCs. The optical links from the front-end FPGAs to the switching boards have a bandwidth of 6 Gbit/s, which fits well with the FPGA specifications. Each FPGA has nine fast transceiver blocks, which connect to the Firefly optical assemblies. The laser has a wavelength of 850 nm and the optical fibre is of 50/125 multi-mode OM3 type, since this is a standard both in industry and in particle physics detector readout.

The links from the switching boards to the filter farm are implemented as 10 Gbit/s high speed links. The PCIe FPGA board is fitted with four quad small form-factor pluggable (QSFP+) optical modules.

All the links have been tested using the development hardware and were found to have bit error rates low enough for stable and consistent running of the experiment [59, 60]; typically, no errors were found in a few days of running, leading to upper limits on the bit error rate of $1 \cdot 10^{-14}$ down to $1 \cdot 10^{-16}$.

17.4. Switching Boards

The main task of the switching boards is to act as switches between the front-end FPGAs on the detector and the online reconstruction farm, thus allowing each farm PC to see data from the complete detector. The board design and choice of FPGAs is dominated by the number of fast links required.



Figure 136: The DE5a NET board built by Terasic Inc. and used as a receiving board in the filter farm PCs. The Arria 10 FPGA with a PCIe Gen3 8 lane interface is complemented by a 16 duplex fast optical links and several GB of DDR4 memory.

We use four *PCIe40* boards (see Figure 135) developed for the LHCb and ALICE upgrades at the LHC [61, 62, 63]. These boards provide up to 48 full duplex optical links at up to 10 Gbit/s, plus two eight lane PCIe 3.0 interfaces bundled to a sixteen lane interface by a switch. The FPGA is an Altera Arria 10. The PCs hosting the boards are used to store and transmit the extensive pixel configuration and tuning data as well as the timing detector ASIC configuration via PCI express, and link the boards to the experiment control and monitoring system via standard Ethernet.

The firmware for the switching board has to receive several data streams in parallel, merge them synchronously and then forward them to the event filter. Additional firmware is needed in the case of the fibre tracker, where hits from both ends of the fibre have to be matched in order to suppress dark counts.

17.5. Event Filter Interface

The filter farm PCs are equipped with FPGA boards in PCIe slots and optical receivers. The boards are commercial DE5a NET boards (see Figure 136) built by Terasic Inc. They are equipped with four QSFP+ quad optical transmitters/receivers, two laptop-compatible DDR3/DDR4 memory interfaces and a large Altera Arria 10 FPGA with an 8 lane PCIe 3.0 interface. This FPGA performs the event building and buffering, and also allows simple clustering, sorting and selection algorithms to be run. The event data is then transferred via Direct Memory Access (DMA) over the PCIe bus²⁶ to the main memory of the filter farm PC and subsequently copied to the memory of a GPU, where the fitting and vertex selection algorithms are run. The GPU then posts IDs of selected events to the main memory of the PC, which triggers a transfer of the respective data from the FPGA buffer memory via the PC main memory and Ethernet to the central DAQ computer

²⁶Note that PCIe is actually not a bus protocol, but offers switched point-to-point connections. The *bus* designation is due to the software-side backwards compatibility to the original PCI bus interface.

running the MIDAS software. At that computer, the data streams from the farm PCs are combined into a single data stream, combined with various slow control data, compressed and stored. The maximum data rate over an eight-lane PCIe 3.0 bus is 7.88 Gbyte/s of which we are able to use 4.8 Gbyte/s for user data, amply sufficient for phase I.

The GPU boards will be obtained commercially as late as possible in order to profit from the ongoing rapid development and sinking prices. Current high-end GPUs already have enough floating point capability for high rate running. Newer boards are, however, expected to offer higher memory bandwidth and better caching. For example, between the GTX 680 and the GTX 980 GeForce GPUs, both the compute power and the copy speed increased by 30 % [64, 65]. The GTX 1080Ti cards we obtained in 2017 were sufficient to run the full Phase I selection load on 12 nodes [66].

The farm PCs are hosted in individual rack-mounted tower casings, ensuring enough space for the FPGA board, the high-end GPU and a custom clock receiver board [67] whilst allowing for air cooling. Each tower consumes around 0.7 kW, so active cooling of the racks and the counting house is necessary.

17.6. Run Control, Data Collection and Storage

17.6.1. The MIDAS System

The filter farm outputs selected events at a data rate of the order of 50-100 MBytes/s in total. This data rate is low enough to be collected by a single PC connected to the filter farm by common Gbit Ethernet and written to local disks. Then the data is then transferred to the central PSI computing centre, where it is stored and analyzed. For the central DAQ, the well-established MIDAS (Maximum Integrated Data Acquisition System) [68] software package is used. This software is currently used in several major experiments such as the T2K ND280 detector in Japan [69], ALPHA at CERN and the MEG experiment at PSI [70]. It can easily handle the required data rate, and contains all necessary tools such as event building, a slow control system including a history database and an alarm system. A web interface allows the control and monitoring of the experiment through the Internet. The farm PCs use MIDAS library calls to ship the data to the central DAQ PC. The framework also offers facilities to send configuration parameters from a central database (the “Online DataBase” or ODB) to all connected farm PCs and to coordinate common starts and stops of acquisition (run control).

For the purpose of monitoring and data quality control of the experiment, the MIDAS system offers the capability to tap into the data stream to connect analysis and graphical display programs.

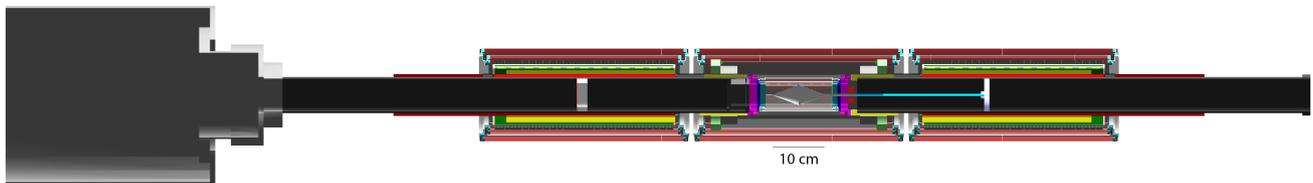


Figure 137: Side view of the simulated phase I detector cut along the beam axis.

17.6.2. Run start/stop synchronisation

In traditional DAQ systems, starting and stopping is controlled by enabling and disabling trigger signals. In a streaming system such as in Mu3e this is not an option, and great care has to be taken to synchronise data across the complete detector at run start and ensure that the frame numbers in all subsystems are in agreement.

To this end, a global reset signal is distributed together with the global clock. At the front-end, the reset signal is forwarded to the pixel sensors and there sets the timestamp counters to zero as long as it is on (note that the pixel sensors cannot be inactivated, so even during a reset they will still collect, process and send hits, however all with timestamp zero). At the start of a run, the reset signal is released synchronously for all sensors, which then start counting timestamps. The front-end firmware will ignore all hits with timestamp zero at the beginning of the run and start sending packets into the switching network as soon as non-zero timestamps arrive. All subsequent stages in the network then synchronise on the first packet and from then on stay in sync using consistent packet numbering. A similar synchronization mechanism is implemented for the MuTRIG ASICs.

At the end of the run, the global reset goes high and the front-end continues forwarding packets until timestamp zero is detected.

18. Simulation

This chapter describes the Geant4 [71, 72] based simulation used to study and optimise the detector design, to develop the reconstruction code and to estimate signal efficiency and background rates.

The Mu3e software stack consists of the simulation described here, which includes generators for many different muon decays, the track reconstruction described in the following chapter, a vertex fit program and a range of analysis codes. Besides Geant4, root [73], which is used for storage, histogramming and related analysis tasks, is the other major external dependency. Core code is written in C++, python is used for some of the analysis and plotting code.

18.1. Detector Geometry

The simulated detector geometry closely follows the planned detector geometry described in earlier chap-

ters. The simulated volume extends for three metres in all directions from the target centre. The magnet metal and the surrounding volume is only used in the cosmic ray simulation. Figures 137 and 138 show the simulated detector geometry.

18.1.1. Beam Delivery

In the detector simulation, the beam starts 1 m in front of the target inside the beam pipe. Beam particles are generated with a profile and momentum spectrum taken from the beam simulation at the same point. The beam passes a 600 μm Mylar moderator followed by thick lead collimator removing particles undergoing large angle scattering in the moderator. It then exits the beam vacuum through a 35 μm vacuum window, the holding structure of which serves as the final collimator.

18.1.2. Target

The target is simulated as a hollow Mylar double cone supported from the downstream side by a thin carbon fibre tube, see also chapter 6.

18.1.3. Pixel Detector

The simulated geometry of the pixel detector includes the sensor, the flexprint (with an average trace density assumed and represented as thinner metal layers) and the polyimide support structure. The plastic end-pieces and support wheels are also simulated in detail, including flex prints, interposers and screws.

18.1.4. Scintillating Fibres

The fibre ribbon simulation implements fibre shape, cladding thickness, staggering as well as optional fibre coatings and glue. The fibres are matched to SiPM arrays at both ends. Parameters of the geometry can be easily changed to study different options.

The baseline setting consists of 12 ribbons in 3 layers. Each layer consists of 128 round 250 μm thick fibres read out by SiPM arrays with 250 μm column width.

18.1.5. Tile Detector

In the simulation, the tile Detector consists of the scintillating tiles, SiPMs, two layers of PCBs hosting the SiPMs and the readout chips, respectively, as well as the support structure.

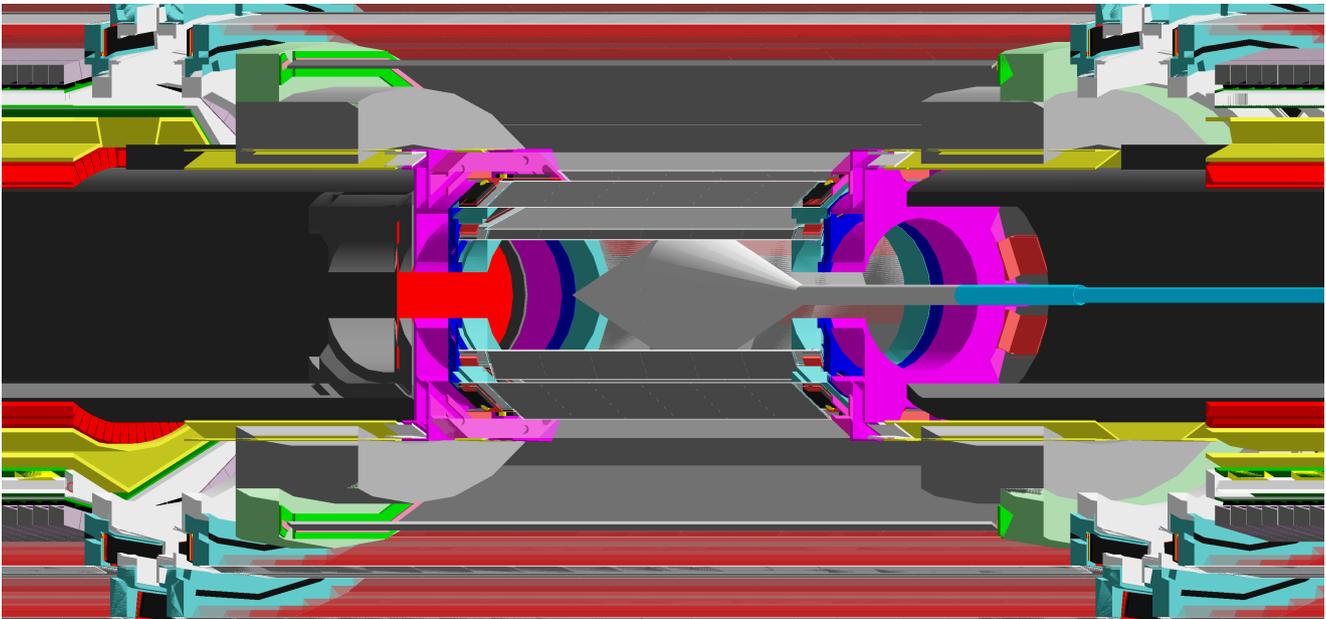


Figure 138: Perspective view of the central part of the simulated phase I detector cut open at $x = -19.0$ mm.

18.2. Magnetic Field

The magnetic field in the simulation is taken from an azimuthally symmetric field map with 10 mm step size calculated by the magnet manufacturer. Linear interpolation is used between the field map grid points. It will be replaced by a measured map as soon as this becomes available.

18.3. Physics Processes

18.3.1. Multiple Coulomb Scattering

Multiple Coulomb scattering is the main limiting factor for the resolution of the experiment; an accurate simulation is thus crucial. Per default, we use the Urban model [74] as implemented and recently improved [75] in Geant4. Alternative models are also implemented, including one derived from the results of a dedicated study of multiple Coulomb scattering in thin silicon at the DESY electron test beam [76]. This however still needs to be validated at the low momenta expected in Mu3e.

18.3.2. Muon Decays

Geant4 implements the Michel decay including polarization of both the muon and the positron based on Scheck and Fischer [77, 78]. The radiative decay of the muon in Geant4 was implemented by the TWIST collaboration [79] based on Fronsdal et al. [80]. This code has been adapted for the simulation of the Mu3e experiment using the differential branching fraction provided by Kuno and Okada [3].

A unified description of radiative corrections for photons below a soft cut-off and photons that are tracked within Geant4 above a cut-off based on calculations by Fael, Mercolli and Passera [10] has been implemented.

The radiative decay with internal conversion is simulated using the matrix element of Signer et al. [7], with the option of using the NLO version [7, 8] when the accuracy is required.

Signal The signal kinematics are highly model-dependent see chapter 1. If not stated otherwise, we have used three particle phase space distributions in the simulation, following the practice of SINDRUM and earlier experiments. We have also implemented the general matrix element by Kuno et al. [3] in order to study the kinematics of different decay dynamics.

Special Decays In order to study accidental background whilst factoring out timing and vertex suppression, the simulation code allows for more than one muon to decay at a single vertex. This is beneficial for studying the overlap of an internal conversion and a Michel decay.

Cosmic Muons As the detector alignment will rely in part on the high momentum tracks of cosmic ray muons, we have implemented a cosmic muon generator based on the spectrum and angle parametrisation of Biallass and Hebekker [81].

18.4. Time Structure and Truth Information

The Mu3e experiment operates with a quasi continuous beam, which has necessitated adaptations of the Geant4 package in order to take into account particles crossing boundaries of reconstruction frames. For every interaction with active detector material, both the particle of origin and the sequence of interactions is saved, we thus have the full simulation truth available at every level of reconstruction and analysis.

18.5. Detector Response

18.5.1. Pixel Detector Response

The response of the pixel detector can be simulated by either setting a threshold on the charge deposited or by defining a single hit efficiency, which is then applied by randomly discarding hits. Noise is simulated by randomly creating extra hits at an adjustable rate.

The simulation does include effects of charge sharing between pixels. δ -electrons are simulated if they have a range above $50\ \mu\text{m}$, the associated (large) clusters should thus be correctly simulated. The response simulation is constantly adapted to the measured properties of the pixel sensors.

Pixel Readout Simulation The readout of the pixel detector is not strictly in order of timestamp (see chapter 8) and very large clusters of hits can lead to overflows in the sorting algorithm on the front-end FPGA (see section 17.2). These effects are simulated by treating each column as a queue, into which hits are pushed at creation. A fixed number of hits is then removed from these column queues for every time slot. Hits are time-sorted in a separate programme and those that are too far out-of-time are dropped; alternatively we can run a bit-accurate simulation of the front-end board firmware. We do currently not simulate the dead-time caused by hits stored in the pixel cell.

18.5.2. Fibre Detector Response

In a first step the response of the scintillating fibres to an incident particle is simulated. Since simulating single photon propagation inside fibres is not feasible in the main simulation, the response of the scintillating fibres is parametrised. The number of arriving photons at both fibre ends can either be parametrised in deposited energy (E_{dep}) and hit position or simply generated according to measured efficiencies.

In a second step the SiPM response to the arriving photons is simulated and the distribution of photons into the different SiPM cells is modelled. The main parameter for this process is the photon distribution at the fibre ends and propagation in the epoxy layers before the SiPM active layer as well as optical cross-talk. The SiPM response depends on an adjustable photon detection efficiency (PDE) and is mixed with a constantly present dark rate and its own pixel to pixel cross-talk. The time distribution of the detected events bases on the measured time resolution of fibre ribbons and photon time of flight in the fibres. In a last step pile-up events are merged.

18.5.3. Tile Detector Response

The tile detector will record the timestamps of the scintillation signals, as well as the energy deposition in the tiles, which is proportional to the number of scintillation photons. In the simulation, the scintillation process and photon propagation is not simulated, in order to maintain a reasonable computation time. In-

stead, the response characteristics of the tile, including the readout electronics, is parametrised, using the true timestamp and energy deposition of a hit as an input. The response is described by the following parameters: time resolution, energy resolution, jitter of the readout electronics, channel dead-time and energy threshold.

In order for a signal in the tiles to be detected by the readout electronics, a minimum energy deposition is required. This corresponds to the energy threshold of the MuTRiG chip, which is assumed to be roughly $E_{thresh} = 0.1\ \text{MeV}$. Due to the linearised ToT method implemented in the MuTRiG chip, the digitised energy information is approximately proportional to the energy deposition in the tile. The energy deposition of consecutive hits (pile-up events) which occur within the dead-time of the channel is assigned to the original hit. This reflects the behaviour of the MuTRiG chip. The channel dead-time is determined by two parameters: the intrinsic dead-time of the MuTRiG TDC and the dead-time related to the ToT of the analogue input signal. The time resolution is parametrised by the intrinsic jitter of the MuTRiG chip and the energy dependent resolution of the tile.

19. Reconstruction

The reconstruction algorithm has to efficiently identify the tracks of particles from muon decays, while dealing effectively with the combinatorial background to keep the rate of incorrectly reconstructed tracks to an acceptable level. The main challenges are the high event rate and resulting occupancy, and the curvature of trajectories of low momentum particles in the 1 T magnetic field. Particle trajectories can make several turns in the detector, and hit combinations can span distances of more than half a meter with hits on opposite sides of the detector. This is of particular importance for the determination of the direction of travel and therefore the charge of the particle, as fully reconstructing tracks is critical in correctly applying the information from the timing systems.

As the detector readout is triggerless, all muon decays have to be fully reconstructed in the filter farm, setting high demands on the speed of the online track reconstruction algorithm.

Multiple Coulomb scattering (MS) in the detector layers is the dominant uncertainty. The track finding and initial fitting is thus built around a fast three-dimensional MS fit, which is based on fitting the multiple scattering angles at the middle hit position in a hit triplet combination (see [82] for a detailed description). In the most basic implementation of the fit, spatial uncertainties of the hit positions are ignored. This is a good approximation in the case of Mu3e, as the pixel resolution uncertainty ($80/\sqrt{12} \approx 25\ \mu\text{m}$) is much smaller than that from multiple scattering (typically several hundred μm).

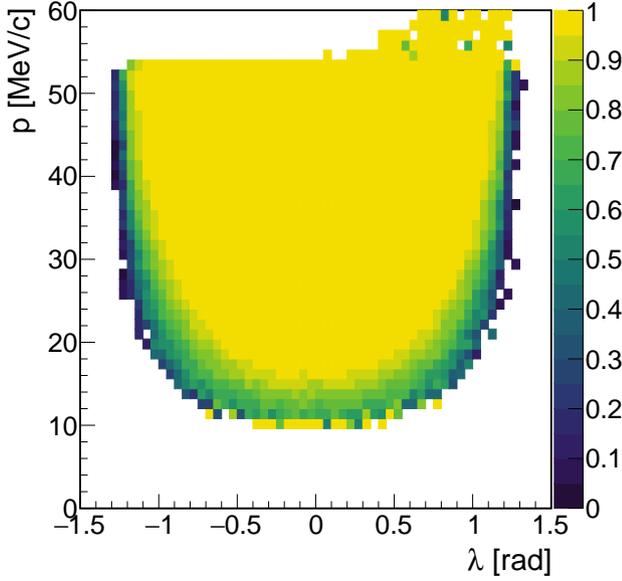


Figure 139: Ratio of reconstructed short tracks to generated particles producing a hit in each of the four detector layers as a function of momentum p and angle λ . The entries at high momentum in the forward direction are from decays in flight.

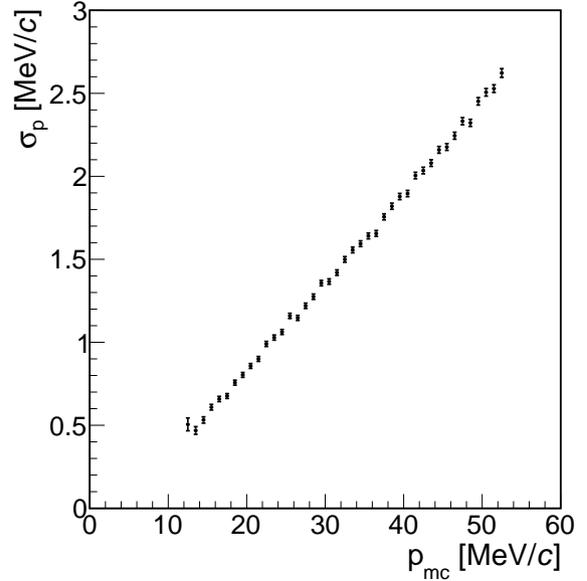


Figure 140: Momentum resolution σ_p as a function of the generated momentum p_{mc} of short tracks.

3484 In order to achieve the best possible resolution, a
 3485 general broken line (GBL) fit [83, 84] can be used. This
 3486 technique determines hit positions and scattering angles
 3487 simultaneously and also incorporates energy loss
 3488 in the detector material, but requires knowledge of the
 3489 assignments of hits to tracks from a preceding linking
 3490 step as well as an approximate track trajectory. There-
 3491 fore, it can only be used as a final step. Currently a
 3492 GBL fit is used for detector alignment (see chapter 21),
 3493 and it will be used in offline analysis.

3494 The track finding and fitting studies presented in
 3495 the following are all based on a fast MS fit that also
 3496 implements energy-loss corrections and takes into ac-
 3497 count hit position uncertainties. Events are generated
 3498 with the full Geant4 simulation (see chapter 18). The
 3499 beam intensity is set such that $1 \cdot 10^8$ muons decay in
 3500 the target region per second, corresponding to an op-
 3501 timistic estimate for the rate achievable at $\pi E5$. In
 3502 these studies the track reconstruction is performed on
 3503 50 ns non-overlapping frames. Studies of the tracking
 3504 acceptance and efficiency are performed on a sample
 3505 without simulated signal decays.

3506 19.1. Track finding

3507 In the first step, triplets of hits in the first three
 3508 layers consistent with tracks originating from the tar-
 3509 get are identified. These triplets are fit with the fast
 3510 MS fit and if the fit χ^2 is sufficiently good, they are ex-
 3511 trapolated to the fourth layer, where the presence of an
 3512 additional hit compatible with the triplet is required.
 3513 Again a fast MS fit is performed and a χ^2 cut applied.

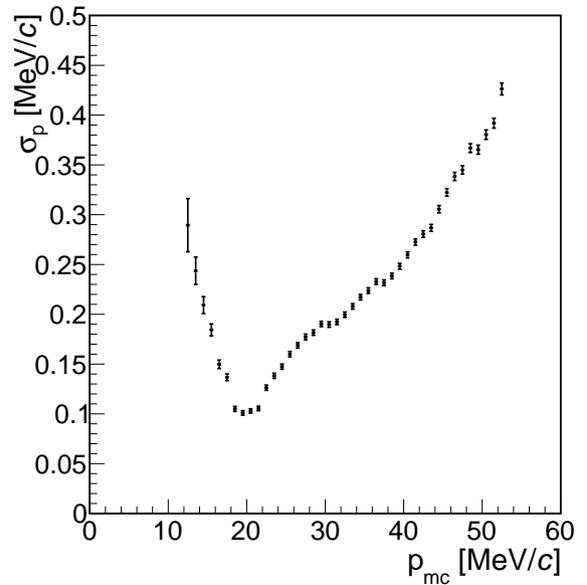


Figure 141: Momentum resolution σ_p as a function of the generated momentum p_{mc} of 6-hit long tracks. The momentum resolution has a minimum for tracks that traverse exactly half a circle outside the outermost pixel layer.

3514 The resulting short tracks, with four hits each, are
 3515 the input for the vertex fit in the online reconstruction;
 3516 see Figure 139 for the reconstruction efficiency and Fig-
 3517 ure 140 for the momentum resolution of 4-hit tracks.

3518 For the full offline reconstruction, the short tracks
 3519 are extended to long tracks with 6 hits (forward and
 3520 backward going tracks) or 8 hits (tracks close to per-

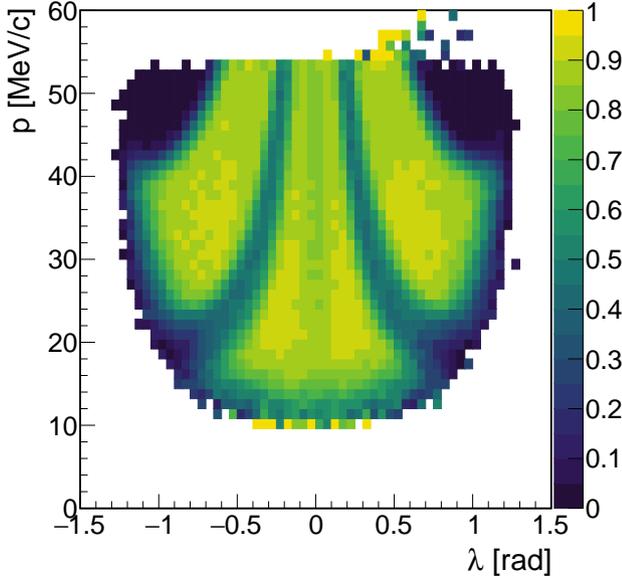


Figure 142: Number of reconstructed long tracks relative to the number of short tracks as a function of momentum p and inclination angle λ . The entries at high momentum in the forward direction are from decays in flight.

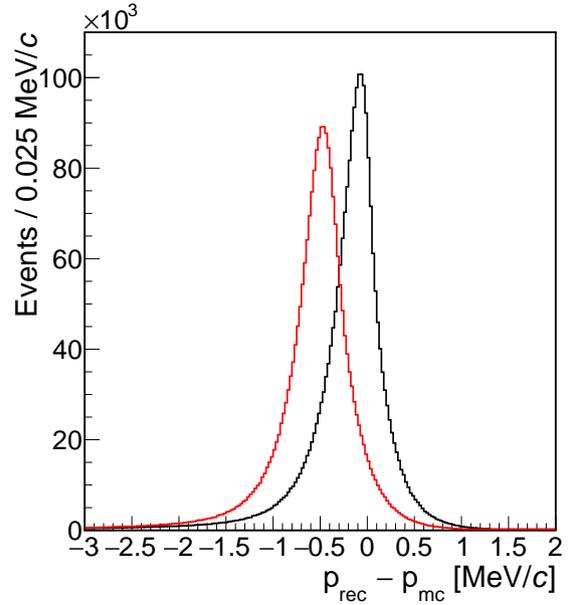


Figure 143: Difference between reconstructed and generated momentum after the first detector layer, for long tracks with (black) and without (red) energy loss correction.

pendicular to the beam, passing the vertex layers repeatedly) incorporating the recurling parts of the track. These long tracks have a much larger lever arm for momentum measurement and thus provide a much enhanced momentum precision, as shown in Figure 141. With the phase I detector setup, there is however a limited acceptance to see the recurling part of the track for low polar angles and also in the gaps between the central part and the recurl stations, as shown in Figure 142.

Additional algorithms are designed to remove incorrectly reconstructed tracks. One algorithm is performed after the reconstruction of short tracks. A graph is constructed where nodes represent tracks and edges correspond to intersections (common hits) between those tracks. A subset of nodes is selected that maximises the number of unconnected nodes (i.e. the maximum number of tracks that do not share hits). A second algorithm is run after the reconstruction of long tracks. Chains of long tracks are constructed where each pair of long tracks shares a short segment. These chains are required to have no intersections, with a maximum length and minimum total χ^2 . In very dense regions with many recurling tracks, machine learning techniques can be used to correctly identify the sequence of track segments [85].

19.2. Energy loss

For long tracks, the momentum resolution becomes comparable with the total energy loss suffered by particles traversing the detector, resulting in an observable

shift in the momentum. The energy loss correction is implemented by adjusting the curvature of each helix according to the sum of the most probable energy losses in each layer passed by the particle up to that point in the helix. Figure 143 shows the momentum resolution for long tracks before and after the implemented energy loss correction.

19.3. Timing Detectors

Reconstructed tracks are extrapolated to the fibre and tile detectors and the closest hits (within a maximum distance) are assigned to the tracks. The timing from fibre hits allows the determination of the direction of rotation (and thus the charge) of recurling particles. Figure 144 shows the time versus distance determined from two linked clusters of fibre hits for all 8-hit tracks, and demonstrates the potential for charge identification by timing.

The tile hits have the best timing resolution, providing an important constraint on the accidental combinatorial background by allowing timing information to be compared for different tracks assigned to a single vertex. The efficiency of the assignment of tile hits to tracks that pass through the tile detector is 98%.

20. Online Event Selection

The full data rate of the detector needs to be greatly reduced before permanent storage – only physically relevant event candidates can be kept. Requiring three tracks coincident in time is not sufficient to reduce the data rate by three to four orders of magnitude. Con-

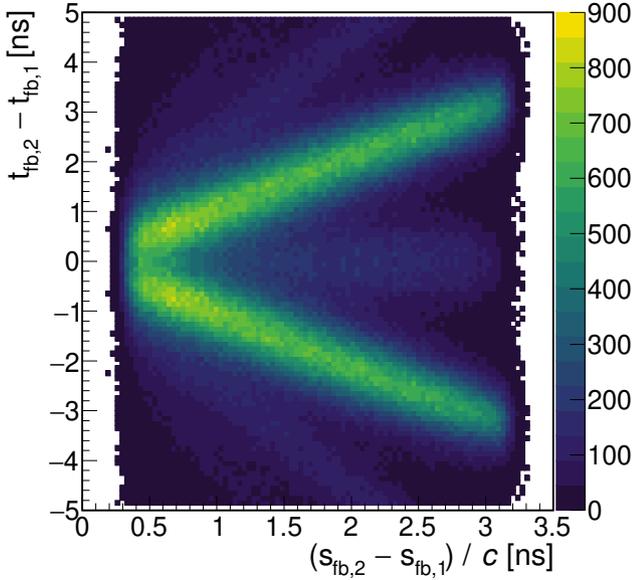


Figure 144: Time difference between fibre clusters assigned to 8-hit long tracks as a function of distance along the trajectory. The upper branch corresponds to the correct charge assignment and direction of rotation, and the lower branch to the wrong charge assignment.

3580 frequently no hardware trigger is employed and instead
 3581 the online filter farm reconstructs all tracks and applies
 3582 a selection algorithm in software. The selection
 3583 requires three tracks coincident in time, and consistent
 3584 with originating at a common vertex and with the expected
 3585 kinematic properties of signal events. The computing power
 3586 required for this is provided by *Graphics Processing Units* (GPUs),
 3587 where we profit from the very high rate of technological advance
 3588 driven by the gaming and deep learning markets.
 3589

3590 A simple version of the fast linear fit based on multiple
 3591 scattering (see chapter 19) is implemented on the GPUs for
 3592 quick track fitting. In addition, events with at least two
 3593 positive and one negative electron tracks are checked for a
 3594 common vertex and signal-like kinematics. This selection is
 3595 applied on a frame by frame basis on individual farm PCs and
 3596 the selected frames are merged into the global data stream,
 3597 see Figure 145 for an overview. The technical implementation
 3598 of the event filter is described in section 17.5.
 3599

3600 For the online reconstruction, only hits from the central
 3601 station of the pixel detector are considered, since matching
 3602 recurling tracks and time information from the tiles and
 3603 fibres is computationally too expensive and also not necessary
 3604 for a first selection.

3605 Combinations of hits from the first three detector layers
 3606 are matched to form triplets. Before the actual fitting
 3607 procedure, a number of simple geometrical selection cuts
 3608 are applied at the FPGA stage in order to reduce the number
 3609 of combinations by a factor of about

50.

3610 The fitting of triplets is non-recursive and linear,
 3611 and hence can be done in parallel for all hit combinations.
 3612 It is therefore an ideal candidate for parallelisation on GPUs.
 3613 With their many computing kernels but small memories, they
 3614 perform well at tasks where many similar computations are
 3615 performed on the same memory content. For a muon rate of
 3616 10^8 Hz and 50 ns time frames, we expect $\mathcal{O}(10)$ hits
 3617 per layer leading to $\mathcal{O}(10^3)$ combinations. With code
 3618 optimised for these conditions, we have achieved $1 \cdot 10^9$
 3619 fits/s on a NVIDIA GTX 980 GPU (released 2014), which
 3620 is sufficient to handle this level of combinations.
 3621

3622 For each triplet passing the χ^2 and radius cuts, the
 3623 track is extrapolated to the fourth detector layer. If at
 3624 least one hit exists within a certain transverse radius and
 3625 distance in z , the hit closest to the extrapolated position
 3626 is used to form a second triplet from hits in layers two,
 3627 three and four and give an improved value for the curvature
 3628 of the track from an updated fit. Finally the charge of the
 3629 particle is derived from the track curvature and all combinations
 3630 of two positive tracks and one negative track are examined
 3631 with respect to a common vertex.
 3632

3633 The vertex position is calculated from the mean of two-
 3634 circle intersections of the tracks in the transverse plane
 3635 (perpendicular to the magnetic field), weighted by the
 3636 uncertainty from multiple scattering in the first layer and
 3637 hit resolution. A χ^2 -like variable is defined using the
 3638 distances of closest approach of each track to the mean
 3639 intersection position and their uncertainties, both in the
 3640 transverse and the $r - z$ plane. Vertices are selected
 3641 based on their proximity to the target and the χ^2 value.
 3642 In addition, cuts on the total kinetic energy and combined
 3643 momentum of the three tracks at the points of closest
 3644 approach are applied. After all cuts, the frame rate is
 3645 reduced by a factor ≈ 200 , which is further reduced by
 3646 the full online reconstruction as described in chapter 19.
 3647

3648 In addition to signal candidate events, cosmic ray
 3649 muon candidates and random frames will be saved for
 3650 calibration, alignment and studies of the selection
 3651 efficiency. The parameters of all reconstructed tracks are
 3652 histogrammed for monitoring as well as for searches
 3653 e.g. for two-body muon decays [86].
 3654

3655 The triplet fit, the propagation to the fourth layer and
 3656 the vertex fit as well as the monitoring have been
 3657 implemented, optimized for performance and tested on
 3658 GTX 1080Ti cards (of 2016/17 vintage). It was shown that
 3659 12 of these cards are sufficient for the phase I load [66].
 3660

21. Detector Alignment

3661 In order for the reconstruction algorithms to work
 3662 optimally, the position and orientation of all active detector
 3663 elements and the stopping target have to be
 3664

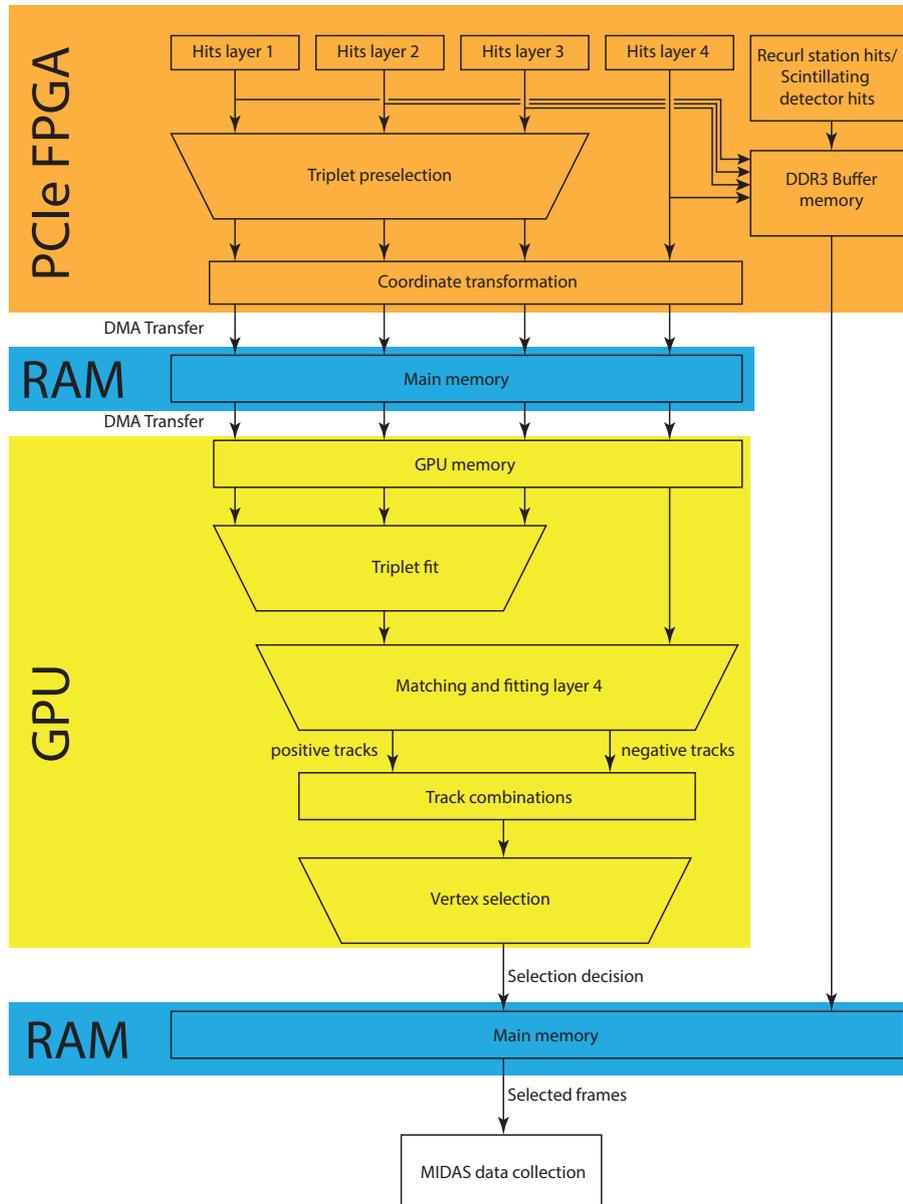


Figure 145: Flow diagram of the online reconstruction software and firmware.

3665 known to good precision. The position of the pixels inside a sensor is given by the tolerances of the manufacturing process, which are much better than the minimal feature size of 180 nm; compared to all other sources of misalignment, this is completely negligible. The task of detector alignment is thus to determine the position, orientation and potentially deformation of all active detector parts (HV-MAPS chips, fibres, tiles).

3673 The first step in ensuring a well-aligned detector is the careful assembly of modules and layers using precision tools, followed by a detailed survey. After detector installation, movements of larger detector parts (e.g. the recurl stations with regards to the central detector) can be followed by a system of alignment mark-

3679 ers observed by digital cameras inside the magnet. The ultimate alignment precision is however only reached with track-based alignment methods, starting with cosmic ray tracks and refining using beam data.

21.1. Effects of Misalignment

3683 We have studied the effects of a misaligned pixel detector on the reconstruction efficiency and tracking resolution using the full detector simulation [87]. For technical reasons the sensors are all in their nominal position for the Geant4 simulation, and the reconstruction is then performed with different sensor positions.

3690 The hierarchical mechanical structure of the pixel detector with stations, modules, ladders and sensors is

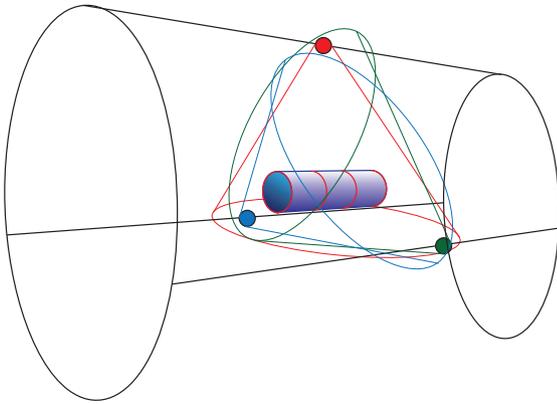


Figure 146: Schematic view of a possible alignment system using three cameras. The detector support cage is shown in black, the blue tube represents the detector stations with the end-rings shown in red. The three cameras and their fields of view are shown in red, green and blue.

3692 expected to be reflected in the misplacements of all detector
 3693 parts after assembly. To reproduce this, the sizes of various
 3694 misalignment modes (i.e. rotations and shifts of all structures,
 3695 and deformations of individual sensors) are estimated and then
 3696 applied in a randomised way. The result is an average absolute
 3697 offset of about $450\ \mu\text{m}$ of single sensor corners²⁷ with
 3698 respect to their nominal position for the estimated misalignment
 3699 after detector construction. This leads to a worsening of the
 3700 reconstruction efficiency; there is however an efficiency plateau
 3701 if the overall error on the corners of the sensors is less than
 3702 $100\ \mu\text{m}$. Far more relaxed criteria apply to global movements
 3703 of detector stations (e.g. recurl stations, vertex layers) with
 3704 regards to each other.

3705 The constraints on the alignment accuracy for achieving optimal
 3706 momentum resolution are much tighter than for the efficiency –
 3707 positions and rotations should be known well enough to achieve
 3708 an error smaller than $50\ \mu\text{m}$ for the sensor edge positions.
 3709
 3710

3711 21.2. Position Monitoring System

3712 The positions of the detector stations relative to each other
 3713 are monitored by a series of cameras mounted to the detector cage.
 3714 They are complemented by light sources (the detector is usually
 3715 operated in the dark) and alignment marks on the end-rings of
 3716 the detector stations. Cameras with a 85° field of view are
 3717 sufficient to view all end rings in the phase I detectors when
 3718 mounted to the detector cage. A system of three cameras (e.g.
 3719 top and $\pm 60^\circ$ from the bottom) also allows tracking the
 3720 relative movements of the cameras, as they can see each other.
 3721 Sub-millimetre resolution requires fairly high resolution
 3722 cameras (2K or 4K) or the use of separate cameras with zoom
 3723 lenses focused on
 3724

²⁷Studying the sensor corners has the advantage of covering shifts as well as rotations of sensors with respect to their nominal position.

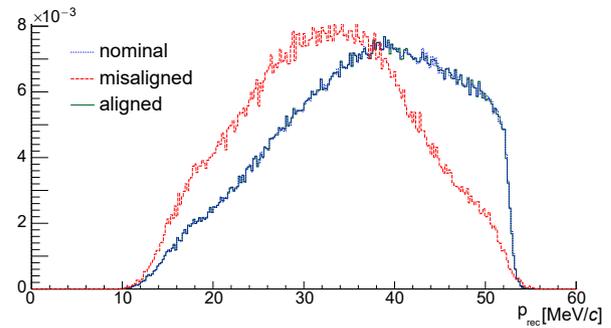


Figure 147: Reconstructed momentum of Michel positrons (using only long tracks) for the nominal detector versus the (estimated) detector after assembly and for the aligned detector.

the station-station transitions. A possible three-camera
 system is shown in Figure 146.

21.3. Track-Based Alignment

The fine alignment of the silicon sensors (as well as the fibres and tiles) will be performed using track-based methods initially developed in the H1 experiment [88] and subsequently successfully applied to a variety of large and very large tracking systems, e.g. CMS at the LHC [83, 89, 90, 91, 92, 93, 94, 95].

The alignment of the complete detector is a large minimisation problem, where, for a very large sample of tracks, the residuals from the measured hits to the fitted tracks have to be minimised under variation of both all track and all alignment parameters (suitably parametrised detector positions). If a rough detector alignment is known, corrections will be small and the minimisation problem can be linearised.

To this end, tracks reconstructed with the standard reconstruction algorithms described in chapter 19 are re-fitted using the general broken lines (GBL) algorithm [83, 84]. The GBL software can calculate and output the complete covariance matrix between track and alignment parameters. As the track parameters are not correlated between tracks and only relate to the alignment of the small subset of sensors which are hit by the track, the resulting matrix is sparse. There are efficient algorithms for the inversion of such gigantic sparse matrices, one of which is implemented in the *Millepede II* programme [96], which we are using.

Whilst the sensor alignment is locally well constrained via the overlap of the sensors in the azimuthal direction and the closeness of the double layers, overall deformations such as shifts of the top part with regards to the bottom part, an overall torsion or the position of the recurl stations are only weakly constrained by using tracks from muon decays. These so-called *weak modes* need additional input from tracks which correlate distant parts of the detector. These tracks are provided by cosmic ray muons. As the cosmic rate is tiny com-

Parameter	Nominal	Misaligned	Aligned
Efficiency (short) [%]	100.00	59.09 ± 0.08	100.01 ± 0.03
Efficiency (long) [%]	100.00	46.72 ± 0.12	100.05 ± 0.14
Momentum resolution (short)	2.628 ± 0.003	4.271 ± 0.006	2.635 ± 0.003
Momentum resolution (long)	1.341 ± 0.002	1.645 ± 0.003	1.337 ± 0.002

Table 18

Tracking performance (using Michel positrons) for nominal, misaligned and aligned configurations of the pixel detector. The efficiencies are relative to the nominal configuration. The misaligned version corresponds to an estimate of the expected sensor misplacements after assembly. Momentum resolutions show the RMS of the distributions.

Parameter	Nominal	Misaligned	Aligned	
Efficiency (short) [%]	100.0	5.9	99.7	
Efficiency (long) [%]	100.0	2.2	100.1	
$x_{rec} - x_{true}$ [mm]	Mean	-0.002 ± 0.011	0.029 ± 0.068	-0.021 ± 0.011
	RMS	0.553 ± 0.008	0.724 ± 0.048	0.550 ± 0.008
$y_{rec} - y_{true}$ [mm]	Mean	-0.010 ± 0.012	-0.188 ± 0.050	0.048 ± 0.012
	RMS	0.555 ± 0.008	0.687 ± 0.035	0.552 ± 0.008
$z_{rec} - z_{true}$ [mm]	Mean	0.003 ± 0.009	0.105 ± 0.067	-0.005 ± 0.009
	RMS	0.356 ± 0.006	0.813 ± 0.048	0.355 ± 0.006

Table 19

Signal reconstruction efficiency and vertex resolution for nominal, misaligned and aligned configurations of the pixel detector. The efficiencies are relative to the nominal configuration. The misaligned version corresponds to an estimate of the expected sensor misplacements after assembly.

pared to the beam muon rate, it is imperative to have a special trigger stream to collect enough cosmics for alignment.

Our strategy is to perform a preliminary alignment of the detector using cosmic muons, which will have to fulfil the efficiency requirements. Michel tracks can then be used until the required resolution is reached. The requirements seem well within reach: in simulation, an average error on the sensor edge position of about 110 μm has already been achieved²⁸. In addition the effects of the residual misalignments do not significantly deteriorate the performance of the tracking detector (see Table 18 and Table 19). The general reconstruction efficiencies and momentum resolutions for short and long tracks, as well as the signal reconstruction efficiencies for short and long tracks, in the re-aligned detector are almost identical to the values for the nominal detector.

In Figure 147 the distributions of the measured momenta of positrons originating from a Michel decay for the misaligned and aligned pixel detector are compared to the result for the nominal detector. The misalignment applied in Figure 147 corresponds to expectations about detector misplacements right after assembly. Where a misaligned detector geometry causes a

²⁸These results are based on an estimate of the misalignment right after detector assembly.

clear distortion of the momentum distribution, we are able to recreate the nominal spectrum almost perfectly by applying the track-based alignment.

We have also implemented sensor deformations and temperature dependent sensor expansion in the alignment software. The fibre and tile detectors will also be aligned using track-based methods, using the pixel detector as a reference. The Millipede II algorithm can then also be used for a precise time alignment of all detector parts.

21.4. Target Alignment

The position of the target needs to be known with very high accuracy to allow placing requirements on the distance between the vertex and target. As the target is passive, the residual-based method described in the previous sections is not applicable. The overwhelming majority of decay positrons originate on the target surface, however, and will thus have a point of closest approach (POCA) to the beam axis inside the target.

This can be used to determine the target position by plotting the distribution of the POCAs in the transverse plane in slices of z for many tracks, which will give an accurate determination of the position of the outer target edge, as shown in Figure 148 and Figure 149. The target thickness has to be determined during manufacture or using photon conversions.

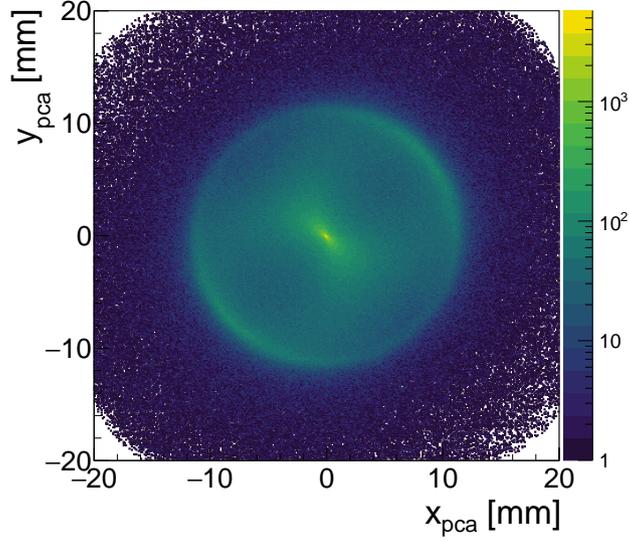


Figure 148: Position in x and y of the points of closest approach to the beam line for a 1 mm slice in z at -20 mm for $3.84 \cdot 10^8$ stopped muons. The target is clearly visible at its nominal position. The accumulation of entries towards the origin is a feature of the reconstruction method.

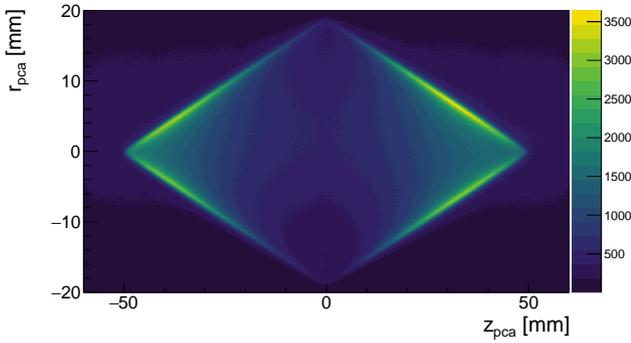


Figure 149: Position in r and z of the points of closest approach to the beam line for $3.84 \cdot 10^8$ stopped muons; the target is clearly visible. Negative radius is defined to be when the beam line is inside the track circle, positive is outside.

22. Performance Simulation

We study the performance of the detector described in the preceding parts by running the Geant4 simulation and the reconstruction programme. Even under optimistic assumptions, only a handful of signal decays are expected in the data. Nonetheless, we use relatively large signal samples to study the detector performance and deduce a very preliminary and rough event selection.

For the various expected backgrounds, in principle the simulation of several times the expected number of decays in data is required. This is impractical both in terms of processing time and available storage space. We thus try to identify important sources of background from either general considerations (inter-

nal conversion) or from simulating a few seconds of run time (accidentals).

From these starting points we generate special background samples. In the case of accidental background samples we can make use of the approximation that timing suppression is independent of vertexing and event kinematic suppression.

We use a simple cut based analysis in order to show that background free running with the conditions at $\pi E5$ is possible. An analysis with optimised cuts or based on likelihoods can likely deliver a higher signal efficiency and thus final sensitivity per running time.

22.1. Signal Performance

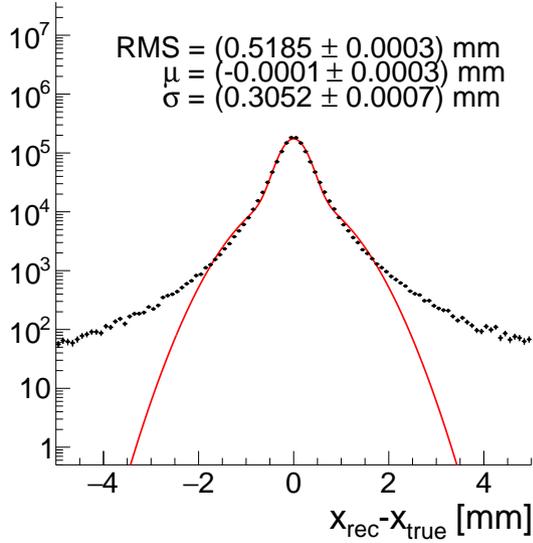
We study the nominal performance of the detector setup using about 8.5 million signal decays. The decay electrons are generated with a phase space distribution. Efficiencies are determined relative to all muons decaying inside a cylinder with the outer dimensions of the stopping target.

In the first step, all three tracks from the signal decay have to be reconstructed to at least short (4-hit) tracks; for the efficiency and resolution of the track reconstruction, see chapter 19.

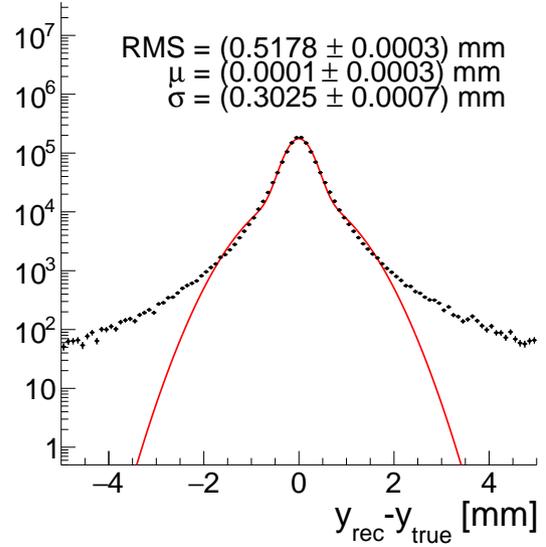
22.1.1. Vertex Fit

The three tracks from signal decays should intercept at a common point on the surface of the target. We look at all combinations of a track with negative charge and two tracks of positive charge. In order not to fit recurling tracks with themselves, the track tangent vector at the point of closest approach is determined. If the cosine of the opening angle between two tracks is more

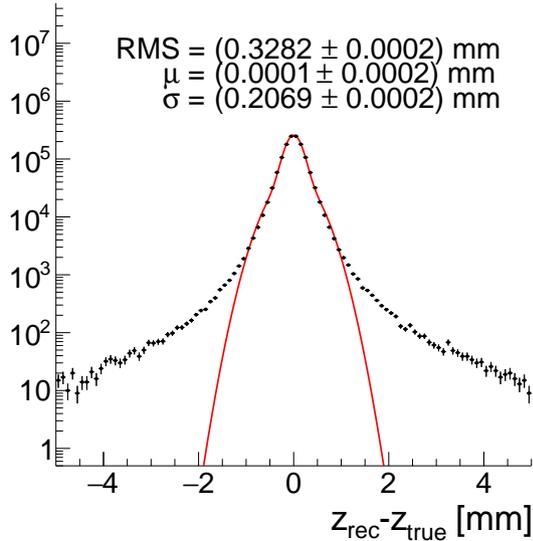
Mu3e Phase I Simulation, 3 recurlers



Mu3e Phase I Simulation, 3 recurlers



Mu3e Phase I Simulation, 3 recurlers



Mu3e Phase I Simulation, 3 recurlers

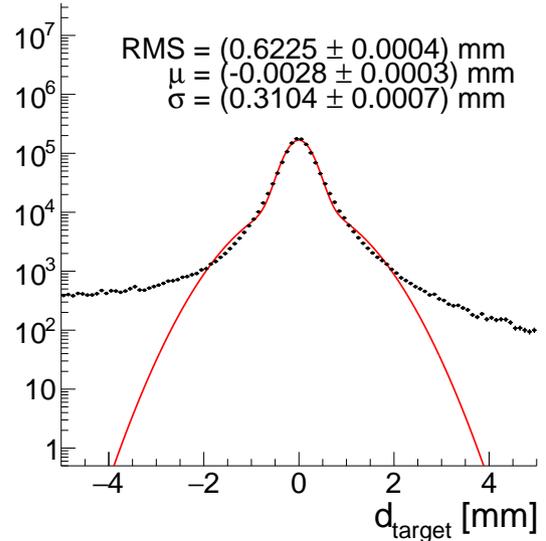


Figure 150: Vertex resolution for signal decays. Three tracks with recurlers are selected. The fits are the sum of two Gaussian distributions and the quoted σ is the area-weighted mean. Top left in x , top right in y , bottom left in z and bottom right in the distance to the target; negative target distances denote a reconstructed vertex position inside the target.

3861 than 0.99 and the momentum difference is less than
3862 1 MeV/c, the combination is not further considered.

3863 Starting from the track positions and directions in
3864 the first detector plane, we perform a vertex fit by forc-
3865 ing three tracks to intersect in a common point in space,
3866 taking multiple scattering in the first detector layer as
3867 the only degree of freedom [97]. The χ^2 of the fit and
3868 the distance of the vertex to the target surface are two
3869 handles for suppressing accidental background; the per-
3870 formance of the vertex reconstruction is illustrated in
3871 Figure 150.

22.1.2. Mass and Momentum Reconstruction

3872 For all candidates with a vertex fit $\chi^2 < 30$ the
3873 tracks are extrapolated to the vertex and four-vectors
3874 are constructed with an electron mass assumption. From
3875 the three four-vectors, the mass of the decaying parti-
3876 cle (should correspond to the muon mass) and the
3877 momentum of the center-of-mass system (CMS) in the
3878 detector frame (should be zero for decays at rest) are
3879 determined.
3880

3881 The resolution for the muon momentum is depicted
3882 in Figure 151. The magnitude of the reconstructed mo-

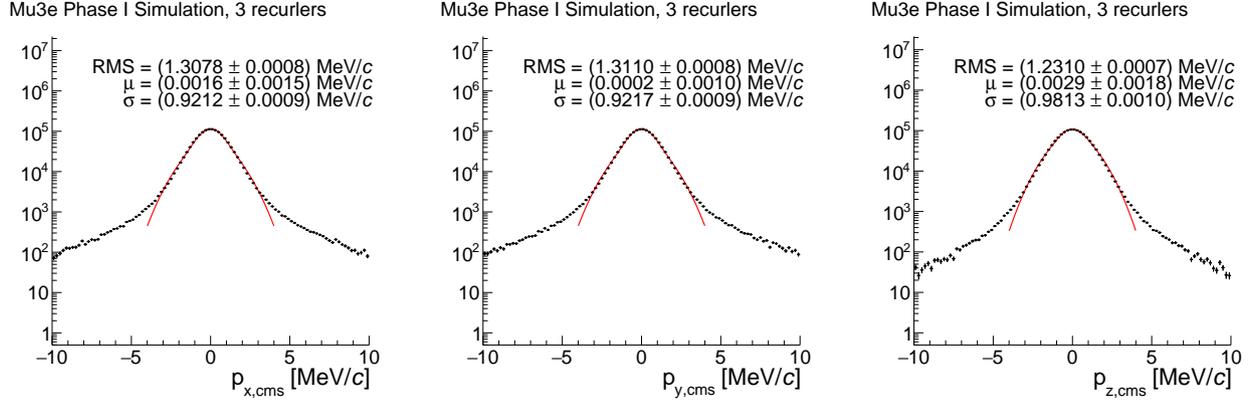


Figure 151: Reconstructed decay muon momentum in x , y and z direction (which corresponds to the resolution for p_x , p_y and p_z for muons decaying at rest). Only long tracks enter the analysis.

Mu3e Phase I Simulation, 3 recurlers

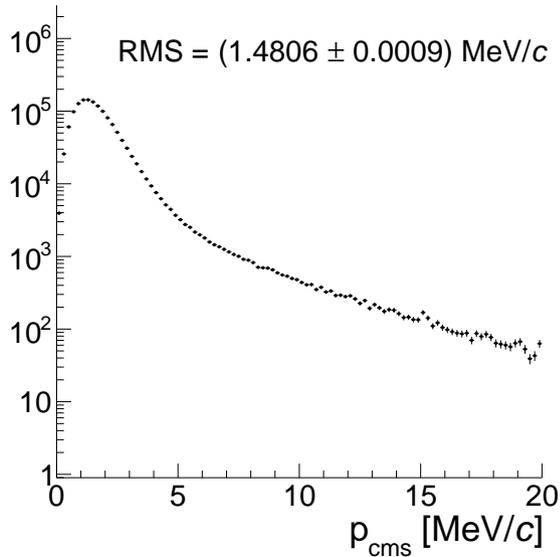


Figure 152: Center of mass system momentum reconstructed for signal events with three recurlers required.

mentum is shown in Figure 152.

We define the decay plane from the three momenta \vec{p}_i ,

$$\vec{a} = \frac{(\vec{p}_1 - \vec{p}_2) \times (\vec{p}_3 - \vec{p}_2)}{|(\vec{p}_1 - \vec{p}_2) \times (\vec{p}_3 - \vec{p}_2)|}. \quad (8)$$

\vec{a} is a vector perpendicular to the decay plane (if the tracks are from a muon decaying to the signal channel at rest).

The SINDRUM experiment based their selection on the projection of the CMS momentum onto this vector, called acoplanar momentum

$$\vec{p}_{acoplanar} = \vec{p}_{CMS} \cdot \vec{a}. \quad (9)$$

and the coplanar momentum

$$\vec{p}_{coplanar} = \vec{p}_{CMS} \times \vec{a}. \quad (10)$$

To first order, the resolution for the acoplanar momentum is only dependent on the measurement (and thus resolution) of the track angle, whereas the coplanar momentum is dominated by the absolute momentum resolution.

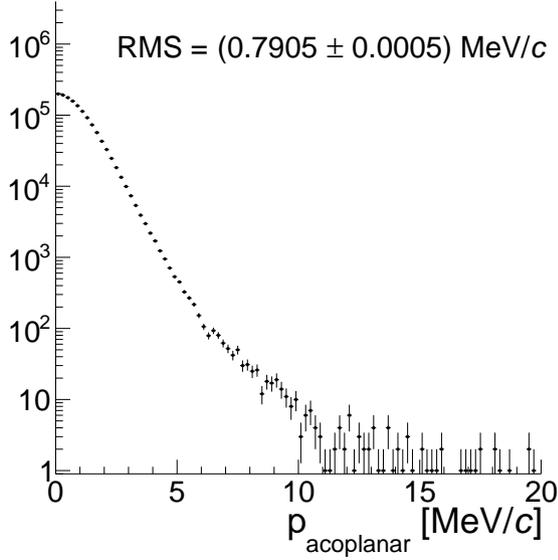
The corresponding distributions are shown in Figure 153; for the Mu3e setup (similar to SINDRUM) the resolution in the acoplanar momentum is superior to the coplanar momentum resolution. No detailed optimization of the momentum selection has been performed for Mu3e so far, so for the distributions shown in this report, we used the requirement of $p_{CMS} < 8$ MeV/c.

Finally, we show the resolution for the reconstructed mass in Figure 154. As the distributions show, the core of the mass resolution fulfils the criteria set out in chapter 1 and especially if requiring recurling tracks. Sizeable Landau-like tails only appear on the low mass side.

22.1.3. Signal Efficiency

For every reconstruction step, there is a possibility of signal loss; the largest loss is due to the geometrical acceptance of the detector. For phase-space signal decays in the target, approximately 38.1% have all three electrons traverse the four layers of the central detector in the active region. If recurling tracks are required, the acceptance is further reduced. There are also inefficiencies in the reconstruction and vertex fit, especially due to the χ^2 cuts, which mostly get rid of tracks with large angle scattering, which preclude a reliable and precise reconstruction. The overall efficiency after applying all mentioned cuts as well as a veto on events where the tracks have inconsistent timing is shown in Figure 155 in dependence of the required number of recurling tracks.

Mu3e Phase I Simulation, 3 recurlers



Mu3e Phase I Simulation, 3 recurlers

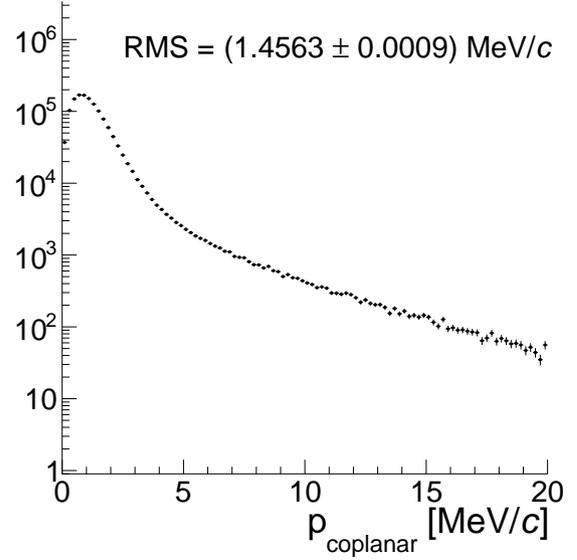


Figure 153: Acoplanar momentum (left) and coplanar momentum (right) reconstructed for signal events with three recurlers required.

Step	Step efficiency	Total efficiency
Muon stops	100%	100%
Geometrical acceptance, short tracks	38.1%	38.1%
Geometrical acceptance, long tracks	68.0%	25.9%
Short track reconstruction	89.5%	34.1%
Long track reconstruction ¹	67.2%	17.4%
Vertex fit	99.4%	17.3%
Vertex fit $\chi^2 < 30$	97.6%	16.9%
CMS momentum $< 8 \text{ MeV}/c$	97.6%	16.5%
Timing	90.0%	14.9%

Table 20

Efficiency of the various reconstruction and analysis steps.

¹: Note that the efficiency of this step is quoted relative to the acceptance for long tracks.

3931 With the used selection criteria, the overall effi- 3949
 3932 ciency is 14.9 % when three recurling tracks are 3950
 3933 required. The efficiency losses are listed in Table 20. Fur- 3951
 3934 ther gains are expected from a through optimisation of 3952
 3935 the cuts; on the other hand, imperfections of the real 3953
 3936 detector will likely lead to some additional losses. The 3954
 3937 selection can optimised for efficiency or mass resolution 3955
 3938 e.g. by requiring recurling tracks only above a minimum 3956
 3939 momentum, see Figure 156.

22.2. Backgrounds

22.2.1. Internal Conversion Background

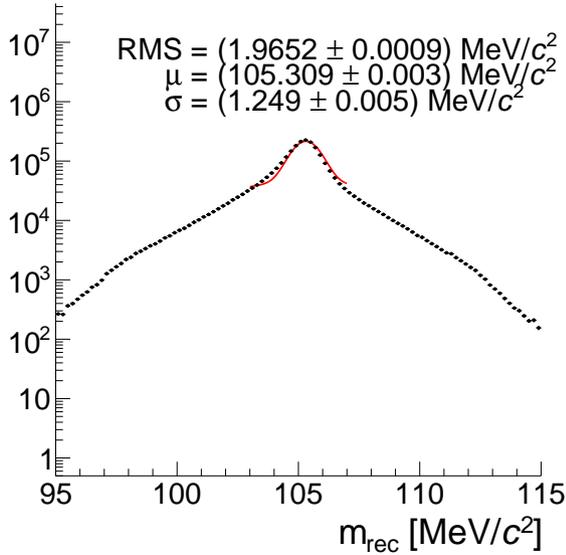
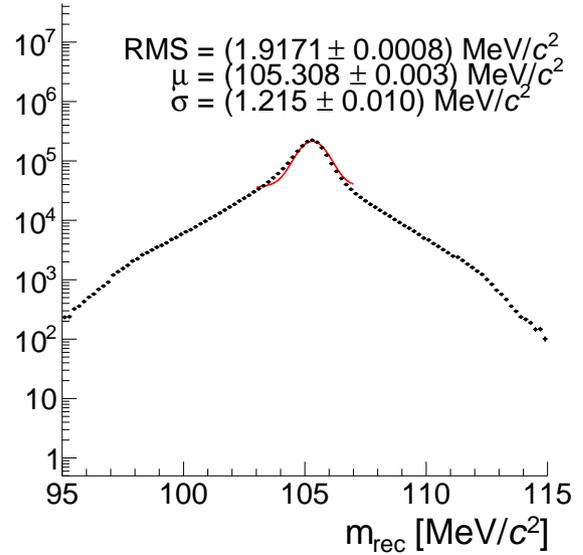
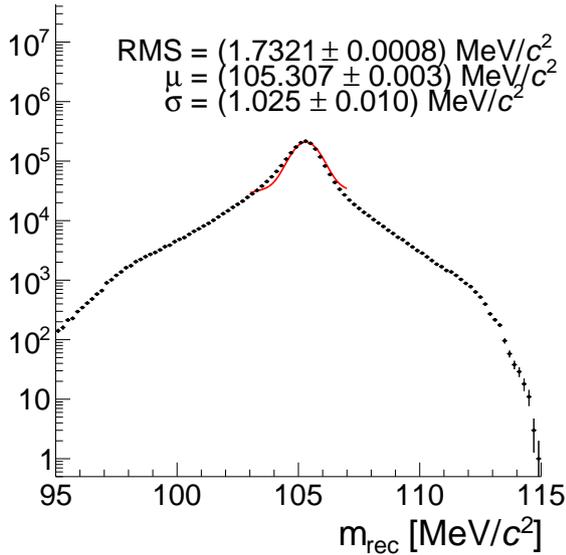
3940 We simulate the internal conversion background as 3957
 3941 described in section 18.3.2 using the matrix element 3958
 3942 provided by Signer et al. [7]. The total branching frac- 3959
 3943 tion for this decay is $3.4 \cdot 10^{-5}$ [6], so a complete simu- 3960
 3944 lation is challenging. We are however mostly interested 3961
 3945 in the region of phase space were the neutrinos carry 3962
 3946 little momentum; the branching fraction for this high 3963
 3947 3964
 3948

3949 visible mass region (we used a lower cutoff of $90 \text{ MeV}/c^2$ 3950
 3951 for the studies presented here), is strongly suppressed 3952
 3953 and we can generously oversample in the simulation. In 3954
 3955 addition, we use weighted events in order to better popu- 3956
 3957 late the high mass tail. Migrations from lower masses 3958
 3959 than $90 \text{ MeV}/c^2$ into the signal region are very strongly 3960
 3961 suppressed if three recurling tracks are required, see 3962
 3963 Figure 157. 3964
 3965

22.2.2. Accidental Background

3957 Accidental background arises from the combination 3958
 3959 of two Michel positrons with an electron. It is thus im- 3960
 3961 portant to understand and limit electron production in 3961
 3962 the target region. This is of particular importance for 3962
 3963 processes such as Bhabha-scattering, where the elec- 3963
 3964 tron and positron tracks intersect in space and time 3964
 3965 and only the separation to the second positron remains 3965
 3966 as a suppression criterion.

Mu3e Phase I Simulation, all tracks


 Mu3e Phase I Simulation, $\geq 1r$ recurler

 Mu3e Phase I Simulation, ≥ 2 recurlers


Mu3e Phase I Simulation, 3 recurlers

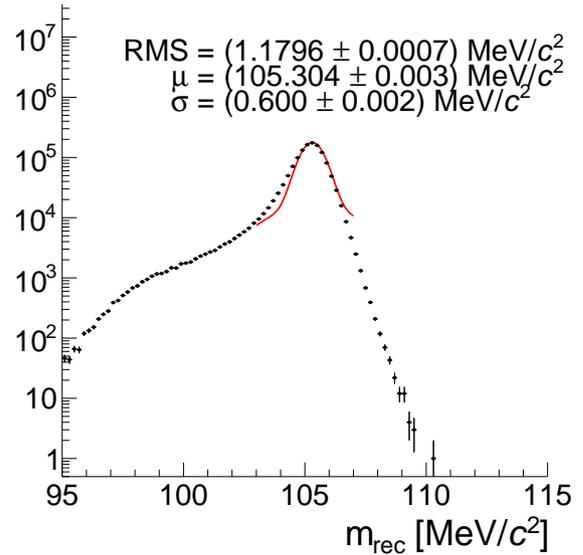


Figure 154: Reconstructed muon mass for all tracks (top left), at least one recurler (top right), at least two recurlers (bottom left) and three recurlers (bottom right). The fits are the sum of two Gaussian distributions and the quoted σ is the area-weighted mean; the main purpose of the fit is to guide the eye and highlight the non-symmetric resolution distribution.

3966 *Electron Production in the Target* The default target
 3967 is part of the Geant4 detector simulation as described in
 3968 chapter 18. The material of the target is a place where
 3969 electrons from Bhabha and Compton scattering as well
 3970 as from photon conversion can be produced and con-
 3971 tribute to accidental background. Bhabha scattering
 3972 needs special attention, as very often both the electron
 3973 and the positron partaking in the scattering process end
 3974 up in the detector acceptance; the corresponding ver-
 3975 tices are shown in Figure 158. As shown in Figure 159,
 3976 almost all the corresponding primary positrons come
 3977 from muon decays in the target and can thus not be

further reduced or shielded.

The total number of electrons produced per Michel
 decay is shown in Table 21. As can be seen, Bhabha
 scattering is the most important background process.
 The reason that there are significantly lower number of
 electron reconstructed is because of the the momentum
 spectrum falling fast, see Figure 160. The means that
 many of the electrons end up at or below the low edge
 of the detector and reconstruction acceptance.

Timing Suppression Time information from hits in
 the fibre and tile detectors provides an important han-
 dle for the suppression of accidental backgrounds. If

Electron source	Produced in inner detector	Produced in target region	Reconstructed inner detector short tracks	Reconstructed target region short tracks	Reconstructed inner detector long tracks	Reconstructed target region long tracks
Bhabha scattering	$5.5 \cdot 10^{-4}$	$1.1 \cdot 10^{-4}$	$2.7 \cdot 10^{-4}$	$5.7 \cdot 10^{-5}$	$2.3 \cdot 10^{-4}$	$4.4 \cdot 10^{-5}$
both visible	$4.3 \cdot 10^{-4}$	$7.7 \cdot 10^{-5}$	$1.5 \cdot 10^{-4}$	$2.6 \cdot 10^{-5}$	$1.1 \cdot 10^{-4}$	$1.7 \cdot 10^{-5}$
Photon conversion	$2.3 \cdot 10^{-5}$	$2.1 \cdot 10^{-6}$	$1.1 \cdot 10^{-5}$	$1.0 \cdot 10^{-6}$	$9.2 \cdot 10^{-6}$	$8.0 \cdot 10^{-7}$
both visible	$5.7 \cdot 10^{-6}$	$4.6 \cdot 10^{-7}$	$1.5 \cdot 10^{-6}$	$1.3 \cdot 10^{-7}$	$1.2 \cdot 10^{-6}$	$9.3 \cdot 10^{-8}$
Compton scattering	$3.6 \cdot 10^{-5}$	$4.3 \cdot 10^{-6}$	$1.7 \cdot 10^{-5}$	$2.2 \cdot 10^{-6}$	$1.4 \cdot 10^{-5}$	$1.7 \cdot 10^{-6}$
Internal conversion	$3.1 \cdot 10^{-5}$	$2.9 \cdot 10^{-5}$	$1.7 \cdot 10^{-5}$	$1.6 \cdot 10^{-5}$	$1.3 \cdot 10^{-5}$	$1.3 \cdot 10^{-5}$
two visible	$1.1 \cdot 10^{-6}$	$1.0 \cdot 10^{-6}$	$3.6 \cdot 10^{-7}$	$3.3 \cdot 10^{-7}$	$2.3 \cdot 10^{-7}$	$2.2 \cdot 10^{-7}$
Total	$6.4 \cdot 10^{-4}$	$1.5 \cdot 10^{-4}$	$3.2 \cdot 10^{-4}$	$7.6 \cdot 10^{-5}$	$2.6 \cdot 10^{-4}$	$5.9 \cdot 10^{-5}$

Table 21

Electrons with transverse momentum larger than 10 MeV created per Michel decay in the target region. The inner detector region is a cylinder including the vacuum window and the first pixel layer, the target region is a cylinder just containing the target.

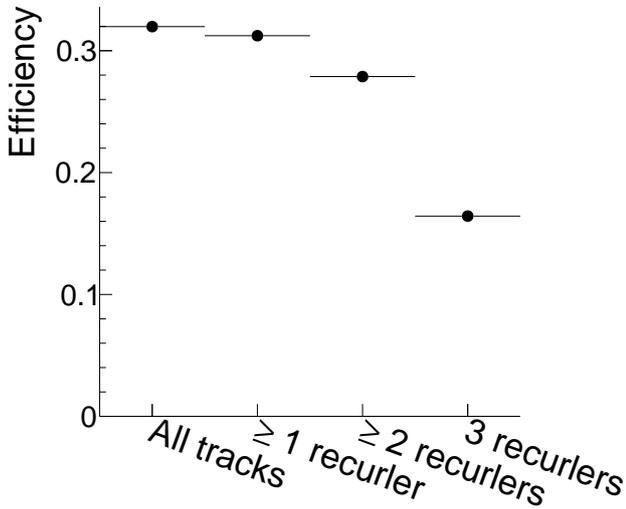


Figure 155: Total efficiency for reconstructing phase-space signal events as a function of the required number of recurring tracks. This includes the geometrical detector acceptance, track and vertex reconstruction and selection inefficiencies.

background with two tracks correlated and one uncorrelated in time and a suppression of more than three orders of magnitude for three uncorrelated tracks is expected.

Kinematic Suppression The largest suppression factors for accidental background come from kinematics, i.e. the requirement that the three momenta sum up to zero (enforced by the total momentum selection) and a mass window around the muon mass. Typical suppression factors are of the order of one million. The kinematics of the event however also strongly affect the suppression power of the vertex fit; the corresponding requirements do unfortunately not factorise and large simulated samples are required.

Vertex Suppression The suppression of accidental background due to the common vertex of three tracks is highly dependent on the kinematics. In the interesting cases of Bhabha scattering or photon conversion, there will be an electron-positron pair with a small opening angle balanced with a positron close to the Michel edge going in the opposite direction. This case is favourable for vertex based background suppression, which is much higher than in a generic three-track arrangement. As vertex and kinematic suppression do not factorise, we have simulated the most common accidental background, Bhabha scattering plus a Michel electron with full statistics, using only mild assumptions. We start with a fraction of $7.7 \cdot 10^{-5}$ of all muon stops that produce Bhabha scattering in the target with both products visible. We then simulate normal frames at $1 \cdot 10^8$ muon stops per second overlaid with a muon, where, immediately after the decay, the Michel positron undergoes Bhabha scattering (here we make the further assumption, that the distribution of muon stops corresponds to the distribution of Bhabha scatters). Assuming a timing suppression factor of 70, the $2.4 \cdot 10^9$ simulated frames then correspond to Bhabha scattering from $1.1 \cdot 10^{16}$ muon stops. After reconstruction and applying all cuts, three simulated Bhabha events

the pixel time resolution is smaller than the length of the reconstruction frames this can already be used to suppress accidental background. The additional suppression by the dedicated timing detectors depends on the size of the pixel timing window, which here was taken to be 50 ns.

The precise timing of a track is determined by the number of assignable hits in the fibre detector and the existence of a matched tile hit. If a track reaches the tile detector in the recurl stations, the timing is dominated by this much more accurate detector. Detailed studies of the signal efficiency and background suppression of the timing detectors are described in [41] and summarised in chapter 10. Using this we have a working point of 90 % efficiency for coincident tracks (signal), a timing suppression of 71 for the dominant accidental

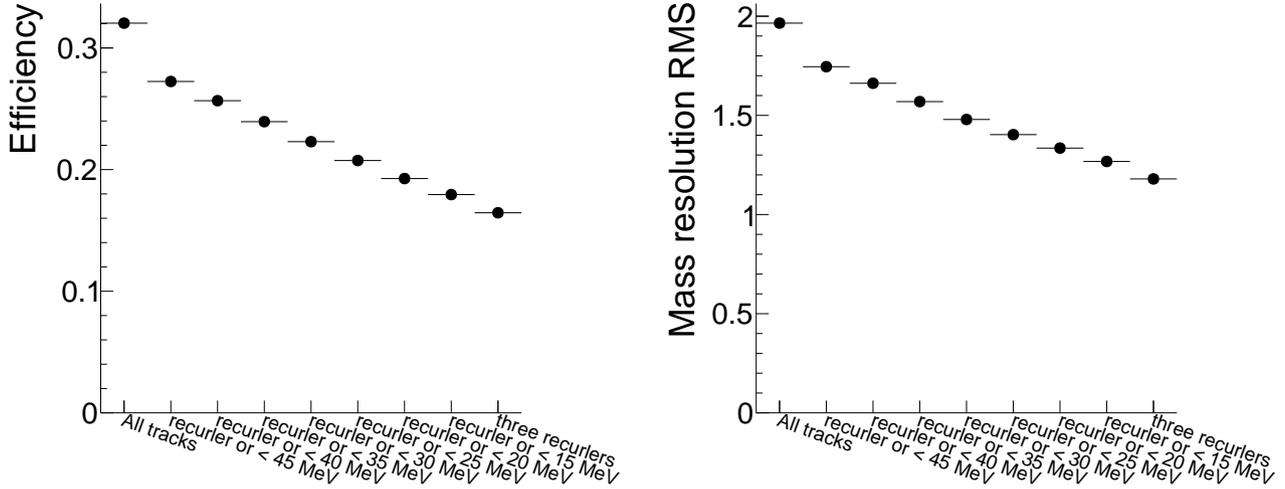


Figure 156: Efficiency before timing selection for reconstructing phase-space signal events (left) and the *RMS* of the corresponding three-particle invariant mass distribution. Both use the same selection criteria.

Mu3e Phase I Simulation, 3 recurlers

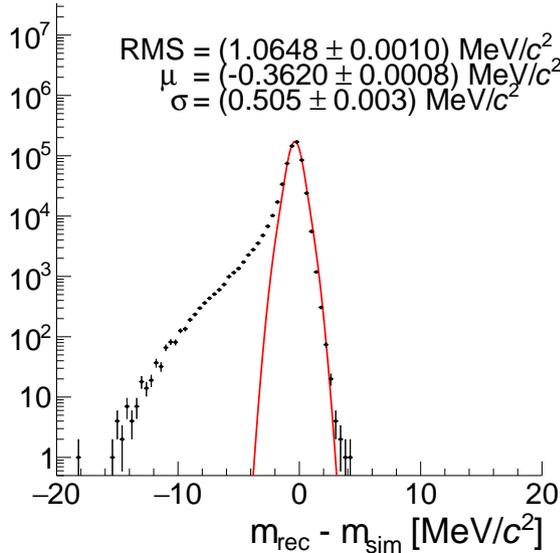


Figure 157: Resolution of the mass reconstruction for internal conversion events with a visible mass above 90 MeV/c² for three recurling tracks and a momentum of the three particle system of less than 8 MeV.

events almost all have the same e^+e^- invariant mass of around 7 MeV/c², see Figure 161. This comes from the minimum momentum transfer required to kick the electron (initially at rest) into the detector acceptance folded with the strongly forward peaked Bhabha cross section. A requirement on this mass can further reduce the Bhabha background, will however also remove a specific part of the signal kinematics.

A similar simulation study for accidental background from combinations of internal conversion decays and Michel decays indicated that this background contributes an expectation of less than 0.1 events in the signal region.

22.3. Sensitivity

With the phase I Mu3e detector we have the capability of suppressing both accidental backgrounds and internal conversion events to a level that allows for a background free measurement for at least $2.5 \cdot 10^{15}$ muon stops. This corresponds to about 300 days of continuous running at $1 \cdot 10^8$ stops per second. The simulated invariant mass distribution is shown in Figure 162, the 2D distribution of invariant mass and CMS momentum is shown in Figure 163 and the sensitivity versus running time is shown in Figure 164.

A. Acknowledgements

We gratefully acknowledge the beamtimes provided by the following facilities: test beam facility at DESY Hamburg (Germany), a member of the Helmholtz Association (HGF), π M1 at Paul Scherrer Institut, Villigen (Switzerland), PS and SPS at CERN, Geneva,

with reconstructed masses above 95 MeV are left.²⁹
 Here we have not yet used the fact that the Bhabha

²⁹The simulation of the Bhabha background was performed with a slightly older version of the detector geometry with smaller gaps between the pixel sensors in longitudinal direction, leading to an overall efficiency about 1.5% higher than in the current version.

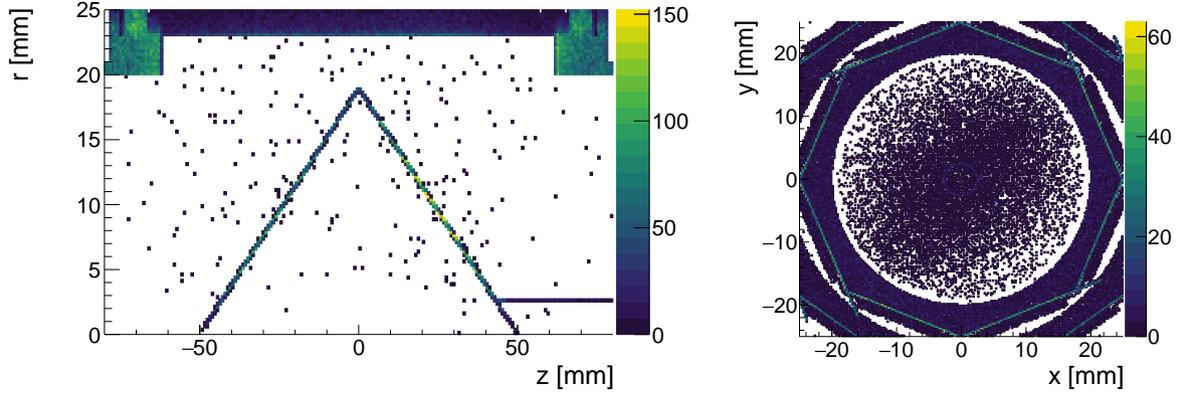


Figure 158: Longitudinal view (left) and transverse view (right) of the loci of Bhabha scattering producing an electron and a positron both in the detector acceptance in the target region for 1.9 s of running at $1 \cdot 10^8$ muon stops per second.

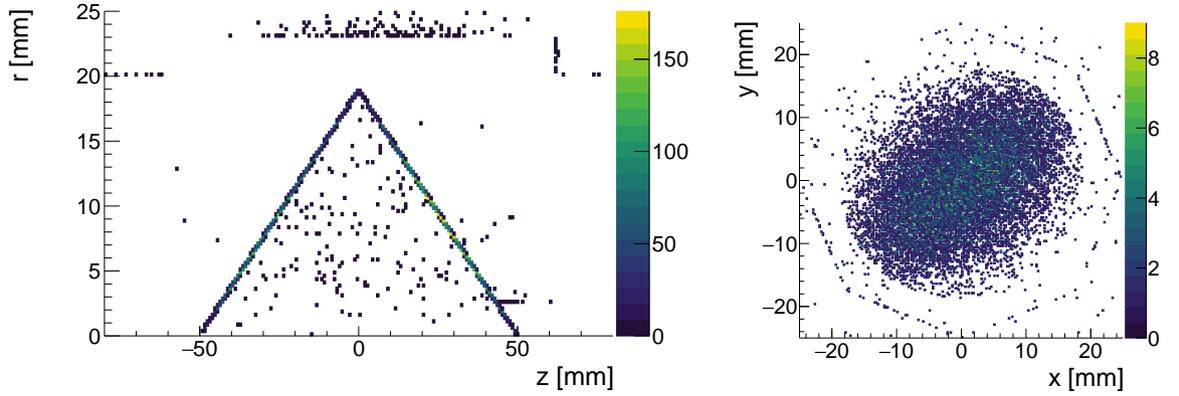


Figure 159: Longitudinal view (left) and transverse view (right) of muon decay vertices leading to a positron then undergoing Bhabha scattering in the target resulting in an electron and a positron both in the detector acceptance in the target region for 1.9 s of running at $1 \cdot 10^8$ muon stops per second.

4077 (Switzerland), and MAMI A2 and X1 at Institut für
4078 Kernphysik at the JGU Mainz (Germany).

4079 The Heidelberg groups acknowledge the support by
4080 the German Research Foundation (DFG) funded Re-
4081 search Training Groups HighRR (GK 2058) and “Particle
4082 Physics beyond the Standard Model” (GK 1994), by
4083 the EU International Training Network PicoSec (grant
4084 no. PITN-GA-2011-289355-PicoSEC-MCNet), by the
4085 International Max Planck Research School for Preci-
4086 sion Tests of Fundamental Symmetries (IMPRS-PTFS)
4087 and the Heinz-Götze-Stiftung.

4088 The work of the Mainz group has also been sup-
4089 ported by the Cluster of Excellence “Precision Physics,
4090 Fundamental Interactions, and Structure of Matter”
4091 (PRISMA EXC 1098 and PRISMA+ EXC 2118/1) funded
4092 by the German Research Foundation (DFG) within the
4093 German Excellence Strategy (Project ID 39083149).
4094 We acknowledge the contributions of the PRISMA De-
4095 tector laboratory to the development of the DC-DC

converters.

4096 The Swiss institutes acknowledge the funding sup-
4097 port from the Swiss National Science Foundation grants
4098 no. 200021_137738, 200021_165568, 200021_172519,
4099 200021_182031 and 20020_172706.

4100 The Particle Physics Department of (DPNC) the
4101 University of Geneva gratefully acknowledges support
4102 from from the Ernest Boninchi Foundation in Geneva.

4103 The UK institutes thank the Science and Technol-
4104 ogy Facilities Council for funding their work through
4105 the Large Projects scheme, under grant numbers: ST/P00282X/1,
4106 ST/P002765/1, ST/P002730/1, ST/P002870/1.

4107 N. Berger, S. Shrestha, A. Kozlinskiy, A.-K. Per-
4108 revoort, D. vom Bruch, Q. H. Huang, U. Hartenstein
4109 and F. Wauters thank the DFG for funding their work
4110 on the Mu3e experiment through the Emmy Noether
4111 programme.

4112 F. Meier Aeschbacher, I. Perić, A. Schöning and
4113 D. Wiedner thank the DFG for funding their work un-
4114

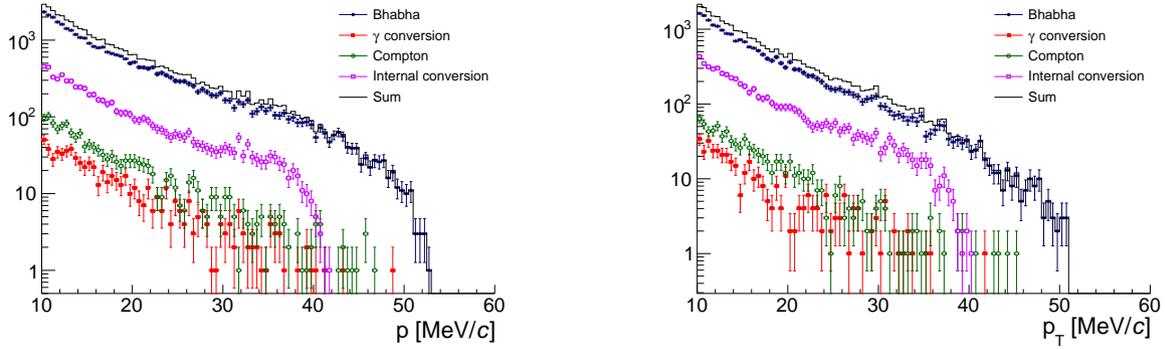


Figure 160: Momentum spectrum (left) and transverse momentum spectrum (right) of electrons produced in the target region.

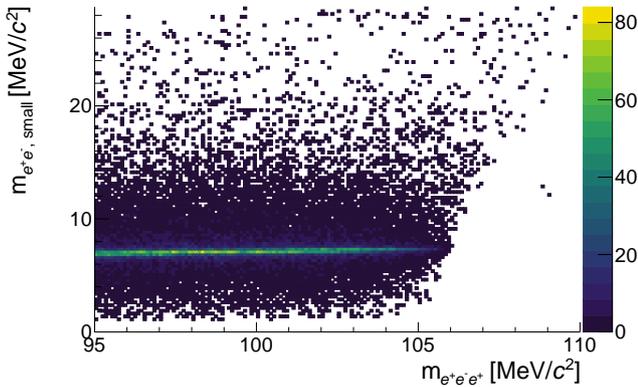


Figure 161: Small invariant mass of e^+e^- pairs versus $e^+e^-e^+$ invariant mass for accidental combinations of a Bhabha e^+e^- pair with a Michel positron.

der grant no. SCHO 1443/2-1.

G. Hesketh gratefully acknowledges the support of the Royal Society through grant numbers UF140598 and RGF\EA\180081.

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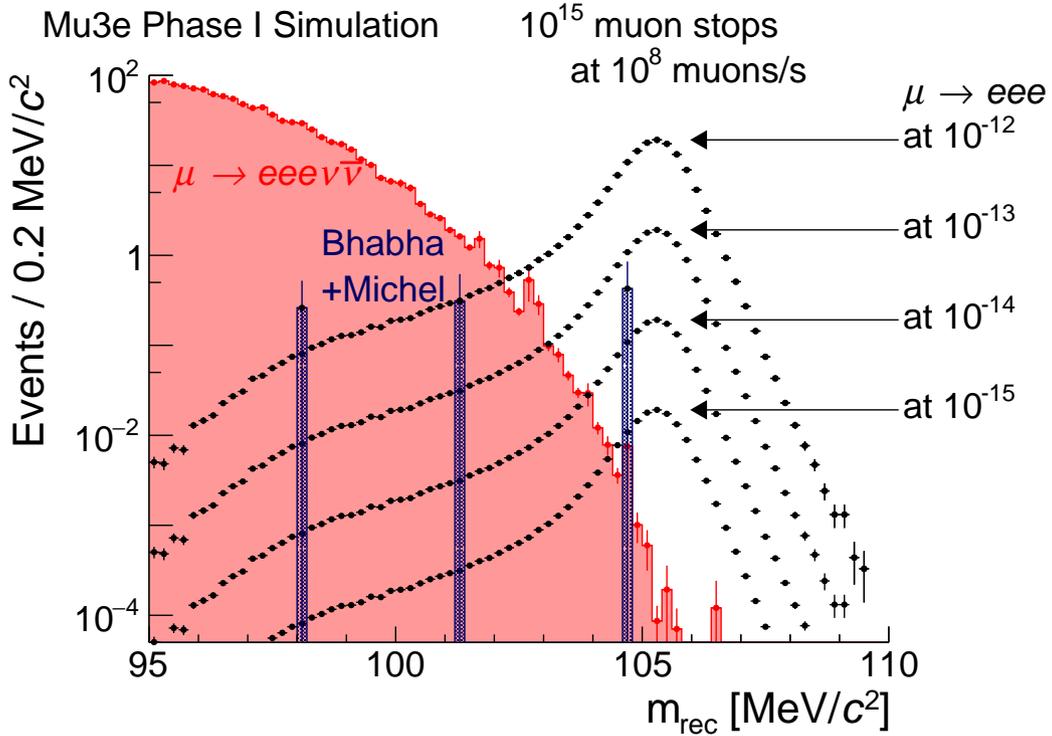


Figure 162: Reconstructed invariant mass for signal events at various branching fractions and internal conversion events. Accidental background from combinations of Bhabha pairs and Michel electrons is also shown. The CMS momentum is required to be less than 8 MeV/c. Note that both the internal conversion and Michel and Bhabha simulation uses weighted events.

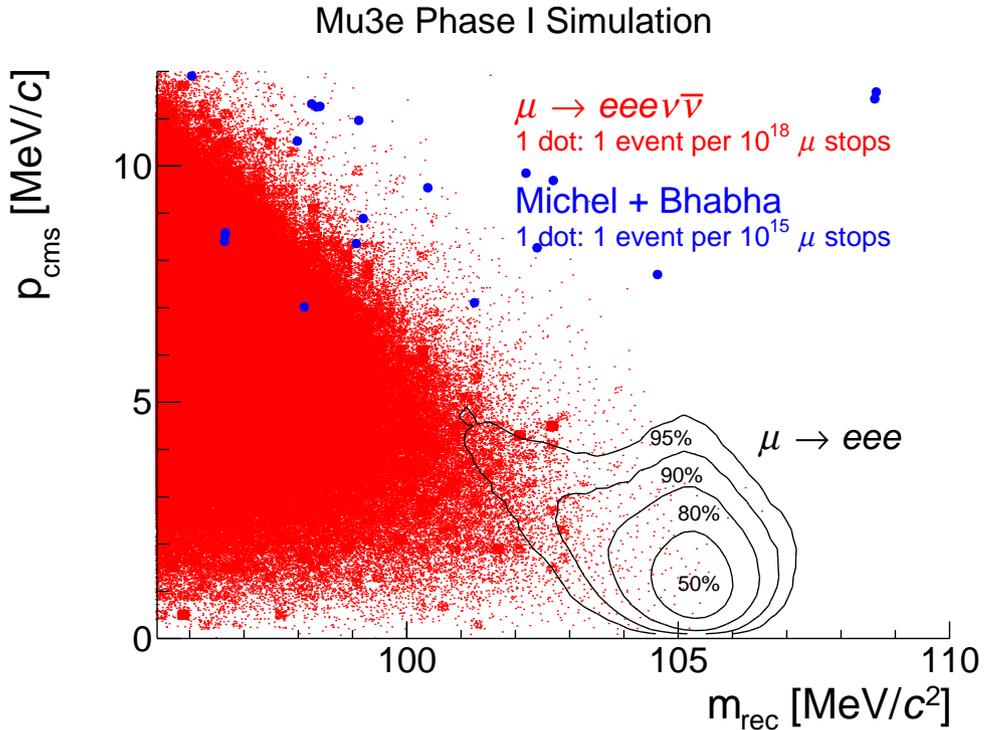


Figure 163: Reconstructed invariant mass versus the CMS momentum for signal events, internal conversion events and accidental background from combinations of Bhabha pairs and Michel electrons. Note that both the internal conversion and Michel and Bhabha simulation uses weighted events.

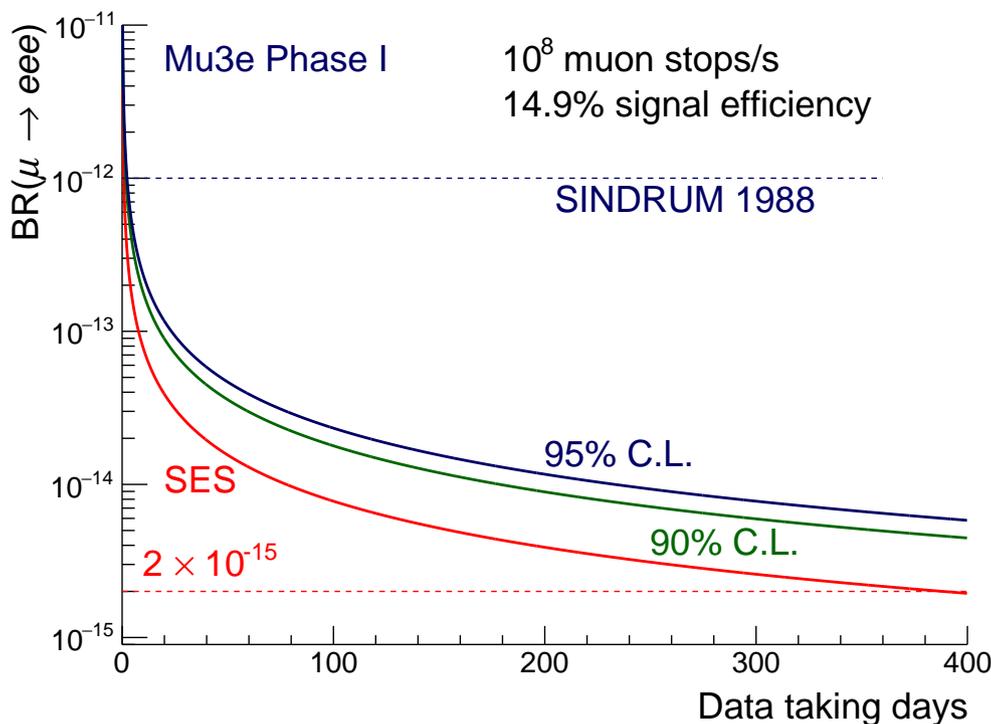


Figure 164: Single event sensitivity (SES) and the corresponding 90% and 95% C.L. upper limits versus data taking days for the phase I Mu3e detector.

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